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Permanent Address - Résidence fixe Country of Birth - Lieu de naissance Ser. 901 · 1220 MERIVALE RORD OTTAWA, ONTARIO KIZ 8P2 Title of Thèsis - Titre de la thèse Aumirical Mithads in Microwau Ontigrated circuits University --- Université Degree for which thesis was presented — Grade pour lequel cette thèse fut présentée Year this degree conferred - Année d'obtention de ce grade Name of Supervisor 7 Nom du directeur de thèse Spring 1983 Hour BER AND AND AND Permission is hereby granted to the NATIONAL LIBRARY OF L'autorisation est, par la présente, accordée à la BIBLIOTHÈ-CANADA to microfilm this thesis and to lend or sell copies of QUE NATIONALE DU CANADA de microfilmer cette thèse et de the film. prêter ou de vendré des exemplaires du film. The author reserves other publication rights, and neither the L'auteur se réserve les autres droits de publication; ni la thèse thesis nor extensive extracts from it may be printed or otherni de longs extraits de celle-ci ne doivent être/imprimés ou wise reproduced without the author's written permission. autrement reproduits sans l'autorisation écrite de l'auteur. Date Signature april 5 /83 acid Shammer

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A THESIS

C SAEID SHAMMAS

NUMERICAL METHODS IN MICROWAVE INTEGRATED CIRCUITS

by

THE UNIVERSITY OF ALBERTA

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RELEASE FORM

NAME OF AUTHOR Saeid Shammas TITLE OF THESIS Numerical Methods in Microwave Integrated Circuits

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83 03 21 Date.



In this thesis, novel numerical methods are devised for analyzing microwave integrated circuits. A review of current methods shows a need for new methods that are efficient and yet flexible to handle various types of microstrip structures. Microstrip lines in the quasi-TEM (transverse electromagnetic) regime are analyzed by the boundary element method (BEM). The accuracy of the obtained results is comparable to other methods but the required computer space/time is decreased significantly (15 x 15 matrix for microstrip lines, 35 x 35 matrix for coupled microstrip lines). A new method is developed for analyzing microstrip lines, which can be considered as a generalization of Green's functions. A closed-form solution for the characteristic impedance of microstrip lines is obtained which exhibits reasonable accuracy (typically 5%). An exact analysis of microstrip lines is presented in which only one potential function is required rather than the customary choice of two potential functions. This reduction in the number of variables is accompanied by generalizing the developed numerical method; the domain of integration in the integral equation is the dielectric air interface (DAI). The numerical results are in good agreement with other methods, while a relatively small matrix size is needed for computation (of the order of 8x8). In order to generalize this method for analyzing microstrip resonators, the method is modified so that the domain

of integration is the area along the strips. As an example, a rectangular microstrip resonator is analyzed. The accuracy of this method is good at high frequencies, but decreases as frequency decreases. This method results in small matrix sizes (e.g., 4×4), shows reasonable accuracy within a specified frequency range, and is shown to be flexible since it can be used to analyze microstrip lines as well as microstrip resonators. ACKNOWLEDGEMENTS

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	LIST OF SYMBOLS
a, â, â, â,	Unit vectors along the x-, y-, and z-axes
hs	Substrate height
h	=Lim y
	y < h
	$y \rightarrow h$
h † s	=Lim y
1	$\mathbf{y} > \mathbf{h}^*$
	$\mathbf{y} \rightarrow \mathbf{h}$
С:	Speed of light in free space
Cs	Capacitance of the microstrip line per unit length
C _o a	Capacitance of the microstrip line per unit length
	assuming that the dielectric substance is removed
Ē	Electric field vector
Ĥ:	Magnetic field vector
f: -	Frequency
$k=2\pi f/c$	Propagation constant of an electromagnetic wave
	in free space
t:	Strip thickness
W:	Strip width
Zs	Characteristic impedance of the microstrip line
Z •1	Characteristic impedance of the microstrip line
	when $\epsilon_{r}=1$
Ze:	Even-mode characteristic impedance of coupled lines
201	Odd-mode characteristic impedance of coupled lines

Propagation constant along the microstrip line Dielectric constant of free space Effective relative dielectric constant Zero frequency . 11 2 Even-mode € 'of coupled lines e of coupled lines Odd-mode Relative dielectric constant of the substrate (Fig. 1-1) The guide wavelength of the microstrip line In dielectric In vacuo =W/(2h), Figs. 1-la, lb, and lc =(s+w)/(2h), Fig. 1-1c Charge distribution per unit length on str Magnetic constant of free space Radian frequency

9/9**n**

^ЕӨО

Normal derivative (to surface)

Subscripts and Superscripts

a:	Air
d:	Dielectric
e;	Even (in case of coupled microstrip lines)
02	Odd (in case of coupled microstrip lines)
ts	Transverse component (with respect to the direction
	of propagation)
tans	Tangential component
nor:	Normal component

Abbreviations

2

BEM :	Boundary element method
DAI:	Dielectric air interface
LSE:	Longitudinal section electric
LSM:	Longitudinal section magnetic
MIC:	Metallic portion of the y=h plane in Fig. 1-1
TE:,	Transverse electric
TEM :	Transverse electromagnetic
TIM :	Transmission line matrix
TM :	Transverse magnetic

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I. HISTORICAL REVIEW OF NUMERICAL METHODS APPLIED TO MICROSTRIPS

A. Introduction

Microstrips are microwave circuits which are constructed by printed circuit techniques. Prior to the development of printed circuit technology, structures formed of conducting surfaces of various configurations were used as electromagnetic waveguides. Microstrip circuits have been favoured over waveguide technology for many applications, due to their low cost and compactness. Also, microstrips are of interest since, in principle, the same microstrip circuit can be used for a very broad frequency range. Extensive research has been carried out on microstrip structures. During the decade spanning the years 1945 to 1955, this field of research grew so rapidly that a special issue of the IRE Transactions on Microwave Theory and Techniques was totally devoted to this field [1].

The basic microstrip structure consists of a dielectric sheet, called the substrate, which is bounded by a ground plane on one side and by a thin, metallic circuit on the other side. The geometry of this circuit determines the electromagnetic properties of the microstrip structure. Significant circuit size reduction can be accomplished by using an appropriate dielectric material; the relative dielectric constant of substrates is typically about 10.

At the heart of many complicated microstrip circuits lie three basic microstrip structures, namely, lines, coupled lines and resonators, as shown in Fig. 1-1. These structures are analyzed numerically in this thesis.

Microstrip lines (Fig. 1-1a) are the "second generation" of printed transmission lines. The original version, called "stripline", was introduced in 1949, [2]. A stripline is similar to a microstrip line, except that it has an additional dielectric and ground plane above the strip conductor. Striplines are no longer commonly used, since they are harder to manufacture than microstrip lines.

A microstrip line (Fig. 1-la) is assumed to extend to infinity in the z-direction (i.e., the direction of propagation of the electromagnetic waves). In practice, the microstrip line exhibits a characteristic impedance, Z, which is used to terminate the line. In this way, the reflection of electromagnetic waves is avoided. Thus, a line of finite length can be treated in the same way as one that is infinitely long.

Microstrip lines are normally placed in a grounded metallic box having dimensions which are usually considerably larger than the line width; the resulting structure is called a shielded microstrip line (Fig. 1-1b). By shielding a microstrip line, electromagnetic interference problems can be avoided. The effect of these shielding walls on the properties of microstrip lines is usually negligible.

A coupled microstrip line consists of a pair of closely spaced parallel metallic strips bonded to the dielectric



shielded microstrip resonator.

substrate at the y=h plane (Fig. 1-1c). The ground plane lies on the opposite side of the substrate. With two conducting strips and a ground plane, the structure has two independent modes of propagation.

Microstrip resonators (Fig. 1-1d) consist of a metallized area in the y=h plane (rectangular, circular, elliptical or triangular shapes are commonly used); the dimensions of this metallized area are usually of the order of a wavelength at the frequency at which the resonator resonates.

Advances in semiconductor technology have created an interest in the integration of microwave circuits. Monolithic microwave integrated circuits are active circuits operating at microwave frequencies in which the solid state devices and the microwave circuit have been integrated. In recent years, the terms "stripline", "microstrip" and "microwave integrated circuits" have come to be used interchangeably. However, the term "monolithic microwave integrated circuits" refers only to the active circuit described above. In this thesis, only microstrip structures are analyzed (i.e., microstrip lines, coupled lines and microstrip resonators).

Rapid advances in microstrip technology have stimulated much theoretical research; an important goal of this field is the computer-aided design of microstrips. The main objective of this thesis is to develop computer algorithms which may eventually lead to the analysis of a wide variety 4

of microstrip structures. The basic concepts underlying the different theoretical methods used to analyze these structures are presented. These methods are important for the design of microstrips. It is hoped that these theoretical methods will lead to the computer-aided design of microstrips.

In order to analyze microstrip lines, the type of electromagnetic waves which propagate in the lines must first be determined. A microstrip line resembles a two-conductor transmission line and thus, at first, it may appear that the structure supports TEM (transverse electromagnetic) waves. However, this is true only if the relative dielectric constant of the dielectric substrate, $\mathcal{E}_{\mathbf{r}}$, tends to unity. Otherwise, the line cannot support TEM waves, since the phase velocity of the waves in the substrate will be different from that in When the operating frequency approaches zero, the the air. electromagnetic fields approach a TEM configuration (even when $\varepsilon_r \neq 1$), which is referred to as the quasi-TEM regime [2]. The microstrip can be assumed to be in the quasi-TEM regime when the wavelength of the propagating waves is larger than the microstrip line width and the substrate height [3]. In the quasi-TEM regime, the parameters of a microstrip line can be calculated with the simplifying assumption that the propagating waves in the microstrip line are TEM. Coupled microstrip lines can be treated similarly. Quasi-TEM methods are useful not only as a first step towards the exact analysis of microstrips, but also as engineering design aids. For example, a 500 microstrip line can be treated as a TEM line

5.

up to approximately 10 GHz. Thus, several quasi-TEM methods which are frequently used are explained briefly in this chapter. With the continuing advances of semiconductor technology, microstrips are being designed for operation at ever higher frequencies, where the quasi-TEM approximation may not be justified. An exact analysis of microstrips thus becomes necessary. Moreover, quasi-TEM approximations can be used } only for some resonator shapes, such as rectangular resonators. In this chapter, some mathematical procedures which have been applied to date to the analysis of microwave integrated circuits (Fig. 1-1) are discussed. The merits of each method (e.g., the accuracy of the results and the computer space and time requirements) are also discussed whenever such data have been given in the original papers. However, it is necessary to emphasize that some of the methods are more analytical in nature and that the time spent in formulating them may overshadow considerations of the final matrix size and computer efficiency. Such analytical methods are important if they can be generalized to a wide variety of microstrip structures. Thus, a number of methods used by engineers are explained in this chapter and the possibility of generalizing them to more

complicated problems is also discussed. Other aspects of microstrips, which deal with higher order modes; radiation from sharp edges, microstrip loss, surface waves, and box resonances are not included in this work. The basic concepts necessary to formulate and analyze

6

microstrips are discussed first. Next, the mathematical methods applied by others to microstrips are summarized. The methods are classified and discussed according to their application to microstrip lines, coupled lines and resonators. These methods are quite diverse and few of them can be used to analyze all the microstrip structures shown in Fig. 1-1.

Sec. B, titled "Microstrip Lines", is based on the work done by Mittra and Itoh [2]. A modified discussion is presented, which includes more recent publications. The approach has been to avoid mathematical détail, while, at the same time, to give a sufficiently comprehensive review of each method to communicate its essence. Some quasi-TEM methods are presented first. Next, a semi-empirical model is explained which describes the frequency behavior of microstrip lines. Subsequently, the works of other researchers dealing with the exact analysis of microstrip lines are presented.

Sec. C (Coupled Microstrip Lines) is similarly a modification of the work of Weiss [4], together with the review of several works published in recent years.

In Sec. D (Microstrip Resonators), some approximate methods for evaluating the resonant frequencies of microstrip resonators are explained. Such approximate methods are applicable to simple resonator geometries, such as rectangular-, circular-, or ring-resonators. Subsequently, other exact formulations are reviewed.

Sec. E (Review Conclusions) compares the methods discussed

in this chapter. It is argued that methods involving integral equations are better suited for analyzing microstrips than other methods. Furthermore, this section introduces the methods that are developed in this thesis.

B. Microstrip Lines

Quasi-TEM Analysis

Preliminary Discussion

For sinusoidal time variations, the electric and magnetic field components of the waves propagating in microstrip lines must satisfy the steady-state Maxwell's equations

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VX HowerE.			(l-lb)
∇· Ĕ=0 ,		a	(l-1¢)
VII-0.	1. 3 . Nation		(l-ld)

where

 \vec{E} is the electric field intensity,

 \overline{H} is the magnetic field intensity,

µ is the magnetic permeability of free space,

E is the dielectric constant of free space,

 c_r is the relative dielectric constant;

(c, in dielectric,

l in air.

and

where f is the frequency.

In the analysis of microstrip lines, it is assumed that the lines are lossless and infinitely long. Consequently, the fields travelling along the positive z-axis are assumed to vary as $\exp(-j\beta z)$. β is called the propagation constant in the z-direction. Eqs. 1, together with the assumption that the fields vary as $\exp(-j\beta z)$ in the z-direction, result in Helmholtz's equation for \vec{E} and \vec{H} in the microstrip line cross section (i.e., the x-y-plane):

 $\nabla_{i}^{*}\vec{E} + (\kappa k^{*} - \beta^{*})\vec{E} = 0,$ $\nabla_{i}^{*}\vec{H} + (\kappa k^{*} - \beta^{*})\vec{H} = 0,$

and

where

 $\nabla_{i}^{2} = (3/3 \times)^{2} + (3/3 \times)^{2}$, (1-2c) $k = 2\pi f/c$, (1-2d)

(1-2a)

(1-2b)

and c is the speed of light in free space.

Microstrip lines can be fully analyzed by solving Eqs. 1-2, subject to the boundary and continuity conditions for \vec{E} and \vec{H} . However, it has been customary to solve Helmholtz's equation for two properly chosen potential functions and to obtain the field components from these potential functions. This approach will be more fully explained in the section "Exact Analysis of Microstrip Lines" (p. 20).

In this section, the simpler case of the quasi-TEM regime is studied. When 4=1, the lowest order solution

of Eqs. 1-2 is of the TEM form [2] and [4], with $\beta = k$. It is then possible to obtain the field components from a potential function which satisfies Laplace's equation in the cross section

$\nabla_t^2 \varphi(x, y) = 0.$ (1-2e)

where **p** is the electrical potential distribution in the microstrip cross section.

When $\epsilon_r \neq 1$, the fields approach a TEM configuration for lower frequencies [2]. This assumption, as explained above, is only valid when f and thus k is small, since for $\epsilon_r \neq 1$, $\beta \rightarrow k$ only as $k \rightarrow 0$.

In order to describe the boundary conditions imposed on φ , two definitions are introduced: DAI connotes the dielectric air interface at the y=h plane in Fig. 1-1, and MIC refers to the metallic portions of the microwave integrated circuits at the. y=h plane (Fig: 1-1). These acronyms will be used throughout the thesis.

The boundary conditions imposed on $\varphi(x,y)$ are as follows (Fig. 1-1a):

 $\varphi(\mathbf{x}, \mathbf{0}) = 0$, $\varphi(\mathbf{x}, \mathbf{h}) = V$ volts on the MIC

The continuity of the displacement vector at the DAI.

 $\mathcal{E}_{\mathbf{h}} \partial \varphi(\mathbf{x}, \mathbf{h}) / \partial \mathbf{y} = \partial \varphi(\mathbf{x}, \mathbf{h}) / \partial \mathbf{y}, \qquad (1-3c)$

(-1 - 3a)

where

h=Lim y y→h y<h

and

H=Lim y y→h y>h

(1-3e)

(1-4a)

(1-3d)

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Furthermore, the strip thickness, t, of Fig. 1-la and 1b is usually assumed to be negligible. With this assumption, the free electrons in the strip can be regarded as a surface charge layer $\rho(\mathbf{x})$; therefore

$\epsilon_{\tau} \partial \varphi(\mathbf{x}, \mathbf{h}^{\tau}) / \partial \mathbf{y} - \partial \varphi(\mathbf{x}, \mathbf{h}^{\tau}) / \partial \mathbf{y} = \rho(\mathbf{x}) / \epsilon. \qquad (1-3f)$

The electric field distribution at a microstrip line cross section is illustrated in Fig. 1-2. Fig. 1-2a shows the field distribution for the case $(\xi_r=1)$.

When $\ell_r \neq 1$, due to the boundary condition of Eq. 1-3c, the electric field lines refract at the DAI (Fig. 1-2b).

At this point, the parameters used to characterize microstrip lines are introduced [2]. The capacitance, C, per unit length of the line is defined as

C=Q/V

where V^* is the potential on the strip (Eq. 1-3b) and Q is the total charge on the strip given by

$\mathbf{Q} = \int \frac{\mathbf{v}}{\mathbf{v}} \mathbf{r} \mathbf{v} \, \mathrm{d}\mathbf{x}. \qquad (1-4b)$

When $\epsilon_r = 1$, the capacitance per unit length is denoted by C_{\bullet} . The characteristic impedance of a microstrip



- (b)
- Fig. 1-2 Sketch of the electric field configuration at a microstrip line cross section
 - (a) the case $l_{r}=1$;
 - (b) the case $c_{p} \neq 1$; the electric field lines refract at the DAI (dielectric air interface).

'line with $\boldsymbol{\varepsilon_r}$ =l is defined as

 $\overline{Z}_{\bullet}=1/(cC_{\bullet})$.

For the case $\xi_{r} \neq 1$, the characteristic impedance is

Z=Z.(C./C) 1/2

The propagation constant along the z-axis is related to the wavenumber, k, as follows

 $\beta = k(C/C_{o})^{1/2}$ (1-4e)

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(1-4c)

(1-4d)

The factor (C/C_{\bullet}) is called the effective dielectric constant and is denoted by \mathcal{E}_{\bullet} . Thus,

B =ve.k.

The physical meaning of C_0 , is as follows: Assume that the dielectric substrate of Figs. 1-1a, b, or c is removed and the whole region around the conductors is filled with a dielectric material with a relative dielectric constant equal to c_0 , then Z and β will still be given by Eqs. 1-4. However, c_0 is frequency dependent. In the quasi-TEM approximation, the value of c_0 at zero frequency is obtained.

Summarizing, in the quasi-TEM method, the Laplace equation (Eq. 1-2e) is solved for the potential distribution, φ , at the microstrip line cross section. The boundary conditions imposed on φ are described in Eqs. 1-3. The characteristic impedance, Z, and the effective dielectric constant, \mathcal{E}_{e} , of the line is calculated from (Eqs. 1-4). In the following sections, the methods used by different authors for the quasi-TEM analysis of microstrip lines are summarized.

Quasi-TEM Methods

Wheeler 1 has used conformal mapping for solving the Laplace equation at the microstrip line cross section.

The mapping transforms the original microstrip line into a parallel-plate structure bounded by two vertical magnetic side walls (i.e., a surface on which the normal component of E is zero). The DAI is mapped into a curved surface. The curved DAI is then approximated by straight lines parallel to the coordinate axes. Microstrip lines are classified into three cafegories, according to their width. Different mapping functions are used for each category.

The results obtained by Wheeler $\begin{bmatrix} 1 \end{bmatrix}$ are extensively used in microstrip designs, because of their low cost and ease of programming. Unfortunately, the method cannot be generalized to the exact analysis of microstrips, since conformal mapping is applicable to Laplace's equation only.

In the finite difference (relaxation) method, the unknown field distribution is quantized at discrete intersections of coordinate grids called the net - or mesh-points [5]. The potential function can be expanded in a Taylor series about each mesh-point.

The potentials at the conductors are known. In this way, a matrix equation is obtained which can be solved by a matrix inversion. However, when the

number of mesh-points is large, the matrix inversion becomes very time consuming.

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A superior method which reduces the computer time for finding the unknowns is the relaxation method [6] and [7]. The relaxation method is a numerical algorithm for finding the unknowns by the method of successive approximations.

The finite difference method is easy to formulate and program. The method can be easily generalized to the exact analysis of microstrips, but the final matrix size is usually large (c.f. Finite Difference Method applied to the wave analysis described on page 23). In the variational method in the Fourier Transform domain [8], the strip is considered as an infinitely thin layer of charge. Thus, Poisson's equation is solved in the cross section of a microstrip line (Fig. 1-1a)

 $\nabla_{i}^{2} \varphi(\mathbf{x}, \mathbf{y}) = -(1/\varepsilon) \rho(\mathbf{x}) \delta(\mathbf{y} - \mathbf{h}), \qquad (1-5)$

Taking the Fourier transform of Eq. 1-5 in the x-direction and applying the boundary conditions yields

$\tilde{\varphi}(\gamma, \mathbf{h}) = \tilde{\varphi}(\gamma) / \{ \boldsymbol{z} | \gamma | [1 + \boldsymbol{\varepsilon}_r \operatorname{cot} \mathbf{h}(|\gamma|\mathbf{h})] \}. \quad (1-6)$

Eq. 1-6 leads to a variational form for the capacitance per unit length, C, in the Fourier domain.

The variational method has the property of including only the charge distribution in the final equation. The accuracy of the results depends on the assumed
charge distribution. The method does, in general,

provide a lower bound to the value of the capacitance.

The typical computer (CPU) time needed is less than 10 secs. on an IBM 7094 computer [8].

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The integral equation method uses Green's functions and can be used in cases where the strip thickness cannot be neglected [9] and [10]. Define

G(x, y; x., y.)

such that

 $\nabla_i^*G(x, y; x_0, y_0) = (1/\epsilon) \delta(x-x_0) \delta(y-y_0).$ (1-7) G is the potential at (x.y) due to a charge located at (x_, y_). Applying the superposition principle, the potential can be expressed as

 $p(\mathbf{x}, \mathbf{y}) = \int_{M\mathbf{x}} G(\mathbf{x}, \mathbf{y}; \mathbf{x}, \mathbf{y}) \rho(\mathbf{x}, \mathbf{y}) d\mathbf{I}_{o}$. (1-8) The potential distribution is known on the MIC, say φ -V; Eq. 1-8 is an integral equation with unknown ρ , and can be solved by discretizing the equation. The typical computer time needed is 30 secs. for a resulting matrix size of 30 X 30.

The method of moments [11] is closely related to the integral equation method. In this method, a function similar to the Green's function is found for a very narrow but finite line. In this way, the integral of Eq. 1-8 is discretized.

In the generalized Wiener-Hopf method [12] and [13], the potential and the charge distributions are found by This method uses Eq. 1-6 obtained above.

Taking the potential of the strip as 1V, we can express φ at the y=h plane as

 $\varphi(x, h) = h(x - \pi/2) u(x - \pi/2)$

+[u(x+w/2) - u(x-w/2)]+h(-x-w/2)u(-x-w/2). (1-9)

where u(x) is a unit step function and h(x) is the unknown potential function on the DAI. Taking the Fourier transform of Eq. 1-9 with respect to x we obtain

 $\tilde{\varphi}(\gamma, h) = 2[\sin(\gamma w/2)/\gamma]$

 $+ \exp(j\gamma w/2) H(\gamma) + \exp(-j\gamma w/2) H(-\gamma). \quad (1-10)$

where $H(\mathbf{i})$ is the Fourier transform of $h(\mathbf{x})u(\mathbf{x})$.

Comparing Eqs. 1-6 and 1-10 we obtain

 $\tilde{\rho}(\gamma) \{ \epsilon | \gamma | [1 + \epsilon_{r} \cot h(|\gamma|h)] \} = 2 \sin(\gamma w/2) / \gamma$

 $+\exp(j\gamma \pi/2) H(\gamma) + \exp(-j\gamma \pi/2) H(-\gamma). \quad (1-11)$

Eq. 1-11 includes two unknown functions, $\tilde{\rho}(\mathbf{i})$ and $H(\mathbf{i})$, but both can be found by considering the properties of the complex functions involved. Firstly, $\tilde{\rho}(\mathbf{i})$ has no poles in the entire complex

7-plane, since $\rho(x)$ is a function which is nonzero on the MIC only. Secondly, H(3') must have all its singularities in the lower 7-plane, since h(x) is nonzero for x greater than w/2 only. H(3') and H(-3') are thus expanded in terms of their poles which must coincide with the poles of the expression in the left-hand side of Eq. 1-11. Evaluating Eq. 1-11 at the known zeros of the left-hand side results in a set of equations in terms of the unknown coefficients of expansion for H(1). These equations are then transformed into a much more rapidly converging set of equations.

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Sketches of the charge and potential distribution obtained by the Wiener-Hopf method [12] are shown in Fig. 1-3. The method gives accurate results even for very small matrix equations (~5x5), and provides the charge and the potential distributions. However, the Wiener-Hopf method is, in general, difficult to formulate and cannot be used as a prescription when applied to new problems. The generalization of the method to coupled microstrip lines and resonators seems very difficult.

In the mode-matching method [3], the cross section of a shielded microstrip line is divided into several rectangular regions. In each rectangular region the fields are expanded in terms of known solutions of the Laplace equation with unknown coefficients. The application of the boundary and continuity conditions yield the unknown coefficients. The resulting matrix size is large (40 x 40 in [3]). The accuracy of the results oscillates as a function of the resulting matrix size [3].



Exact Analysis of Microstrip Lines

Preliminary Discussion

In the previous section, the quasi-TEM approach to microstrip lines and the concept of e_e were introduced. However, since the wave velocity in the dielectric is different from that in free space, it is impossible to support a TEM mode in the microstrip line; as the frequency is increased, e_e and consequently Z are changed.

In the exact analysis of microstrip lines, called the wave analysis, the field components are usually expressed in terms of a superposition of the TE (transverse electric) and TM (transverse magnetic) fields, which are, in turn, derivable from two scalar potentials [14], namely,

$\psi^{(\bullet)}$ and $\psi^{(h)}$

which satisfy the Helmholtz equation (i.e., Eqs. 1-2) such that

 $E_{z}=j[(\kappa k^{z}-\beta^{z})/\beta]\psi^{(e)}(x, y)\exp(-j\beta z) \qquad (1-12a)$ $H_{z}=j[(\kappa k^{z}-\beta^{z})/\beta]\psi^{(h)}(x, y)\exp(-j\beta z) \qquad (1-12b)$ $E_{t}=\nabla_{t}\psi^{(e)}\exp(-j\beta z)-(\omega \mu/\beta)\hat{a}_{z}X\nabla_{t}\psi^{(h)}\exp(-j\beta z) \qquad (1-12c)$ $H_{t}=(\omega \kappa \varepsilon/\beta)\hat{a}_{z}X\nabla_{t}\psi^{(e)}\exp(-j\beta z)+\nabla_{t}\psi^{(h)}\exp(-j\beta z) \qquad (1-12d)$

where \vec{E} is the electric field and \vec{H} is the magnetic field; the indices z and t denote the z- and the transverse-components. \hat{a}_z is the unit vector along the z-axis. The boundary and continuity conditions on the field components are obtainable by Eqs. 1-12. The lowest-order mode approaches the quasi-TEM mode, as explained above. In the following sections, methods used for the wave analysis of microstrip lines are summarized. The strip thickness, t, is assumed to be negligible, unless otherwise specified.

LSE (Longitudinal Section Electric) Model

Based on the field configurations in a microstrip line, Getsinger [15] has proposed a model for the microstrip line which supports LSE (longitudinal section electric) waves, shown in Fig. 1-4a. It is easier to analyze this model than the actual microstrip line. The solution for the structure of Fig. 1-4 is found and yields

 $\varepsilon_{e} = \varepsilon_{r} - (\varepsilon_{r} - \varepsilon_{ee}) / [1 + G(1/1_{p})^{2}]$ (1-13)

where Coo is the zero frequency limit of Co

(obtainable by quasi-TEM methods) and G and f, are parameters that depend on the characteristic impedance.

Eq. 1-13 shows the general behavior of the dispersion relation (i.e., Covs. f); it is drawn in Fig. 1-4b. The slope of Cogoes to zero as the frequency approaches zero. The dispersion curve possesses an inflection point at

 $f_1=f_p/\sqrt{3G}$

and asymptotically approaches e_r as the frequency



Fig. 1-4 (a) LSE (longitudinal section electric) model for a microstrip line; (b) general behavior of the effective dielectric

general behavior of the effective dielectric
 constant, *c*, as a function of frequency
 obtained from the LSE model.

goes to infinity. In the following sections, more rigorous methods of obtaining the dispersion relation

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Exact Methods

The two potential functions

4(*) and 4(h)

of Eqs. 1-12 satisfy a two-dimensional wave equation in the microstrip line cross section (Fig. 1-1b); thus, they can be expanded in terms of known solutions to the Helmholtz equation in dielectric and in air. The imposition of the boundary and continuity conditions on \vec{E} and \vec{H} yields a pair of coupled integral equations [16]. These equations may be transformed into a matrix equation and solved numerically, yielding the dispersion relation. The final matrix size and accuracy depend on which boundary and continuity conditions on the six electromagnetic components are chosen and how they are manipulated. Similar methods are presented in [17] and [18].

The finite difference method discussed in the quasi-TEM approach can be extended to apply to the wave analysis of microstrip lines.

After properly applying the discretized version of the wave equation and the boundary conditions at all of the mesh-points, an eigenvalue matrix equation is obtained. The algorithm in this method is straightforward, but the final eigenvalue matrix is large (e.g., 100 x 100 or larger [19]) and the results are less accurate than those obtained by integral equation methods [2]. The mode matching method discussed in the quasi-TEM approach can also be applied to the wave analysis of microstrip lines [20]. The dielectric and air regions in the cross section of a microstrip line are divided into a few rectangles. In each rectangle, the two potential functions are expanded in terms of solutions to the Helmholtz equation. The functions are chosen so that the boundary conditions on the electric and magnetic walls are satisfied. Using the conditions for the continuity of the electromagnetic field components, the solutions written in the rectangular subregions can

be matched. In this way, a set of equations for the unknown coefficients is obtained. The final matrix required for reasonable accuracy is 42×42 , [2].

In the finite element method, the differential equations and the boundary conditions are transformed into a variational expression, which yields the field distributions and **c** when optimized. The microstrip line cross section is subdivided into a number of arbitrarily shaped triangles; each corner of a triangle is called a node. In each triangle, the fields are written in terms of known linear functions of x and y and unknown nodal values of the potential functions. Since the potential functions are linearized in each triangle, it is possible to integrate the variational expression.

The resulting expression is then optimized with respect to the unknown nodal values, yielding an eigenvalue matrix equation in terms of ℓ_{\bullet} . The resulting matrix size may be as large as 126 x 126; the obtained results are accurate within a few percent [21].

In the transmission line matrix method (TLM), the microstrip line cross section is subdivided into a mesh as in the finite difference method. However, the functions are not linearized in between the mesh-points; the distance between any two adjacent pairs of mesh-points which lie along the coordinate axes is considered to be a segment of transmission line. The response to an impulse applied at a node is calculated by letting the impulse scatter in the mesh and reflect back and forth a large number of times.

This method is easily capable of handling losses and discontinuities. The dimension of the final matrix size is typically 270 X 270. The iteration number is 200, the required time is 2.16 min. on an ICL 1906A computer, and the required memory space is 20k words [22].

Open Microstrip Lines

The effect of the enclosing walls on the properties of a shielded microstrip line is usually negligible (by design). However, some mathematical methods are simplified when applied to open microstrip lines (Fig. 1-1a). In the integral equation method [23], the Fourier transform of the Helmholtz equation for the potential functions of Eqs. 1-12 is taken with respect to x. The Fourier transforms of the two potential functions are expressed in terms of known solutions of the Helmholtz equation. Separate solutions are written in dielectric and in air, which satisfy the boundary conditions on the ground plane and at infinity.

The following conditions at the y=h plane (Fig. 1-1a) are used to match the solutions obtained for the dielectric and the air regions

 $E_{t}(x,h^{-})=E_{t}(x,h^{+}), \text{ on the DAI}$ $E_{t}(x,h^{-})=E_{t}(x,h^{+})=0, \text{ on the MIC}$ $H_{z}(x,h^{-})-H_{z}(x,h^{+})=J_{x}(x), \text{ on the MIC}$ $H_{x}(x,h^{-})-H_{x}(x,h^{+})=J_{z}(x), \text{ on the MIC}$ $E_{t}(x,h^{-})-H_{x}(x,h^{+})=J_{z}(x), \text{ on the MIC}$ $E_{t}(x,h^{-})-H_{x}(x,h^{+})=J_{z}(x), \text{ on the MIC}$

where E_t is the tangential component of the electric field, H_x and H_z are the x- and z-components of the magnetic field, and J_x and J_z are the x- and z-components of the current distribution on the MIC, respectively.

The matching procedure results in a set of equations in terms of the current distribution on the MIC. The resulting equations are then solved by trying suitable functions with unknown coefficients which approximate the actual current distributions. This method of expressing the unknown fields in terms of the current distribution on the MIC is widely used in microstrip analyses. The resulting matrix equation can be solved, yielding \mathcal{E}_{e} . The size of the final matrix equation is usually small and depends on the assumed current distribution [23].

In Galerkin's method [24] the final equations are solved in the Fourier transform domain. The tangential component of the current distribution along the z-axis, J_x , is non-zero only on the MIC (Fig: 1-1a); E_x is non-zero only on the DAI. Thus, the product of $J_x(x)$ and $E_x(x,h)$ is identically zero. Applying Parseval's theorem, we have

 $\int_{-\infty}^{\infty} J_{s}(x) E_{s}^{a}(x, h) dx = f/(2\pi) \int_{-\infty}^{\infty} \tilde{J}_{s}(\gamma) \tilde{E}_{s}^{a}(\gamma, h) d\gamma = 0. \quad (1-14)$

A similar equation can be obtained in terms of J_x . Eq. 1-14 can be used as a boundary condition yielding a pair of coupled integral equations in terms of \tilde{J}_x and \tilde{J}_z . The equations are then solved by expanding \tilde{J}_x and \tilde{J}_z in terms of known basis functions with unknown

coefficients. The merits of this method are similar to the integral equation method described in the previous *section.

C. Quasi-TEM Analysis of Coupled Microstrip Lines

Preliminary Discussion

Due to the symmetry of the coupled lines about the y-axis (Fig. 1-1c) there are two normal modes for the structure, namely, the even mode and the odd mode. In the quasi-TEM regime, the mode with equal voltages on the left and the right strips is called even, and the mode with equal amplitude voltages but of opposite sign is called odd.

Since the field configurations are different for the two modes, it is expected that there are two values for Z and ϵ_{e} , namely

Ze: [#]even-mode characteristic impedance,

€.o: odd-mode €.

The numerical methods applied to the coupled microstrip lines in the quasi-TEM regime are presented in the following sections.

Green's Function

In the Fourier integral method, a function g(x,y;x',h) is found, where g(x,y;x';h) refers to the electrostatic potential at point (x,y) due to a line charge at (x',h), [25]. In practice, it is easier to consider a charge element of nonzero width and finite charge density.

The strips may be regarded as a parallel arrangement of such charge elements. Using the superposition principle.

 $\varphi(\mathbf{x}, \mathbf{y}) = \int_{-\infty}^{\infty} g(\mathbf{x}, \mathbf{y}; \mathbf{x}', \mathbf{h}) \rho(\mathbf{x}') d\mathbf{x}', \qquad (1-15)$

where ρ is the charge distribution over the microstrip lines. Let R(1) be the Fourier transform of $\rho(x)$ and $G(x,y; \mathbf{i})$ be the Fourier transform with respect to x' of g(x,y;x',h) then Eq. 1-15 can also be written as $\mathbf{r}(x,y) = \int_{a}^{\infty} G(x,y;\gamma) R(\gamma') d\gamma.$ (1-16)

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(1-17)

For the normal modes, the potential values on the strips are known. The charge distribution can be found from Eq. 1-16.

G(x,y;i) can be interpreted as the potential distribution due to the surface charge

 $\rho_{o}(x) = (1/2\pi) \exp(-j\gamma x)$,

since

 $G(\mathbf{x}, \mathbf{y}; \mathbf{\gamma}) = (1/2\pi) \int g(\mathbf{x}, \mathbf{y}; \mathbf{x}', \mathbf{h}) \exp(-j\mathbf{\gamma}\mathbf{x}) d\mathbf{x}'$. (1-18) Thus, G can be obtained. An alternate method for finding the Green's function is described below:

In the bound charge method, the Green's function is first approximated by a function $g_{\bullet}(x,y;x',h)$. $g_{\bullet}(x,y;x',h)$ is the same as the actual Green's function when the substrate is removed [26]. The error in this assumption is a function $g_{e}(x,y;x',h)$ such that

 $g(x, y; x', h) = g_o(x, y; x', h) + g_o(x, y; x', h).$ (1-19) Since g_o is the solution for the structure without the dielectric, it will be the solution to the actual structure, provided that there is a charge distribution at the y=h plane given by

 $\rho_{\epsilon}(\mathbf{x}; \mathbf{x}') = \epsilon(\epsilon_{r}-1) \hat{\mathbf{a}}_{r} \cdot \nabla g_{\epsilon}(\mathbf{x}, \mathbf{h}; \mathbf{x}', \mathbf{h}). \quad (1-20)$ We may place a compensating bound charge

 $\rho_{e}(\mathbf{x}; \mathbf{x}')$ at y=h

so that g satisfies the DAI continuity condition. The next step is to find $\rho_c(x;x')$ and $g_c(x,y;x',h)$. g_e is given by

 $g_{c}(\mathbf{x}, \mathbf{y}; \mathbf{x}', \mathbf{h}) = (1/4\pi\epsilon) \int_{\mathbf{L}} \rho_{c}(\mathbf{x}'; \mathbf{x}'') g_{c}(\mathbf{x}, \mathbf{y}; \mathbf{x}'', \mathbf{h}) d\mathbf{x}'', \quad (1-21)$

where L is the line described by y=h (Fig. 1-1a).

Applying the continuity condition at the DAI to g yields an integral equation in terms of the unknown .

Having found P_c , Eq. 1-21 can then be used to obtain g_c . The desired Green's function is eventually found from Eq. 1-19 by adding g_t to g_c . The time needed on an IBM 360/67 computer is 0.72 + 21.4NT, where NT is the number of the lines of data produced (e.g., 214.72 secs. for 10 lines of data). The computer space needed is 64,000 bytes [26].

Mode Matching

This method is the same in principle as the mode matching method described under the quasi-TEM analysis of microstrip lines on p. 18, 3, only this time for coupled microstrip lines.

Variational Method

The Laplace equation can be transformed into the

variational expression

 $W = \int \int_{\mathbb{R}^{d}} [(\partial \varphi / \partial \mathbf{x})^{2} + (\partial \varphi / \partial \mathbf{y})^{2}] d\mathbf{x} d\mathbf{y}. \qquad (1-22)$ where S is the cross section of the microstrip line. W can be interpreted as the stored electric energy. If a function φ is found such that W is minimized, then φ satisfies the Laplace equation.

The trial field φ can be chosen to be the same functions as used in the mode matching method above [27]. After the necessary boundary and continuity conditions are imposed on the solutions, a set of unknown coefficients remain. W of Eq. 1-22 is then optimized with respect to these coefficients, yielding a set of linear equations in terms of the coefficients. The final matrix size is about 4x4. The method provides the upper-bound values of the capacitance. The results are poor for very narrow microstrip lines, but the accuracy increases for moderately wide microstrip lines [27]. This work is complementary to that of Yamashita and Mittra [8], in that their results provide lower bound values for the capacitance.

Variational Method in the Fourier Transform Domain

This is exactly the same method as explained in the quasi-TEM analysis of the single microstrip lines [28]. For coupled microstrip lines the method should be modified slightly to accommodate for the even and the odd modes. The charge distribution is identical on the two strips for the even modes. For the odd modes the charge distributions on the two strips are equal in magnitude but are opposite in polarity.

The required computer time per data point is 32 secs. on a Univac 1108 computer. The efficiency of this method depends on which function is chosen to represent the charge distribution [28].

D. Microstrip Resonators

Transmission Line Models

One of the simplest microstrip resonators is a length of microstrip line called the rectangular resonator (Fig. 1-5a). Assuming perfect open circuits at both ends (Fig. 1-5b), the resonator will resonate at frequencies for which

 $L=n(\lambda_{a}/2), n=1, 2, \cdots$ (1-21)

(1-23)

Considering that the guide wavelength is given by $\lambda_{e} = c/(f\sqrt{e})$, (1-22) we obtain

 $f = nc/(2L\sqrt{c}), n=1, 2, \cdots$

 ϵ_{e} is in turn a function of f. The resonant frequencies can be found from Eq. 1-21 and the dispersion relation. The results obtained by Eq. 1-21 are accurate within a few percent, the inaccuracy being primarily caused by the fringing fields at the resonator ends.

A more accurate transmission line model is shown in Fig. 1-5c. The end effects are taken into account



Fig. 1-5 Transmission line models for microstrip resonators;

- (a) rectangular resonator;
- (b) transmission line model neglecting fringing fields;
- (c) transmission line model with fringing fields;
- transmission line model with fringing fields; due (d) to odd symmetry, half of model (c) is sufficient; (e)
 - open-ring resonator which can be modelled by (d).

by adding the capacitors C_{i} at the ends. The values of C_{i} are calculated and are available in [29] and [30].

If the rectangular resonator is "bent" so that the two ends come close to each other, the open-ring resonator shown in Fig. 1-5e is obtained [31]. The transmission line model for this resonator is shown in Fig. 1-5d, [32]. This resonator shows interesting properties [31]. especially for the principal mode (i.e., n=1 in Eq. 1-21). For this mode, the resonator shas an odd symmetry with respect to the z=0 plane; Fig. 1-5c can be short circuited in the middle. The resulting model is shown in Fig. 1-5d.

The resonant frequency can be obtained by letting the impedance at the right and the left at any cross section of the transmission line add up to zero (Fig. 1-5d).

Z₁+Z₂=0,

where

 $Z_1 = 1/(j\omega C_1)$, (1-25)

(1-24)

and

 $Z_{g}=Z/tan[\omega f_{L}/(2C)]$ (1-26)

Substituting Eqs. 1-25 and 26 into 24 we get $tan[\omega \sqrt{L}/(2C)] = \omega C_{2}Z.$ (1-27)

Eq. 1-27 yields the odd mode resonant frequencies of the resonator. The accuracy of this method is typically -4% or better [32].

Transmission-line modelling can also be applied to the ring resonator of Fig. 1-6a; the resonator resonates at frequencies at which L, the mean length, is an integral multiple of λ_g . The model gives accurate results only when w/L ≤ 0.05 , [33].

Magnetic Wall Models

The effect of w and curvature in the ring resonators are not negligible. For this reason, ϵ_0 as calculated for a straight microstrip line is not necessarily the same for the ring resonator [33]. The effect of curvature in the ring resonator is included by regarding the resonator as a cavity with electric walls on the top and the bottom, and magnetic walls on the sides (Fig. 1-6b). The cavity is assumed to be filled with the substrate dielectric material.

Moreover, it is assumed that the variation of fields in the y-direction is negligible; the fields are TH with respect to the y-axis; Maxwell's equations yield

 $J_{a}'(\varepsilon_{r}kr_{o})Y_{a}'(\varepsilon_{r}kr_{i}) - J_{a}'(\varepsilon_{r}kr_{i})Y_{a}'(\varepsilon_{r}kr_{o}) = 0.$ (1-28) where J_{n} and Y_{n} are Bessel functions [33].

This model gives accurate results when $w/L \leq 0.05$, [33]. Based on this theory, the mode chart for the resonator is obtained in [34].



Fig. 1-6 (a) Ring resonator at y=h plane [33]; (b) magnetic wall model of ring resonator.

Fringing Effects

The resonant frequencies calculated by the magnetic wall modelling can be inaccurate up to several per cent [35] (e.g., up to 10% for the open-ring resonator [36]), since the fringing fields at the resonator edges are not negligible.

The effect of the fringing fields can be taken into account by regarding the resonator as a capacitor. The theoretical calculation of the capacitance reveals an effective change in the resonator dimensions due to fringing. Furthermore, an effective dielectric constant is found which reflects the nonuniform charge distribution in the resonator, which is different from the DC charge distribution. Finally, to obtain the resonant frequency, a magnetic wall model is considered for which the effective dimensions are obtained theoretically and is filled with a dielectric material with the effective dielectric constant.

The results of the above theory show good agreement with experiments [36].

Exact Formulation

In this section, the exact methods which have been applied to microstrip resonators are summarized, namely, the mode-matching, self-reaction, Galerkin and TLM methods.

The mode matching method, as described above, can be applied to the disc resonator. The size of the resulting matrix equation is 20x20. With this matrix size, the results are accurate to within 1%. The computer time on a TELEFUNKEN computer TR440 is 0.666 secs. [37].

In the self-reaction method as mentioned above, the reaction of the field on its own source, should be zero. The ring resonator has been analyzed by this method [38]. However, the generalization of this method to other geometries seems impossible.

Rectangular resonators have been analyzed by Galerkin's method [39] which is a generalization of the Galerkin method described previously. The typical computer time on CDC G-20 computer is 200 secs. per structure. More time is required for analyzing narrower rectangular resonators.

In [40], the six component Maxwell equations are solved, including the loss in the dielectric and the metals by the TLM method.

This method can be applied to microstrip resonators of any geometry. The size of the resulting matrix is 704 x 704 and the iteration number is 400. The computer time on the ICL 1906A computer is 11.26 mins. The computer space needed is 46k words.

E. Review Conclusions

In the previous sections, methods for obtaining the properties of microstrip lines, coupled lines, and resonators were reviewed. Few of these methods can be easily generalized so that they will include the three structures of Fig. 1-1.

Since microstrip technology is advancing rapidly, a need exists for accurate methods which can be easily programmed, which are sufficiently flexible to include all three basic microstrip structures, and which are cheap and efficient in terms of computer time and memory space. In this thesis, novel numerical methods are developed which attempt to fulfil these requirements.

Due to the sharp edges of the MIC, some of the field components can be expected to become singular near these edges [41]. For this reason, any numerical method which does not include these singularities will likely result in large matrices. However, since the total energy around the edges remains finite, it must be possible to remove the singularities. Following this reasoning, it can be deduced that methods which employ integral equations are intrinsically better suited for analyzing microstrips (since integration is performed over the singularity). Many such methods, including methods using Green's functions, were discussed in the previous sections. In some cases, such as in the "Bound Charge Method", it is a major undertaking to obtain the Green's functions.

In order to utilize the interesting properties of

Green's functions, while at the same time keeping the effort of finding these functions minimal, it is possible to modify the integral equations in such a manner that simpler Green's functions can be employed. One such method is the BEM (boundary element method) [42] and [43]. This method, as well as other novel methods, are applied to the analysis of microstrips.

The analysis of microstrip resonators is a complex problem. Therefore, simpler structures are analyzed first. The methods developed for analyzing single and coupled microstrip lines are then applied to the analysis of microstrip resonators. However, each method is useful and applicable to engineering design.

F. Thesis Organization

Chap. 2 deals with the quasi-TEM analysis of microstrip lines and coupled lines. The boundary value problem is first transformed into an integral equation which is then solved by the BEM. Chap. 2 introduces two new concepts. First, the thin MIC sheet is included in the integral equation and is represented as a charge layer, and the singularity in the charge distribution on the MIC is explicitly included in the integral equation. Second, the integral equation is formulated in such a manner that a simple free-space Green's function can be used, regardless of the dielectric substrate; therefore, no method of images is necessary to find more complicated Green's functions.

However, the generalization of the method presents some difficulties. For this reason, the integral equation method of Chap. 2 is further modified in Chap. 3. In this chapter, Green's functions are generalized and are made more flexible so that they can be applied more easily to the wave analysis of microstrips.

In Chap. 4 the generalized Green's functions developed in Chap. 3 are employed. Moreover, Chap. 4 introduces a new approach to the wave analysis of microstrips. It is shown that boundary conditions for Ey, the y-component of the electric field (Fig. 1-1), can be totally separated from the other components of the electromagnetic fields. Thus, instead of using two potential functions $\psi^{(e)}$ and $\psi^{(h)}$ (introduced in this chapter), it is possible to solve the boundary value problem for Ey. The parameters of engineering interest, such as \mathcal{E}_{e} for the microstrip lines, and the resonant frequency of resonators, can be obtained from Ey alone. This greatly reduces the effort of analyzing microstrips.

The domain of integration of the integral equation derived in Chap. 4 is the DAI. It seems difficult, if not impossible, to generalize this method to microstrip resonators. For this reason, the method of Chap. 4 is modified in Chap. 5 so that the domain of integration will be that of the MIC. Chap. 5 also gives an example of how this method can be applied to microstrip resonators.

In Chap. 6, the overall conclusions of this thesis are summarized and recommendations are made for further research.

II. A BOUNDARY ELEMENT METHOD

A. Introduction

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In this chapter, microstrip lines and coupled lines in the quasi-TEM regime are analyzed by the boundary element method (BEM). The BEM is a method in which a boundary value problem is first converted into a boundary integral equation, integrated over the boundaries of a domain. The boundary is then divided into a set of elements over which the functions under consideration can vary in different ways, as in the method of finite elements [42] and [43].

The BEM offers important advances over the finite element and finite difference methods; the resulting system of equations is much smaller, less time is required to solve a problem, and the accuracy is greater than in the "domain" type methods, i.e., finite elements 42 and 43. Moreover, the BEM can be applied to problems with infinite domains.

The classical boundary solution known as the boundary integral method is closely related to the BEM [42], [43], and [44].

As noted in Chap. 1, a boundary value problem can be transformed into an integral equation by many different ways. A good formulation can greatly reduce the effort for solving a problem. One possible formulation uses Green's functions. However, as Beckenbach [45] has stated, "in actual boundary-value problems it is often difficult to

determine the Green's function and in many cases it is easier to solve the problem directly by numerical methods than by the use of the general theory".

To analyze microstrip lines in the quasi-TEM regime, the Laplace equation for the potential function at the microstrip cross section is transformed into an integral equation. The domain of integration of the integral equation is the y=h plane (Fig. 1-1). In this way, the boundary conditions for the thin MIC sheet are imbedded in the integral equation and are represented in the form of a charge distribution. Moreover, the integral equation is formulated in such a way that the free-space Green's function can be used, regardless of the dielectric substrate; thus, the method of images is not required to find a more complicated Green's function. Finally, the obtained integral equation is applied to coupled microstrip lines.

B. Formulation

For a microstrip line in the quasi-TEM regime, it is required to solve the Laplace equation

$\nabla_{t}^{*}\varphi=0,$

in the microstrip cross section (Fig. 2-la). It is assumed that the microstrip is unshielded, the ground plane potential is zero, and the strip potential is unity. The boundary conditions at the y=h plane are as follows: The continuity of the potential implies that /

9 7-2 - - - P 7-2 +

Further, the continuity of the normal component of the

43

(2-1)

(2 - 2a)



displacement vector on the DAI implies that

$$e_{r}(\partial \varphi / \partial y|_{y=b}) = (\partial \varphi / \partial y|_{y=b}) \qquad (2-2b)$$

Moreover, on the MIC

$$e_{\mathbf{y}}(\partial \varphi / \partial \mathbf{y}|_{\mathbf{y} \to \mathbf{h}}) - (\partial \varphi / \partial \mathbf{y}|_{\mathbf{y} \to \mathbf{h}}) = p(\mathbf{x}), \qquad (2-2c)$$

where p(x) is the charge distribution on the MIC. The microstrip structure in Fig. 2-la is equivalent to that of Fig. 2-lb, [1]. The boundary and the continuity conditions on the y=-h plane in Fig. 2-lb resemble Eqs. 2-2.

The infinite geometry of Fig. 2-1b is first approximated by the finite geometry of Fig. 2-2, enclosed within a circle of radius R; the two geometries become identical when R tends to infinity. Consider Green's second identity

 $\int_{\mathbf{S}} (\varphi \nabla_{t}^{2} \psi - \psi \nabla_{t}^{2} \varphi) dS =$

 $\int d \varphi(\partial \psi/\partial n) - \psi(\partial \varphi/\partial n)] dC \qquad (2-3)$ where S is the area enclosed by the curve C, and $2/\partial n$ designates the normal derivative. In this work φ is the potential function, and ψ is an auxiliary function called the fundamental solution. This is similar to a Green's function, by means of which φ can be obtained. The procedure is explained below.

Applying Eqs. 2-3 to regions S_1 , S_2 , and S_3 yields $\int_{\mathbf{S}} (\varphi \nabla_{\mathbf{v}}^2 \psi - \psi \nabla_{\mathbf{v}}^2 \varphi) d\mathbf{S} =$

 $\int c_i Ur_i [\varphi(\partial \psi/\partial n) - \psi(\partial \varphi/\partial n)] dC \qquad (2-4a)$

 $\int_{\mathbf{S}_2} (\varphi \nabla_t^2 \psi - \psi \nabla_t^2 \varphi) \, \mathrm{dS} =$

 $\int_{\mathbf{r}_{\mathbf{z}}} \int \mathcal{U}_{\mathbf{z}} \mathcal{U}_{\mathbf{z}} \mathcal{U}_{\mathbf{z}} \mathcal{U}_{\mathbf{z}} \left[\varphi(\partial \psi / \partial \mathbf{n}) - \psi(\partial \varphi / \partial \mathbf{n}) \right] dC, \qquad (2-4b)$ $\int_{\mathbf{z}_{\mathbf{z}}} \left(\varphi \nabla_{\mathbf{z}}^{\mathbf{z}} \psi - \psi \nabla_{\mathbf{z}}^{\mathbf{z}} \varphi \right) dS =$

 $\int_{\mathbf{r}_{4}\mathbf{v}c_{3}} \left[\varphi(\partial \psi/\partial \mathbf{n}) - \psi(\partial \varphi/\partial \mathbf{n}) \right] d\mathbf{C}. \qquad (2-4c)$



Fig. 2-2 Equivalent structure for the microstrip line used for BEM (Boundary Element Method); R is assumed to be infinitely large.

•

where U designates the union of two sets. Thus $C_1 U \Gamma_1$ is the curve which encloses S_1 (Fig. 2-2).

Multiplying Eq. 2-4b by \mathcal{E}_r and adding it to Eqs. 2-4a and 4c results in

$$\int \mathbf{s}_{1} U \mathbf{s}_{3} \left(\varphi \nabla_{t}^{2} \psi - \psi \nabla_{t}^{2} \varphi \right) dS + \int \mathbf{s}_{2} \varepsilon_{r} \left(\varphi \nabla_{t}^{2} \psi - \psi \nabla_{t}^{2} \varphi \right) dS = \int c_{1} U r_{1} U r_{4} U c_{3} \left[\varphi \left(\partial \psi / \partial \mathbf{n} \right) - \psi \left(\partial \varphi / \partial \mathbf{n} \right) \right] dC + \int r_{3} U c_{3} U r_{4} U c_{4} \left[\varphi \left(\partial \psi / \partial \mathbf{n} \right) - \psi \left(\partial \varphi / \partial \mathbf{n} \right) \right] dC$$

The fundamental solution is assumed to satisfy

$$\nabla_t^2 \psi = \delta(\mathbf{x} - \mathbf{x}_i) \, \delta(\mathbf{y} - \mathbf{y}_i)$$

regardless of the boundary conditions. Considering Eqs. 2-1 and 6, the left hand side of Eq. 2-5 reduces to $-a_i \varphi_i$ where

if (x_i, y_i) is in the air,

 ε_r if (x_i, y_i) is in the dielectric,

and

a......

 $\boldsymbol{\rho}_{i} = \boldsymbol{\varphi}(\mathbf{x}_{i}, \mathbf{y}_{i}) \quad (2-8)$

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(2-5)

(2-6)

(2-7)

If (x_i, y_i) is chosen to have a nonzero distance from the origin, then as R tends to infinity, the integrands of the right hand side of Eq. 2-5 vanish on $C_1 \cup C_2 \cup C_3 \cup C_4$. Thus, as R- ∞ , Eq. 2-5 yields

$$-\partial_{1} \varphi_{j} = \int_{\infty}^{\infty} \left[\varphi(\partial \psi/\partial y) - \psi(\partial \varphi/\partial y) \right]_{y=h}^{+} (-dx) \\ + \int_{\infty}^{\infty} \left[\varphi(-\partial \psi/\partial y) - \psi(-\partial \varphi/\partial y) \right]_{y=h}^{-} dx \\ + \int_{\infty}^{\infty} \left[\varphi(\partial \psi/\partial y) - \psi(\partial \varphi/\partial y) \right]_{y=h}^{-} (-dx) \\ + \int_{\infty}^{\infty} \left[\varphi(-\partial \psi/\partial y) - \psi(-\partial \varphi/\partial y) \right]_{y=h}^{+} dx .$$
(2-9)

Considering Eqs. 2-2, Eq. 2-9 results in $a_{j}\varphi_{j} = -(e_{r}-1)\int [\varphi(\partial\psi/\partial y)]_{y=h} dx - \int [\psi]_{y=h} dx$ $f(e_{r}-1)\int [\varphi(\partial\psi/\partial y)]_{y=h} dx + \int [\psi]_{y=h} dx$, (2-10) where P is the charge distribution over the upper strip in Fig. 2-2. Considering the odd symmetry of φ with respect to the y=0 plane (Fig. 2-1b), Eq. 2-10 reduces to

$$-\mathbf{a}_{\mathbf{y}}\varphi_{\mathbf{y}} = (\varepsilon_{\mathbf{x}} - 1) \int \mathcal{A} \left[\varphi \right]_{\mathbf{y} - \mathbf{h}} + \left[\left(\frac{\partial \psi}{\partial \mathbf{y}} \right]_{\mathbf{y} - \mathbf{h}} + \right] d\mathbf{x}$$
$$+ \int \mathcal{A} \left[\frac{\psi}{2} \left(\rho/\varepsilon \right) \left(\frac{\psi}{\mathbf{y}} \right]_{\mathbf{y} - \mathbf{h}} + \frac{\psi}{2} \right] d\mathbf{x} \qquad (2-11)$$

The solution to Eq. 2-6 is [42]

$$\psi = (1/2\pi) \ln r_{j} = (1/4\pi) \ln[(x-x_{j})^{3} + (y-y_{j})^{3}], \qquad (2-12)$$

where

$$r_{j} = \sqrt{(x-x_{j})^{2} + (y-y_{j})^{2}}$$
 (2-13)

Thus

$$\partial \psi / \partial y = (1/\pi) \{ (y-y_i) / [(x-x_i)^2 + (y-y_i)^2] \}.$$
 (2-14)

Eq. 2-11 should be modified if (x_i, y_i) is chosen to lie on y=h, since Eq. 2-14 becomes indefinite as (x, y)approaches (x_i, y_i) . Therefore, Γ_3 and Γ_4 must be deformed into a semicircle with radius r, in the vicinity of (x_i, y_i) as shown in Fig. 2-3; the limit of the first integral at the right of Eq. 2-11 is found as r tends to zero.

It can be shown that, if y=h, then

 $\int_{7_{4}} \varphi(\partial \psi / \partial \mathbf{n}) \, dC + \varepsilon_{r} \int_{7_{3}} \varphi(\partial \psi / \partial \mathbf{n}) \, dC = -(e_{r} - 1) \varphi_{i} / 2 \,. \qquad (2-15)$ Eq. 2-11 should thus be modified to

$$(1/2)(\varepsilon_{r}+1)\varphi_{r}=(\varepsilon_{r}-1)\int_{-\infty}^{\infty}(\varphi|_{y=b}+)[(\partial\psi/\partial y|_{y=b}+)-(\partial\psi/\partial y|_{y=b}+)]dx$$

$$=\int_{-\infty/2}^{\infty}(\rho/\varepsilon)(\psi|_{y=b}+\psi|_{y=b}+)dx. \qquad (2-16)$$

Substituting the results of Eqs. 2-12 and 14 into 16 yields $-(1/2)(e_r+1)g(x_h,h^+) =$

 $(\varepsilon_{x}-1)\int_{-\pi}^{\pi} \varphi(x, h^{+})(h/\pi) \{1/[(x-x_{j})^{2}+(2h)^{2}]\} dx$ $-\int_{-\pi}^{\pi}/2[\rho(x)/(4\pi\varepsilon)] \ln[(x-x_{j})^{2}/[(x-x_{j})^{2}+(2h)^{2}]\} dx$ 48

(2-17)



Fig. 2-3 DAI deformed in the vicinity of (x_i, y_i) in order to find the limit of $\frac{3\Psi}{3y}$ as (x, y)approaches (x_i, h) , (Eq. 2-11).

Eq. 2-17 is an integral equation which is equivalent to the Laplace equation and the boundary conditions described by Eqs. 2-2. To make this integral equation suitable for numerical solutions, three additional modifications are required:

- the fact that $\rho(x)$ is singular at $\pm w/2$ must be included, - there must be a change of units to simplify the integrals, and

-the symmetry of the microstrip line about the y-axis must be taken into consideration.

The fact that the energy should be finite in the vicinity of the microstrip edges leads to the conclusion that $\rho(x)$ should vary as r''^{*} at the edges, [41] and [46], where r is the distance from the MIC edges; thus let the charge distribution be explicitly expressed in terms of these singularities at $x=\pm w/2$;

$p(\mathbf{x}) = \overline{\chi}(\overline{\mathbf{x}}) / \sqrt{1 - (2\mathbf{x}/\mathbf{w})^3}, \qquad (2-18)$

(2-19)

where $\bar{\chi}(x)$ is a slowly varying function which describes the behavior of the charge distribution away from the singular edges of the MIC. The factor ϵ is included in the definition in order to make the computations easier. An explicit representation of the singularity in ρ greatly reduces the numerical effort and leads to a higher computational accuracy with smaller matrix sizes [47].

The change of units

<=2x/w

together with substitution of Eq. 2-18 in 17 results in

$-2\pi(\varepsilon_{+}1)\Phi_{i}=(2/\eta)(\varepsilon_{r}-1)\int_{-}^{-}\varphi(\xi)\{1/[(\xi-\xi_{i})^{2}+(2/\eta)^{2}]\}d\xi$ $-\eta \int_{-1}^{1} [x(\xi)/\sqrt{-\xi^{2}} \ln \{(\xi-\xi)^{2}/[(\xi-\xi)^{2}+(2/\eta)^{2}]\} d\xi,$ (2-20)

 η - \(2h),			(2-21a)
 ζ ₁ =2 <u>1</u> ₁ / w , =φ(wζ/2,			(2-21b)
Ψ ₁ ======(ζ ₁);	μ,		(2-21c)

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$$x(5) = x(m5/2).$$
 (2-21-5)

Eq. 2-20 can be solved numerically by the usual BEM procedures combined with quadrature formulae for integration.

In the following sections the algorithm for solving Eq. 2-20 is presented for special cases and is then generalized to include the analysis of single and coupled microstrip lines.

Microstrip Lines with 4=1

When $e_r=1$, Eq. 2-20 reduces to

where

where

and

$$G_{1} = -\int_{-1}^{1} [\chi(\zeta) / \sqrt{-\zeta^{2}}] \ln[(\zeta-\zeta)^{2} + (2/\eta)^{2}] d\zeta, \qquad (2-22b)$$

$$G_{2} = \int_{-1}^{1} [\chi(\zeta) / \sqrt{1-\zeta^{2}}] \ln(\zeta-\zeta)^{2} d\zeta, \qquad (2-22c)$$

Note that $\Phi_i = 1$ on the MIC.

Eqs. 2-22 are the same as those obtained by Acton 47 using Green's functions. The techniques presented by Acton 47 to treat the singularities are very helpful in solving " Eqs. 2-22. The integral Eqs. 2-22, when discretized, yield a set of linear equations. The domains of integration of
Eqs. 2-22 should be transformed to remove the singularities. The singularities of Eq. 2-22b occur at

ζ=±1;

The following transformation removes this singularity:

$\zeta = \sin 0.5\pi v$

(2-23)

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Considering this transformation and the even symmetry of the quasi-TEM mode about the y-axis, and using the quadrature formulae for integration [48], we can write

$G_{1} \approx (\pi/2) \sum_{j} W_{j} \chi_{j} \ln \{ [\zeta_{j} - \zeta_{j}]^{2} + (2/\eta)^{2}] [(\zeta_{j} + \zeta_{j})^{2} + (2/\eta)^{2}] \}$ (2-24) where

$\zeta_1 = \sin 0.5\pi \nu_{\rm fr}$

and X_j is the value of χ at ζ_j

$\chi_j = \chi(\zeta_j)$.

W_j and ν_j are the parameters of the quadrature formulae for integration given in [48]. The computer program for evaluating G₁ is called FIRST and appears in App. A. The singularities of Eq. 2-22c lie at

ζ=±1,

and at

۲-۲4

To discretize the integral of Eq. 2-22c it is assumed that the slowly varying function $X(\zeta)$ is constant at small intervals containing ζ_j as shown in Fig. 2-4. Thus, equation 2-22c can be discretized as

$$G_2 = \sum \chi \int \{\frac{1}{\sqrt{1-\zeta^2}} \ln(\zeta^2-\zeta^2)^2 d\zeta$$
. (2-26)

By the transformation

(2-25a)

(2-25b)



Fig. 2-4 $\chi(\zeta)$ discretized to facilitate the numerical solution of Eqs. 2-22.

the integral in Eq. 2-26 can be rearranged as $\int_{\frac{1}{2}}^{\frac{1}{2}} (1/\sqrt{1-\zeta^{2}}) \ln(\zeta^{2}-\zeta^{2})^{2} d\zeta = \int_{\theta_{1}}^{\theta_{2}} \ln(\sin^{2}\theta - \sin^{2}\theta_{1})^{2} d\theta$ $= \int_{\theta_{1}}^{\theta_{2}} \ln\left[\sin(\theta - \theta_{1}) / (\theta - \theta_{1}) \right] \left[\sin((\theta + \theta_{1}) / 2) / ((\theta + \theta_{1}) / 2) \right]$ $\left[\sin((\pi/2) - ((\theta + \theta_{1}) / 2)) / ((\pi/2) - ((\theta + \theta_{1}) / 2)) \right]^{2} d\theta$ $+ \int_{\theta_{1}}^{\theta_{2}} \ln(\theta - \theta_{1})^{2} d\theta + \int_{\theta_{1}}^{\theta_{2}} \ln(\theta + \theta_{1})^{2} d\theta$ $+ \int_{\theta_{1}}^{\theta_{2}} \ln(\theta + \theta_{1} - \pi)^{2} d\theta - (\ln 4) (\theta_{2} - \theta_{1})$

where

$\theta_1 = \sin^{-1} \zeta_{ij},$	· · ·			(2-29a)
$\theta_2 = \sin^{-1} \zeta_{uv}$		1	•	(2-29Ъ)

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(2 - 27)

(2-28)

(2-31)

and

at

$$i_{i} = \sin^{-1} \zeta_{i}$$
 (2-29c)

The last step is performed to remove the singularities

$$\theta_{\mu} = \theta_{\mu} (\theta + \theta_{j})/2 = 0$$
, and $(\theta + \theta_{j})/2 = \pi/2$.

Let

$$=\theta - \theta_{1} (thus e.g. A_{g} = \theta_{g} - \theta_{j}), \qquad (2-30a)$$

$$B = (\theta_{f} + \theta_{j})/2. \qquad (2-30b)$$

and

$$\overline{C} = (\theta + \theta_1 - \pi) / 2, \qquad (2 - 30c)$$

To use the quadrature formulae for integration, the integration domain has to be between -1 and +1, thus the

following transformation is employed

$$\theta = (\left(\theta_{1} + \theta_{1}\right)/2) + \nu \left(\left(\theta_{2} - \theta_{1}\right)/2\right)$$

Then Eq. 2-28 can be rewritten as

$$\int_{\frac{1}{2}}^{\frac{1}{2}} (1/\sqrt{1-\xi^{B}}) \ln(\xi^{B}-\xi^{B})^{B} d\xi = \\ (\theta_{B}-\theta_{1}) \int_{-1}^{-1} \ln[(\sin A/A)(\sin B/B)(\sin \overline{C}/\overline{C})] d\nu \\ + 2\ln[(A_{B}^{-\frac{1}{2}}A_{1}^{-1})(B_{B}^{-\frac{1}{2}}B_{1}^{-\frac{1}{2}})(\overline{C}_{B}^{-\frac{1}{2}}A_{1}^{-\frac{1}{2}})] \\ -(6+\ln 4)(\theta_{B}-\theta_{1}),$$

$$(2-32)$$

Considering Eq. 2- $3\overline{2}$, the results are presented in terms of forms like

sinA/A and A1^{A1}

since as A or A_1 tend to zero, these forms tend to unity; in the programming language, APL, these indeterminate forms are defined as unity. In this way, no extra branchings are required in the computer programs when A_1 , A_2 , etc., are zero in Eq. 2-32. The program to perform the integration of Eq. 2-32 is called INT and appears in App. A.

D. Final Assembly of the Matrix Equation

The different parts of Eq. 2-22 can be assembled to form the final matrix equations. Letting i and j vary over all the possible values, Eq. 2-24 results in

$[G_i]\{\chi\},$

where, from Eq. 2-24

 $G_{i,ij} = (\pi/2) \operatorname{W_{ln}}[((\zeta_j - \zeta_j)^2 + (2/\eta)^2][((\zeta_j + \zeta_j)^2 + (2/\eta)^2]]. \quad (2-33)$ is a column matrix containing χ_i, χ_2, \dots . Similarly, Eqs. 2-26 and 31 result in

$[G_2]\{\chi\}$

Thus, in matrix form, Eqs. 2-22 can be written as $\{F\} = ([G_1] + [G_2]) \{x\}$.

where $\{F\}$ is a column matrix, all elements of which are equal to $4\pi/\eta$ (Eq. 2-22a). The program FNL in App. A forms and solves the matrix Eq. 2-34.

(2 - 34)

The capacitance per unit length of a microstrip line with $\xi_{z}=1$ is the total charge per unit length divided by the strip potential, which is assumed to be unity. To find **C** the total charge, ρ must be integrated over the strip, thus $C = \int_{\eta}^{\eta} \rho d\mathbf{x} = \epsilon \eta \int_{-\mathbf{i}}^{\mathbf{i}} \chi / \sqrt{1-\zeta^{2}} d\zeta$, (2-35a)

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(2-35b)

(2-36e)

 $C_{\circ}\approx(\epsilon_{\eta}) \sum W_{j} \chi_{j}$ In the computations, C_{\circ} is found in units of ϵ .

E. Microstrip Line with E,#1

In the case where ζ_{\neq} 1, Eq. 2-20 must be solved. Let the first integral on the right hand side of Eq. 2-20 be designated by G_{ζ}

$$G_{5} = \int_{-\frac{\pi}{2}} \frac{d\zeta}{\zeta} / [(\zeta - \zeta_{1})^{2} + (2/\eta)^{2}] d\zeta \qquad (2-36a)$$

 Φ is known on the MIC and is equal to one volt. Thus, the portion of G₅ which is integrated over the MIC, G₆, can be easily found as

 $G_{e} \approx (\eta/2) \tan^{-1}[(1+\zeta_{1})\eta/2] - (\eta/2) \tan^{-1}[(1+\zeta_{2})\eta/2]$ (2-36b) Using the quadrature formulae of integration [48], the portion of G₅ which is integrated over the DAI, G₇, can be approximated by

 $G_{\eta} = \int \Phi_{j} \overline{W}_{j} \{ 1/[(\zeta_{j} - \zeta_{j})^{2} + (2/\eta)^{2}] + 1/[(\zeta_{j} + \zeta_{j})^{2}(2/\eta)^{2}] \}, \quad (2-36c)$ where

(2-36d)

 \overline{W}_j and \overline{v}_j are tabulated in [48]. G_5 is the sum of G_6 and G_7

$$G_{\mathfrak{g}} = G_{\mathfrak{g}} + G_{\mathfrak{f}} \, .$$

The results obtained for the case $\varepsilon_r = 1$ can be used for the case $\varepsilon_r \neq 1$ when slightly modified. Considering Fig. 2-5,



Fig. 2-5 Demonstration of ζ-axis divided into various segments using the data for numerical integration. (ζ-axis is the path defined by the y=h plane in a microstrip line cross-section). ζ_i can be greater than unity for the case $\varepsilon_r \neq 1$; ζ_i can lie on the DAI, since the integrals on the DAI do not vanish (Eq. 2-20) for $\varepsilon_r \neq 1$. The matrices $[G_1]$ and $[G_2]$ should be modified to $[G_3]$ and $[G_4]$, respectively, when $\zeta_i > 1$. The final matrix equation is

where

 $\{\Phi\}$ is a column matrix containing the unknown φ_i 's on the DAI (Fig. 2-5).

 $[G_1]$ and $[G_2]$ are the same as defined above, (Eqs. 2-33 to 34)

 $[G_3]$ is a modification of $[G_1]$ when $\zeta_i > 1$,

 $[G_{4}]$ is a modification of $[G_{5}]$ when $\zeta_{i} > 1$.

 $[\hat{G}_5]$ is defined by Eqs. 2-36, and

 $\{\hat{F}\}$ is a column matrix, the i' th element of which is

 $-2\pi(z_r+1)\varphi_i$

in

Eq. 2-37 should be further rearranged since φ_i is known only when ζ_i lies on the MIC. $\{\hat{F}\}$ contains some unknown φ_i and $\{\Phi\}$ contains some known φ_i ; rearranging Eq. 2-37 results

where $\{F\}$ is a column matrix all elements of which are equal to $-2\pi(\epsilon_{r}+1)$. By solving Eq. 2-38, the charge distribution on the MIC, the potential distribution on the DAI,

(2-38)

and the capacitance per unit length, C, can be calculated. Having $\{\chi\}$, the charge distribution can be obtained from Eq. 2-18 and the capacitance per unit length, C, can be calculated from Eq. 2-35a. Moreover, $\{\Phi\}$ provides the potential distribution on the DAI.

Having C, and C, it is easy to determine ϵ_e and Z from Eqs. 1-4. Calculated results are presented in Figs. 2-6 and 7 for the case $\epsilon_r = 9.9$ and w/h=1.0, and for several values of ϵ_r in Figs. 2-8 and 9. The results coincide with the results obtained by Yamashita and Mittra [8], and Mittra and Itoh 12. The overall matrix size is 15 x 15. The CPU time per run on the U, of A. AMDAHL 47/V6 computer is 0.08 sec. The computer programs, together with an illustrative example are presented in App. A.

As Figs. 2-6 through 9 show, the obtained results are identical to those obtained in [8] and [12]. However, the present method is easier to formulate, is more economical, and provides more information than other methods. Specifically, the variational method [8] provides ε_e and Z only; the computer time is 10 secs. on an IBM 7094. The integral equation method [11] provides $\rho(x)$, ε_e , and Z and the typical computer time is 30 secs. with a final matrix size of 30x30. The Wiener-Hopf method [12] provides $\rho(x)$, $\varphi(x,h)$, ε_e , and Z; the final matrix size is less than 10x10, but it is essentially an analytical method which seems impossible to generalize to coupled lines.

F: Coupled Microstrip Lines

Eq. 2-17 can easily be generalized to the case of

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Fig. 2-6 Potential <u>distribution</u> of a microstrip_line on the DAI vs. normalized distance with $c_r=9.9$ and w/h=1.0; results coincide with those of [12].



Fig. 2-7 Surface charge of a microstrip line vs. normalized distance on the MIC with $\xi = 9.9$ and w/h=1.0; results coincide with those of [12].



with those of [8].

Ű.



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Fig. 2-9 Normalized wavelength of a microstrip line vs. w/h for various c,; results coincide with those of [8]. coupled microstrip lines. The integration domain of the second integral on the right hand side of Eq. 2-17 should be modified to include both strips. The formulation details are given only for the case $\xi_{r}=1$ since the procedure for $\xi_{r}\neq 1$ closely follows that of the single microstrip line.

For coupled microstrip lines with &,=1, Eq. 2-17 reduces to

 $4\pi \bar{\Psi}_{i} = \int_{MiC} \left[\rho(\mathbf{x}) / \varepsilon \right] \ln \left\{ (\mathbf{x} - \mathbf{x}_{i})^{2} / \left[(\mathbf{x} - \mathbf{x}_{i})^{2} + (2h)^{2} \right] \right\} d\mathbf{x}.$ (2-39) Let

ξ=x/h;

define (Fig. 2-10)

σ=(s+w)/(2h),

and

η-w/(2h).

Then Eq. 2-39 can be rewritten, as.

 $4\pi \Phi_{4} = \int \left\{ \sum_{n=1}^{\infty} \left[\rho_{p}(\xi) / \varepsilon \right] \ln \left\{ \left(\xi - \xi \right)^{2} / \left[\left(\xi - \xi \right)^{2} + \left(2/\eta \right)^{2} \right] \right\} d\xi \\ + \int \sum_{n=1}^{\infty} \left[\rho_{n}(-\xi) / \varepsilon \right] \ln \left\{ \left(\xi - \xi \right)^{2} / \left[\left(\xi - \xi \right)^{2} + \left(2/\eta \right)^{2} \right] \right\} d\xi.$

where r_{p} and r_{p} are the charge distributions on the MIC on the positive and on the negative ξ -axis. For the even modes

 $\rho_{p}(\xi) = \rho_{n}(-\xi);$ (2-42a)

For the odd modes

$$\rho_{\mathbf{y}}(\xi) = \rho_{\mathbf{z}}(-\xi).$$
 (2-42b)

Considering the singularity of the charge at the MIC edges $P_{\mu}(\xi)$ can be written as

$$\varphi = \overline{\chi}(\sigma - f) / \sqrt{1 - [(\sigma - f) / \eta]^2}, \qquad (2 - 43)$$

where $\bar{\chi}$ is a slowly varying function of ξ .

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(2-40a)

(2-40b)

(2-40c)

(2-41)



⁽b**)**

Fig. 2-10 (a) Coupled microstrip lines; (b) coupled microstrip lines with normalized x-axis. For the even modes it is assumed that the voltages on both strips are +1 volt and that the voltage is zero on the ground plane. For the odd modes, it is assumed that the voltages are +1 volt on the right strip, -1 on the left strip, and zero on the ground plane.

The point ξ_i is chosen to lie on the right strip; thus $\Phi_i = 1.$ (2-44)

Combining Eqs. 2-41, 43, and 44 results in

$$\frac{1}{2} \frac{1}{2} \frac{1$$

where the plus sign holds for the even modes and the minus sign for the odd modes.

The transformation

simplifies Eq. 2-45 to

$$\eta \int_{-1}^{+1} [x(\zeta) / \sqrt{1-\zeta^{*}}] \{ \ln[(\zeta_{1}-\zeta)^{*} / [(\zeta-\zeta_{1})^{*} + (2/\eta)^{*}]] \\ \pm \ln[(\zeta_{1}'-\zeta)^{*} / ((\zeta_{1}'-\zeta)^{*} + (2/\eta)^{*})] \} d\zeta, \qquad (2-47)$$

where

$$i' = 2(\sigma/\eta) - i_{\rm H}$$

Eq. 2-47 can be discretized as follows

$$4\pi = \eta \sum_{j} \chi_{j} (G_{i,ij} - G_{i,ij} \pm G_{j,ij} \pm G_{j,ij}), \qquad (2-49)$$

where

$$G_{1,4} = \int \{\frac{1}{2} \ln((\zeta_1 - \zeta_1)^2 / \sqrt{1 - \zeta_1^2} d\zeta_1, (2-50a) \}$$

$$G_{2,4} = \int \{\frac{1}{2} \ln((\zeta_1 - \zeta_1)^2 / \sqrt{1 - \zeta_1^2} d\zeta_1, (2-50b) \}$$

 $G_{s,z} = -W_{jin}[(\xi_1 - \xi_j)^{s} + (2/\eta)^{s}],$ (2-50c)

$$G_{4,4} = \pi_{jn} [(S_{1} - S_{j})^{2} + (2/\eta)^{2}].$$
 (2-50d)

 X_j was defined in Eq. 2-25b, W_j and ζ_j are the parameters

(2 - 46)

of formulae for quadrature integration available in [48].

Eq. 2-49 can be written in matrix form as

$\{U_{i}^{t} = ([G_{1}] \pm [G_{2}]) \{\chi_{i}^{t} + ([G_{3}] \pm [G_{4}]) \{\chi_{i}^{t}\}.$

where {U} is a column matrix, all elements of which are equal to 4π , and {X} is a column matrix with elements χ_j . The plus and minus signs refer to the even and the odd modes, respectively. To evaluate $G_{1,ij}$, let

$\zeta = \sin\theta$,

Then, it can be shown that

$$G_{i,ij} = \int_{\theta_1}^{\theta_1} \ln\left[\sin\left(\left(\theta - \theta_i\right)/2\right) / \left(\left(\theta - \theta_i\right)/2\right) \right]^2,$$

$$\pi \cos\left(\left(\theta + \theta_i\right)/2\right) \right]^2 / \left[\left(\left(\pi/2\right) - \left(\left(\theta + \theta_i\right)/2\right)\right) \left(\left(\pi/2\right) + \left(\left(\theta + \theta_i\right)/2\right)\right) \right]^2 \right] d\theta$$

$$- 2 \left(\theta_2 - \theta_1\right) \ln(2\pi) + 2 \int_{\theta_1}^{\theta_2} \ln(\theta - \theta_1) d\theta$$

$$+ 2 \int_{\theta_1}^{\theta_2} \ln\left[\pi - \left(\theta + \theta_i\right)\right] d\theta + 2 \int_{\theta_1}^{\theta_2} \ln(\pi + \theta + \theta_1) d\theta.$$

(2-53)

(2-51)

(2-52)

G_{2,ij} can be found similarly.

Coupled Lines with $\epsilon_{,\neq 1}$

For coupled lines with $\epsilon_{r} \neq 1$ Eq. 2-17 should be modified as

$$\frac{-2\pi(\varepsilon_{x}+1)\Phi_{1}=2(\varepsilon_{x}-1)\Phi_{-}\Phi(\xi)/[(\xi-\xi_{y})^{2}+4]d\xi}{\int_{\sigma+\eta}^{\sigma+\eta}[\bar{\chi}(\sigma-\xi)/\sqrt{-((\sigma-\xi)/\eta)^{2}}]\{\ln(\xi-\xi_{y})^{2}/[(\xi-\xi_{y})^{2}+(2/\eta)^{2}]} \\ \pm \ln(\xi+\xi_{y})^{2}/[(\xi+\xi_{y})^{2}+(2/\eta)^{2}]\}d\xi, \qquad (2-54)$$
where
$$\bar{\Phi}(\xi)=\Phi(\pi\xi)-\Phi(-\xi)$$

The + and - signs in the right hand side of Eq. 2-54 refer to the even and odd modes, respectively. To simplify the integrations we introduce the following change of variables

$$\begin{aligned} \zeta = (\sigma - \xi)/\eta , & (2-55a) \\ o' = \sigma/\eta , & (2-55b) \\ \zeta'_{i} = 2 \sigma' - \zeta_{i} & (2-55c) \end{aligned}$$

Consider the integrals of Eq. 2-54. The potential is unknown on the DAI and the charge is unknown on the MIC. Thus, the integration domain is divided into three regions (i.e., the DAI in between the two strips, the strips and the DAI outside the strips) to make the numerical integration possible:

$$\begin{array}{c} (\sigma' -1) \overline{\nu}/2 + (\sigma' +1)/2; & 1 < \zeta < \sigma' \\ \sin 0.5 \pi \overline{\nu}; & -1 < \zeta < 1 \\ -(1 + \overline{\nu}); & -\infty < \zeta < -1 \end{array}$$

Substituting the change of variables for Eqs. 2-55 into 54 and following the same procedures as in the previous sections leads to $\mathbf{F} = (\mathbf{F} + \mathbf{F}) + \mathbf{F} + \mathbf$

$\{F\} = ([E_1] \pm [E_2]) \{\bar{\varphi}\} + ([E_3]) \pm [E_4]) \{\bar{\varphi}\}$

+([E_{s}] ±[E_{s}]) {x} +([E_{7}] ±[E_{s}]) {x} (2-56)

where $\{\clubsuit\}$ is a column matrix which contains the unknown values of the potential on the DAI in between the strips. Similarly, $\{\clubsuit\}$ is a column matrix with the unknown potential values on the DAI outside the strips. $\{\chi\}$ is a column matrix representing the unknown charge distribution on the strips. $\{\clubsuit\}$ is a column matrix with elements $-2\pi(c, +1)\clubsuit_i$, if the point i lies on the DAI and

$-2\pi (\epsilon_r+1) \Phi_i - 2(\epsilon_r-1) \int_{Mic} \left[(\epsilon - \epsilon_i)^2 + 4 \right]^{1} d\epsilon$

(2-57a)

if the point i lies on the MIC (c.f. the first integral in the right hand side of Eq. 2-54).

 $\begin{bmatrix} E_1 \end{bmatrix}$ through $\begin{bmatrix} E_8 \end{bmatrix}$ are defined as $E_{1,\frac{n}{2}} = \begin{bmatrix} (z_r - 1) (\sigma' - 1) / \eta \end{bmatrix} \overline{w}_f$

 $\left\{\frac{1}{[(\zeta_{1}-\zeta_{j})^{3}+(2/\eta)^{3}]\pm\frac{1}{[(\zeta_{1}'-\zeta_{j})^{3}+(2/\eta)^{3}]}\right\};$

 $-\infty \leq t_1 \leq \sigma'$; $1 \leq t_1 \leq \sigma'$.

 $\mathbf{E}_{s,y\pm E_{4,y}=}[2(\varepsilon_{y}-1)/\eta]\overline{\mathbf{w}}_{n}$

 $\left\{\frac{1}{[(\zeta_1-\zeta_2)^{2}+(2/\eta)^{2}]\pm 1}/[(\zeta_1'-\zeta_2)^{2}+(2/\eta)^{2}]\right\};$

-==<<;i<or; -==<<;i<-1; (2-57b)

Es, 1=Es, 1=17 1/2.

 $\{\ln[(\zeta_{1}-\zeta_{j})^{2}+(2/\eta)^{2}]\pm\ln[(\zeta_{1}-\zeta_{j})^{2}+(2/\eta)^{2}]\};$

 $E_{7, \frac{1}{2} \pm E_{8, \frac{1}{2}} = \eta \int_{T_{1}}^{T_{2}} (1/\sqrt{-\xi^{8}})$

 $\left[\ln(\zeta_1-\zeta)^*\pm\ln(\zeta_1'-\zeta)^*\right]d\zeta$

-••≤{₁≤σ': -1≤{₁≤1} (2-57d)

Moreover, different numerical procedures are

required in evaluating $[E_7]$ and $[E_8]$ depending on which region the point ζ_i lies in ; let

$$E_{7.4} = \begin{cases} F_{1.4} & \text{if } 1 \leq i \leq \sigma' \\ G_{1.4} & \text{if } -1 \leq i \leq 1 \\ H_{1.4} & \text{if } -1 \leq i \leq 1 \\ H_{1.4} & \text{if } -1 \leq i \leq 1 \end{cases}$$
(2-58a)

Thus

$$\begin{bmatrix} \mathbf{E}_{\mathbf{7}} \end{bmatrix} = \begin{bmatrix} \begin{bmatrix} \mathbf{F}_{\mathbf{1}} \end{bmatrix}$$

(2-58ъ)

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Finally, considering Eq. 2-56, some of the Φ_1 's appearing in $\{\hat{\mathbf{F}}\}$ are unknown and should be transferred to the right hand side of the equation. Eq. 2-56 can thus be rearranged as (1-1)

$$\{F_e\} = [G_e] \{\overline{a}\}$$

(2-59)

for the even modes. Similarly a matrix equation can, be obtained for the odd modes.

By solving the final matrix equations the evenand odd-mode characteristic impedance and c can be evaluated. The computer programs are presented in App. B. The results obtained by this method are presented in Figs. 2-11 and 12, and coincide with the results in [4] and [26]. The charge and the potential distributions at the DAI are calculated and presented in Figs. 2-13 and 14.

Neg. 2-15 shows the ε_e vs. s/h obtained for the case

w/h=1.0, and $c_r = 9.0$

The final matrix size is 35x35 and the CPU time on an AMDAHL 47/V6 per point per mode is 2.165 secs. For the sake of comparison, we note that with Green's functions [26], the required time on an IBM 360/67 is 22.12 secs., to obtain the same results with the same accuracy; the variational method [28] provides only to and Z with a required time of 32 secs. on a Univac 1108, and is less accurate (within 2%) than [26].

G. Summary

In this chapter, microstrip lines and coupled lines in the quasi-TEM regime were analyzed by the BEM. Laplace's equation at the cross section of a microstrip line (Fig. 1-1a) should be solved for the potential distribution-

 $\nabla^2 \varphi = 0.$ (2-1) The boundary and the continuity conditions at the y=h plane were

> > (2-2b)

On the DAI,

 $\varepsilon_{\tau}(\partial \varphi / \partial y|_{y=0}) = (\partial \varphi / \partial y|_{y=0})$

and on the MIC,



Fig. 2-11 Even- and odd-mode characteristic impedance of a coupled microstrip line vs. w/h for various values of s/h and 4=9.0; results coincide with [4] and [26].



Fig. 2-12 Even- and odd-mode ϵ_{e} of coupled microstrip lines vs. w/n for various values of s/h and $\epsilon_{r} = 9.0$.



Fig. 2-13 Even- and odd-mode surface charge vs. normalized distance on coupled microstrip lines; $\varepsilon_r = 9.0$, w/h=1.0 and s/h=0.3.





Fig. 2-15 Even- and odd-mode & of coupled microstrip lines vs. s/h; w/h=1.0 and & =9.0.

$$z(\partial \varphi/\partial y|_{y=1}) - (\partial \varphi/\partial y|_{y=1}) = P(x)/e \qquad (2-2)$$

where $\rho(x)$ was the charge distribution on the MIC. Green's second identity was used

 $\int_{\mathcal{S}} (\varphi \nabla^2 \psi - \psi \nabla^2 \varphi) \, \mathrm{dS} =$

$$\int d\varphi(\partial\psi/\partial n) - \psi(\partial\varphi/\partial n)] dC \qquad (2-3)$$

where γ was the free space Green's function. Using Eq. 2-3, both Laplace's equation and the boundary conditions were transformed into an integral equation on the y=h plane. $-(1/2)(z_r+1)\varphi(x_r,h')=$

 $(e_r-1)\int_{-\pi}^{\pi} \varphi(\mathbf{x}, \mathbf{h}^*) (\mathbf{h}/\pi) \{1/[(\mathbf{x}-\mathbf{x})^2+(2\mathbf{h})^2] d\mathbf{x} -\int_{-\pi}^{\pi} \frac{2\pi}{2} \rho(\mathbf{x})/(4\pi e_r) \ln[(\mathbf{x}-\mathbf{x})^2/[(\mathbf{x}-\mathbf{x})^2+(2\mathbf{h})^2] d\mathbf{x}$

The singularity in the charge distribution was inserted explicitly into Eq. 2-17

$$\rho(\mathbf{x}) = \bar{\mathbf{x}}(\mathbf{x}) / \sqrt{1 - (2\mathbf{x}/\mathbf{w})^2}.$$
 (2-18)

where $\vec{X}(x)$ was a slowly varying function. This reduced the final matrix size and increased the accuracy [59].

The simple case of a microstrip with $\ell_p=1$ was analyzed first. The singularities in the resulting equations were removed using appropriate transformations. The case $\ell_p = 1$ was then analyzed. The numerical results obtained for the single lines were shown in Figs. 2-6, 7, 8, and 9 and coincided with results obtained in [8] and [12].

The method was then applied to coupled microstrip lines. The results obtained by this method were presented in Figs. 2-11 and 12 and coincided with the results obtained in [4] and [26]. Additional original data were presented in Figs. 2-13, 14 and 15. 76

(2-17)

Conclusions

The BEM has been successfuly applied to microstrip lines and coupled lines in the quasi-TEM regime; the analysis is capable of evaluating the characteristic impedance, ε_e , the charge, and the potential distributions. The only other method yielding all of the above parameters and distributions is, to the author's knowledge, the Wiener-Hopf method [12]; however, it seems impossible to generalize the latter method to coupled lines and resonators.

The singularity in the charge distribution is included in the formulation. Moreover, the BEM has been modified by using the quadrature formulae for integration. This has resulted in increased accuracy and in a reduction of the size of the final set of equations. For microstrip lines, the final matrix size is 15x15 and for coupled lines, the final matrix size is 35x35.

The method is very efficient and accurate; the CPU time per run on the AMDAHL 74/V6 computer is 0.08 secs., for the analysis of microstrip lines and 2.165 secs. per run per mode for the analysis of the even- and odd-modes in coupled lines. III. AN ALTERNATIVE INTEGRAL EQUATION METHOD

A. Introduction

In Chap. 2 the BEM was applied to microstrip lines in the quasi-TEM regime. It is possible to generalize this method to the wave analysis of microstrip lines, but the fundamental solution will be difficult to obtain. To solve the Laplace equation, Green's functions are customarily defined so that they satisfy Poisson's equation; the forcing function is chosen to be a point charge. In this chapter, instead of Green's functions, a fundamental solution, $\boldsymbol{\gamma}$, is chosen so that it satisfies the Laplace equation. Moreover, the boundary conditions on ψ are defined such that the final integral equation is expressed in terms of the charge distribution alone. The method leads to expressions for the characteristic impedance and the effective dielectric constant for microstrip lines. The method is then applied to coupled microstrip lines, and in the following chapters it is generalized to the wave analysis of microstrips.

B. Formulation

For a microstrip line in the quasi-TEM regime, Laplace's equation for the potential function φ should be solved in the cross section of a microstrip line. The boundary conditions are given in Eq. 2-2 and are demonstrated in Fig. 3-1. The radius of the semicircle, R, in Fig. 3-1 is assumed to be infinite.

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Fig. 3-1 Open microstrip line; R is assumed infinitely.

large.

 (Φ_{i})

6.00-

Green's second identity can be applied to S_1 and S_2 of Fig. 3-1.

 $\int_{S_1} (\varphi \nabla_i^2 \psi - \psi \nabla_i^2 \varphi) \, \mathrm{dS} =$

 $\int c_1 U r_1 U c_3 U c_4 \left[\varphi(\partial \psi/\partial n) - \psi(\partial \varphi/\partial n) \right] dC; \qquad (3-1a)$ $\int s_2 \left(\varphi \nabla_t^2 \psi - \psi \nabla_t^2 \varphi \right) dS =$

 $\int_{C_2} y_{\Gamma_2} [\varphi(\partial \psi/\partial n) - \psi(\partial \varphi/\partial n)] dC. \qquad (3-1b)$ where, as shown in Fig. 3-1, the region S₁ is enclosed by paths C₁, Γ_1 , C₃, and C₄; the region S₂ is enclosed by paths Γ_2 and C₂; φ is the desired potential distribution; ψ is an auxiliary function (fundamental solution), and $\partial/\partial n$ designates the normal derivative. Adding Eq. 3-la to b results in

 $\int_{S_1 \cup S_2} (\varphi \nabla_t^2 \psi - \psi \nabla_t^2 \varphi) \, \mathrm{dS} =$

 $\int c_1 \forall r_1 \lor c_3 \lor c_4 \left[\varphi(\partial \psi / \partial n) - \psi(\partial \varphi / \partial n) \right] dC + \int \bar{c}_2 \lor r_2 \left[\varphi(\partial \psi / \partial n) - \psi(\partial \varphi / \partial n) \right] dC.$ (3-2)

 φ is zero on C₄ (Fig. 3-1). ψ is also defined to be zero on C₄. Moreover, φ and $\partial \varphi / \partial n$ tend to zero at infinity. Thus by letting R tend to infinity, Eq. 3-2 reduces to

 $\int_{\mathcal{B}_1 \cup \mathcal{B}_2} (\varphi \nabla_t^2 \psi - \psi \nabla_t^2 \varphi) \, \mathrm{dS} =$

 $\int_{\mathbf{r}_{\mathbf{i}}} [\varphi(\partial \psi/\partial \mathbf{n}) - \psi(\partial \varphi/\partial \mathbf{n})] d\mathbf{C} + \int_{\mathbf{r}_{\mathbf{a}}} [\varphi(\partial \psi/\partial \mathbf{n}) - \psi(\partial \varphi/\partial \mathbf{n})] d\mathbf{C}, \quad (3-3)$ where it is required that

∇²φ=0.

Up to this point, the procedure is almost the same as that in Chap. 2. However, the auxiliary function $\boldsymbol{\gamma}$ is assumed to satisfy Laplace's equation

(3-5)

(3-4)

80

This choice makes the final equation much simpler and results in a very simple numerical procedure. Moreover, as will be explained in the next chapter, it is easier to generalize this method, rather than the one in Chap. 2 to the wave analysis of microstrip lines.

Considering Eqs. 3-4 and 5, Eq. 3-3 can be written

$$= \int \left[\varphi(\partial \psi / \partial y|_{y=h}) - \psi(\partial \varphi / \partial y|_{y=h}) \right] (-dx) + \int \left[\varphi(-\partial \psi / \partial y|_{y=h}) - \psi(-\partial \varphi / \partial y|_{y=h}) \right] dx = \int \left[\varphi(\partial \psi / \partial y|_{y=h}) - \varphi(\partial \psi / \partial y|_{y=h}) \right] dx = \int \left[\varphi(\partial \psi / \partial y|_{y=h}) - \psi(\partial \varphi / \partial y|_{y=h}) \right] dx = \int \left[\psi(\partial \varphi / \partial y|_{y=h}) - \psi(\partial \varphi / \partial y|_{y=h}) \right] dx = (3-6)$$

By properly imposing the boundary conditions on Ψ , Eq. 3-6 can be reduced to a simple integral equation in terms of the charge distribution alone; let

$$(\mathcal{Y}|_{\mathbf{y} \to \mathbf{h}}) = \mathcal{E}_{\mathbf{r}}(\mathcal{Y}|_{\mathbf{y} \to \mathbf{h}}), \qquad (3-7a)$$

.81

and

as

$$(\partial \psi / \partial y|_{y=b}) - (\partial \psi / \partial y|_{y=b}) = 0.5[\delta(x=x_i) + \delta(x+x_j)].$$
 (3-7b)

Substituting from Eqs. 3-7 into 6, and considering the boundary conditions on φ at y=h (Eqs. 2-2) the following integral equation is obtained

$$0 = \varphi(\mathbf{x}, \mathbf{h}) - \int_{\mathrm{mic}} (\rho/\varepsilon) (\psi|_{\mathbf{y}-\mathbf{h}}) d\mathbf{x}. \qquad (3-8)$$

To find the function ψ which satisfies Eqs. 3-7, let (considering an even symmetry in a microstrip line),

$\int_{0}^{\infty} A(\gamma) \cos(\gamma x) \sinh(\gamma y) d\gamma; \quad 0 \le y < h$

$\int_{\mathbf{0}} \mathbf{B}(\gamma) \cos(\gamma \mathbf{x}) \exp(-\gamma \mathbf{y}) d\gamma, \quad \mathbf{h} < \mathbf{y}. \quad (3-9a)$

(3-9b)

 ψ as defined in Eq. 3-9a satisfies Laplace's equation. Imposing the boundary conditions of Eqs. 3-7 on ψ yields

$$A(\gamma) \sinh \gamma h = c_r B(\gamma) \exp(-\gamma h)$$
,

•

 \mathcal{D}

and

$B(\gamma) = (2/\pi) \exp(\gamma h) \cos(\gamma x_i) / [\gamma [1+\epsilon_r/t \operatorname{anh}(\gamma h)]]. \quad (3-9c)$

Substituting ψ from Eqs. 3-9 into 8 results in $\int \int_{\text{Euc}} [\rho(\mathbf{x})/\epsilon] \cos(\gamma \mathbf{x}) \cos(\gamma \mathbf{x}) / \{\gamma [1+\epsilon_r/\tanh(\gamma h)]\} d\mathbf{x} d\gamma = \pi/2.$ (3-10) where \mathbf{x}_i is chosen to lie on the MIC,

Eq. 3-10 is solved for the single microstrip line and coupled microstrip lines in the following sections.

C. Single Microstrip Line

As in Chap. 2, the singularity in the charge distribution is explicitly included in Eq. 3-10 for reducing the final matrix sizes'

$$y(x) = z \bar{\chi}(x) / \sqrt{1 - (2x/w)^2},$$
 (3-11)

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Eq/2-10 can be written as

of
$$J = \frac{1}{2} \chi(\mathbf{x}) \cos(\gamma \mathbf{x}) / \sqrt{1 - (2\mathbf{x}/\mathbf{w})^2} d\mathbf{x}$$

 $\frac{\cos(\gamma x_{i}) / \{\gamma [1 + \epsilon_{r} / \tanh(\gamma h)] \} d\gamma = \pi / 2.}{\text{To solve Eq. 3-12, let}}$ (3-12)

$$I = \int \frac{1}{\sqrt{2}} (x) \cos(\gamma x) / \sqrt{1 - (2x/\pi)^2} dx; \qquad (3-13)$$

Considering the even symmetry of the quasi-TEM mode in a microstrip line, the slowly varying function $\overline{X}(x)$ can be expanded in a Taylor series as

(3-15)

Thus

$$=\int_{-\sqrt{2}}^{\sqrt{2}} (\overline{K}_{0} + \overline{K}_{1} \mathbf{x}^{2} + \cdots) \cos(\gamma \mathbf{x}) / \sqrt{1 - (2\mathbf{x}/\mathbf{w})^{2}} d\mathbf{x}.$$

Applying the transformation

$$\sin \theta = 2x/w$$

to Eq. 3-15 and using the tabulated integrals of [49] yields

 $I = (\pi/2) [K_{o} J_{o} (0.5 \gamma \pi) + K_{1} J_{g} (0.5 \gamma \pi) + \cdots]. \qquad (3-16)$

Substituting from Eq. 3-16 into 12 yields

 $\sum_{n=0}^{\infty} K_{n} \int_{2n}^{\infty} (0.5\gamma w) \cos(\gamma x_{j}) / \{\gamma [1+c_{s}/t \operatorname{anh}(\gamma h)] \} d\gamma = 1.$ (3-17)

The following transformations are further used to simplify Eq. 3-17

α=γh, (3-18a) (3-18b)

and

η=ν/(2h).

Applying Eqs. 3-18 to 17 results in .

 $\sum_{n=0}^{\infty} K_n / \overline{\sigma} I_n(\eta \alpha) \cos(\alpha \eta \zeta_i) / [\alpha(1+\epsilon_r/t \operatorname{anh}\alpha)] d\alpha = 1.$ (3-19) Choosing N points for ζ_i and truncating the sum to N-1 results in an NxN matrix equation from which the charge distribution on the MIC can be found. However, for most practical values of η the only term of significant value is K_n; thus

 $K_{o}[J_{o}]_{o}(\eta \alpha) \cos(\alpha \eta \zeta_{i}) / [\alpha(1+\epsilon_{r}/t \operatorname{anh}\alpha)] d\alpha 1.$ (3-20) Only one ζ_{i} is needed in order to obtain K.in Eq. 3-20, so/let

and hence

 $K_{o}\int d_{o}(\eta \alpha) / [\alpha(1+\epsilon_{r}/t anh\alpha)] d\alpha \alpha 1.$

ζ₁=̀0,

A direct numerical integration of Eq. 3-22 leads to. inaccurate results due to the oscillatory nature of $J_{\bullet}(\eta \alpha)$; neither is the integral listed in available handbooks of integrals or Hankel transforms [49] and [50]. Thus, the fraction in the integrand of Eq. 3-22 is expanded as

 $1/(1+\varepsilon_r/t anba) = [1/(\varepsilon_r+1)](1-e^{-2\alpha}) \sum_{r=0}^{r} (-r)^{r} e^{-2\alpha r}$ (3-23a)

where

$$r=(\varepsilon_r-1)/(\varepsilon_r+1).$$

(3-23b)

(3-21)

(3 - 22)

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(3-18c)

Substituting from Eq. 2-23a into 22 yields

 $K_{abc} (-\tau)^{n} \int_{0}^{\infty} (\eta \alpha) \left[e^{-2\alpha \alpha} - e^{-2(n+1)\alpha} \right] / \alpha \, d\alpha \approx (r_{r}+1), \quad (3-24)$ Using the tabulated integrals of [49] and manipulating, Eq. 3-24 results in

 $K_{2} = (-\tau)^{n} \ln \{ [2(n+1) + \sqrt{(n+1)^{2} + \eta^{2}}] / (2n + \sqrt{4n^{2} + \eta^{2}}) \} = (\varepsilon_{r} + 1). \quad (3-25)$ The capacitance per unit length can be readily found from, Eq. 3-25. For $\varepsilon_{r} = 1$

$$C_{\sigma} = 2 / \{ \epsilon \ln [(2 + \sqrt{4} + \eta^{2}) / \eta] \}, \qquad (3-26)$$

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(3-27)

'and for $\varepsilon_r \neq 1$

 $C = (\varepsilon_{r}+1) / \{ \varepsilon \sum_{n=0}^{\infty} (-\tau)^{n} \ln [[2(n+1) + \sqrt{4(n+1)^{3}} + \eta^{3}] / (2n + \sqrt{4n^{3}} + \eta^{3})] \}.$

Considering Eqs. 3-26 and 27, ϵ_e is given by

 $\varepsilon_{\bullet} = [(\varepsilon_{s}+1)/2] \ln[(2+\sqrt{4+\eta^{5}})/\eta]/$

 $\{\sum_{n=0}^{\infty} (-\tau)^{n} \ln [[2(n+1) + \sqrt{4(n+1)^{2} + \eta^{2}}]/(2n + \sqrt{4n^{2} + \eta^{2}})]\}, \quad (3-28)$ and the characteristic impedance is given by

 $Z = [120/\sqrt{2(\varepsilon_{r}+1)}] \{ \ln[(2+\sqrt{4+\eta^{2}})/\eta] \}^{1/2}$

 $\{\sum_{n=0}^{\infty} (-\tau)^{n} \ln \left[\left[2(n+1) + \sqrt{4(n+1)^{2} + \eta^{2}} \right] / \left(2n + \sqrt{4n^{2} + \eta^{2}} \right) \right] \}^{1/2}.$ (3-29) The results obtained by this method are compared to

the results obtained in [8], as shown in Figs. 3-2 and 3.

The method is efficient and the accuracy is reasonable. As evident from Fig. 3-2 for $\xi_r \leq 20$ the largest error is in the order of 5%. The accuracy reduces for $\xi_r=51$ to approximately 10%, as is evident from Fig. 3-2. For practical values of η for the results obtained by Eqs. 3-28 and 29 are acceptable. For increased accuracy, more terms in the Taylor series expansion of Eq. 3-14 can be included; this procedure. will be carried out for coupled microstrip lines in the







Fig. 3-3 Normalized wavelength of a microstrip line
 vs. w/h. Solid curves: [8],
 +: present method.

following sections. For the sake of comparison, note that experimental results obtained by Pucel, et. al. [51] indicate 5 to 10% error for the value of Z over 1 to 6 GHz in the widely used Wheeler's formulae [1].

D. Coupled Microstrip Lines

For doupled microstrip lines, Eq. 3-12 and 13 should be modified so that the domain of integration includes both strips in the coupled lines. Considering Fig. 2-10a let

s*=s+(w/2)	•	(3-30a)
$\eta = \pi/(2h)$,		(3-30b)

and

(3-31b)

(3-31c)

Eq. 3-12 can in general be written as

		(3-31a)		
where I	is	different for the even and odd modes.	The	
		explained for the over - 1		•

the odd modes are then summarized.

For the even modes,

I-Ircos(7x1),

where

$I_{x}=(1/\varepsilon)\int_{a}^{a}\int_{a}^{a$

and f(x) is the even-mode charge distribution. The charge distribution can be expressed as

 $p_{2}(s'-x)/\epsilon = \chi(s'-x)/\sqrt{1-[2(s'-x)/w]^{2}}.$ (3-32)

Substituting $\rho_{\rm g}$ from Eq. 3-32 into 31c and introducing the
change of variable

$$\sin\theta = 2(s' - x)/w$$

to remove the singularities at $x=s'\pm w/2$ results in

 $I_{\mathbf{x}} = 2(w/2) \int_{-w/2}^{w/2} \chi_{\mathbf{x}}(0.5w \sin\theta) \cos[\gamma(s'-0.5w \sin\theta)] d\theta,$

The slowly varying function χ_z can be expanded in powers. of (s'-x) as follows

$$(\mathbf{w}/2)\chi(\mathbf{s}'-\mathbf{x}) = \bar{K}_{\mathbf{s}} + \bar{K}_{\mathbf{s}}(\mathbf{s}'-\mathbf{x}) + \bar{K}_{\mathbf{g}}(\mathbf{s}'-\mathbf{x})^{\mathbf{z}} + \cdots$$
$$= K_{\mathbf{s}} + K_{\mathbf{s}} \sin\theta + K_{\mathbf{s}} \cos 2\theta + K_{\mathbf{s}} \sin 3\theta + \cdots$$

Substituting from Eq. 3-35 into 34 and utilizing the tabulated integrals of [49] results in

Iz=2πcos(γs') 5 KerJ z(0. 5γm)

+275in(75') E Kal+1 J zi+1 (0. 57w).

Substituting from Eqs. 3-23 and 36 into 31a, and introducing the change of variable

7h=α,

results in

 $\{K_{n} \operatorname{Re} \int_{0}^{\infty} \left[e^{-\epsilon n \alpha} - e^{-\epsilon (n+1)\alpha} \right] / \alpha \}.$

 $\{\pm \exp[-j(\xi_1+\sigma)\alpha] + \exp[-j(\xi_1-\sigma)\alpha]\} J_{z1}(\eta\alpha) d\alpha$

$+K_{g_{1+1}}^{\bullet} \operatorname{Im} \int_{0}^{\infty} \left[e^{-i \alpha \alpha} - e^{-i (\alpha + 1)\alpha} \right] / \alpha \right]$

 $\{\exp[-j(\xi_1+\sigma)\alpha] - \exp[\pm j(\xi_1-\sigma)\alpha]\}J_{\pm + i}(\eta\alpha) d\alpha\} \qquad (3-37)$

where the plus signs hold for the even modes and the negative signs for the odd modes. The integral which is essential for solving Eq. 3-37 is

 $/ W_{\nu}(\mathbf{n}, \zeta) = \int_{0}^{\infty} J_{\nu}(\eta \alpha) \exp[-(2\mathbf{n}+i\zeta)\alpha] d\alpha.$ The integral can be found in [49] and [50]. For $\mathbf{n}\neq 0$ and $\nu\neq 0$ 88

(3-33)

(3-34)

(3 - 35)

(3-36)

the result is

 $W_{\nu}(n, \xi) = \exp[-j\nu\Phi(n, \xi)] / \{\nu[R(n, \xi)]^{\nu}\}.$ (3-38a) R and Φ are defined as follows; let

 $P(n, \zeta) = (2n+i\zeta) + \sqrt{(2n+i\zeta)^{2} + \eta^{2}}, \qquad (3-38b)$

then $P(n, \zeta)$ can be written in polar form as

$p(n, \zeta) = \eta R(n, \zeta) \exp[j\Phi(n, \zeta)].$

Thus, $\eta \cdot R(n, \zeta)$ is the modulus of P, and Φ is the phase of P. Similar expressions can be obtained for the special cases where n=0 or $\gamma=0$. Eq. 3-37 thus yields a matrix equation in the terms of unknown K_y. From K_y the charge distribution and thus the parameters of the coupled lines can be evaluated.

E. Numerical Results

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The results obtained by this method for coupled microstrip lines are presented in Fig. 3-4 and are compared with the results obtained in [4]. As in the case of single lines, the results are more accurate for small values of w/h (less than unity). The charge distribution on the two strips are perturbed less for larger values of s/h than in the case of single lines. Therefore, the results are more accurate for larger values of s/h. A complete error analysis is presented below.

There are two infinite sums which are truncated in the numerical solution, namely,

1. the infinite sum of Eq. 3-24 is truncated to N_m terms, and

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(3-38c)



Fig. 3-4 Even- and odd-mode characteristic impedance vs. w/h for s/h=0.2; coupled microstrip lines with $c_r=9.0$; Solid curves: [4],

- e: present method, even mode,
- **9**: present method, odd mode.

2. the infinite sum of Eq. 3-35 is truncated to L_m terms; L_m is the final matrix size. The effect of each truncation is considered separately.

The Effect of Nm

To assess the effect of N_m on the numerical results, L_m is assigned the fixed value of 5, and N_m is increased until the values of the calculated parameters are no longer influenced by N_m . The results of one typical analysis are presented in Fig. 3-5 below. A value of N_m =50 is seen to be sufficiently large to produce negligible truncation error; in fact, such a value is large enough for-all cases of interest <u>The Effect of Lm</u>

To assess the effect of L_m on the numerical results, N_m is assigned the fixed value of 50, and L_m is varied. The percentage error in each case can be obtained and plotted versus L_m . A typical result, is shown in Fig. 3-6. Unfortunately, as L_m increases, some of the intermediate numbers become excessively large, causing an overflow in the computer (specifically R' in Eq. 3-38a). Thus, a further increase in the final matrix size is not useful. However, for values of η less than unity this overflow does not occur.

An example of typical values of the different parameters in this error analysis is as follows: For w/h=1.5 and s/h=0.3, N_m=30 and $L_m=9$ (the final matrix size) will result in 5% error for the values of the characteristic impedance. The results will be more accurate for smaller values of w/h and larger values of s/h. In general, the



Fig. 3-5 Percent error in final value of Z_e vs. N_m; (N_m is the number of terms to which the sum of Eq. 3-24 is truncated).

w/h=1.5, s/h=0.3, \mathcal{E}_r =9.0, and L_m=5 (L_m is the final matrix size).



Fig. 3-6 Percent error in Z, vs. L_m ; (L_m is the final matrix size).

w/h=1.5, s/h=1.0, ϵ_r =9.0 and N_m=40. (N_m is the number of terms to which the sum of Eq. 3-24 is truncated).

recommended value for L_m is 9 to obtain results with reasonable accuracy. The method developed in this chapter is quite efficient and the computer time and memory space required is minimal, since the resulting matrix sizes are small (of the order of 8x8). For the sake of comparison, the final matrix size obtained by the mode matching method is 40x40 as explained in Chap. 1, [3].

F. Summary

In this chapter, an integral equation method was developed in order to obtain the potential distribution, φ , at the cross section of microstrip lines in the quasi-TEM regime. Green's second identity was considered

 $\int_{\mathbb{S}} \left(\varphi \nabla_t^2 \psi - \psi \nabla_t^2 \varphi \right) dS =$

$$\int_{\mathcal{C}} \left[\varphi(\partial \psi/\partial \mathbf{n}) - \psi(\partial \varphi/\partial \mathbf{n}) \right] d\mathbf{\hat{C}}; \qquad (2-3)$$

where φ satisfied Laplace's equation. Unlike Green's functions, we also required that

∇²**/**=0.

This reduced the left hand side of Eq. 2-3 to zero. By properly choosing the boundary conditions on ψ it was possible to reduce the right hand side of Eq. 2-3 to $\int_{-\infty}^{\infty} \int \left[\rho(\mathbf{x})/\varepsilon \right] \cos(\gamma \mathbf{x}) \cos(\gamma \mathbf{x}) / \left[\gamma \left[1+\varepsilon_r / \tanh(\gamma h) \right] \right] d\mathbf{x} d\gamma = \pi/2. \quad (3-10)$ The singularity in the charge distribution was included in Eq. 3-10;

$$\rho(\mathbf{x}) = \varepsilon \overline{\chi}(\mathbf{x}) / \sqrt{1 - (2\mathbf{x}/\mathbf{w})^2},$$

 $\rho(\mathbf{x})$ was in turn expanded in terms of a Taylor series with unknown coefficients. Thus, the integral on the left hand side of Eq. 3-10 could be evaluated. For microstrip lines, the following expressions were obtained for $\varepsilon_{\mathbf{e}}$ and Z.

(3-5)

(3-11)

$$\begin{aligned} \varepsilon_{\bullet} &= \left[\left(\varepsilon_{r} + 1 \right) / 2 \right] \ln \left[\left(2 + \sqrt{4 + \eta^{2}} \right) / \eta \right] / \\ &\left\{ \sum_{n=0}^{\infty} \left(-\tau \right)^{n} \ln \left[\left[2 \left(n + 1 \right) + \sqrt{4 \left(n + 1 \right)^{2} + \eta^{2}} \right] / \left(2n + \sqrt{4n^{2} + \eta^{2}} \right) \right] \right\}, \\ &Z = \left[120 / \sqrt{2} \left(\varepsilon_{r} + 1 \right) \right] \left\{ \ln \left[\left(2 + \sqrt{4 + \eta^{2}} \right) / \eta \right] \right\}^{1/2} \\ &\left\{ \sum_{n=0}^{\infty} \left(-\tau \right)^{n} \ln \left[\left[2 \left(n + 1 \right) + \sqrt{4 \left(n + 1 \right)^{2} + \eta^{2}} \right] / \left(2n + \sqrt{4n^{2} + \eta^{2}} \right) \right] \right\}^{1/2}. \end{aligned}$$
(3-29) wher (A)

$$\tau = (\varepsilon_{r} - 1) / (\varepsilon_{r} + 1).$$
 (3-23b)

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The numerical results obtained using the above expressions were shown in Figs. 3-3 and 4 and were compared to the results of Ref. [8]. The accuracy was better than 5% for $\xi, \leq 20$ and w/h ≤ 1 .

For coupled lines, the method led to a matrix equation from which Z and e_0 could be obtained. The results obtained by this method were presented in Fig. 3-4 and were compared to the results of Ref. [4].

<u>G.</u> Conclusions

The method developed in this chapter makes the use of Green's functions more flexible. Green's functions are obtained by placing a point charge in the geometry of interest. The final solution is then obtained by the superposition principle. In the method developed in this chapter no point charge is needed in obtaining a fundamental solution by which the actual solution can be obtained. The boundary conditions on the fundamental solution can be arbitrarily chosen to simplify the final integral equation. The inaccuracy in the obtained results is caused by the approximations which are introduced in solving the obtained integral equations (specifically, truncating the infinite sums of Eqs. 3-24 and 35). Chap. 3 can be viewed as a building block for the wave analysis of microstrips. The theory developed for solving Laplace's equation is applied to Helmholtz's equation in the following chapters.

IV. WAVE ANALYSIS OF MICROSTRIP LINES

A. Introduction

The wave analysis of microstrip lines is presented in this chapter. The theory developed in Chap. 3 is applied to Helmholtz's equation for the wave analysis of microstrip lines. Furthermore, rather than using the two customary potential functions $\psi^{(e)}$ and $\psi^{(h)}$ which were introduced in Chap. 1, this chapter uses one function only; it is shown that the boundary conditions for E_y are separable from the other components of \vec{E} and \vec{H} . The choice of E_y as the unknown function greatly reduces the numerical effort of analyzing a microstrip line.

B. Formulation

The boundaries and the interfaces of microstrips are along or perpendicular to the coordinate axes. Therefore, the boundary conditions for the electric field, \vec{E} , and the magnetic field, \vec{H} , are greatly simplified. On the conductors

Etan=0. (4-la)

$$H_{\text{mor}} = 0, \qquad (4-1b)$$

$$\partial \mathbf{E}_{nor}/\partial \mathbf{n}=0,$$
 (4-1c)

$$\partial \mathbf{H}_{en} / \partial \mathbf{n} = 0.$$
 (4-1d)

(4-2a)

where the subscript "tan" denotes the tangential component, and "nor" denotes the normal component.

The continuity of the normal component of the displacement vector at the DAI implies that

 $\varepsilon_r(E_{y|y=b}^-) = (E_{y|y=b}^+).$

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On the MIC

$$\mathbf{F}_{\mathbf{r}}(\mathbf{E}_{\mathbf{y}}|_{\mathbf{y}=\mathbf{b}}^{-}) - (\mathbf{E}_{\mathbf{y}}|_{\mathbf{y}=\mathbf{b}}^{+}) = \rho/\epsilon \qquad (4-2b)$$

In the absence of charge

Thus,

A new or the loss of the

$$(\partial \mathbf{E}_{\mathbf{y}}/\partial \mathbf{y}|_{\mathbf{y}=\mathbf{h}}^{-}) = -[\partial \mathbf{E}_{\mathbf{x}}/\partial \mathbf{x} + \partial \mathbf{E}_{\mathbf{y}}/\partial \mathbf{z}]_{\mathbf{y}=\mathbf{h}}^{-}, \qquad (4-4a)$$

$$(\partial \mathbf{E}_{\mathbf{y}}/\partial \mathbf{y}|_{\mathbf{y}=\mathbf{b}}^{+}) = -[\partial \mathbf{E}_{\mathbf{x}}/\partial \mathbf{x} + \partial \mathbf{E}_{\mathbf{y}}/\partial \mathbf{z}]_{\mathbf{y}=\mathbf{b}}^{+}. \qquad (4-4\mathbf{b})$$

Subtracting Eq. 4-4b from 4a results in

 $(\partial E_y / \partial y|_{y=b}) - (\partial E_y / \partial y|_{y=b}) =$

$$(\partial/\partial x)[(E_x|_{y=b}^+) - (E_x|_{y=b}^-)] + (\partial/\partial z)[(E_x|_{y=b}^+) - (E_x|_{y=b}^-)].$$
 (4-5)

 $E_{\rm x}$ and $E_{\rm z}$ are continuous across the DAI, so Eq. 4-5 leads to

$$(\partial E_y / \partial y|_{y=b}) = (\partial E_y / \partial y|_{y=b})$$
 on the DAL (4-6)

According to Eq. 4-1c

$$(\partial E_y / \partial y|_{y=b}) = (\partial E_y / \partial y|_{y=b}) = 0$$
 on the MIC. (4-7)

Eqs. 4-2, 6, and 7 indicate that the boundary conditions for Eyare separable from the other components of \vec{E} and \vec{H} . Similarly, it can be proven that

$$(H_y|_{y=b}) = (H_y|_{y=b})$$
 on the DAI, (4-8a)

$$(H_{y|y=b}) = (H_{y|y=b}) = 0 \text{ on the MIC,} (4-8b)$$

$$(\partial H_y/\partial y|_{y=b}) = (\partial H_y/\partial y|_{y=b})$$
 on the DAL (4-8c)

Eqs. 4-2, 6, 7, and 8 do not prove that pure LSE or LSM (Longitudinal Section Magnetic) modes can exist in microstrips. Rather, they indicate that microstrips can be analyzed by considering E_y and H_y separately. For the determination of the fields, both E_y and H_y should be found. However, the quantities of interest, such as ϵ_0 of microstrip lines or the resonant frequencies of resonators can be found

from either E_y or H_y and the boundary conditions. The above conclusions are based on the assumptions that the dielectric and the conductors are lossless, and that a microstrip line is infinitely thin.

For the case of microstrip lines, the variation of the fields along the z-axis is as $\exp(-j\beta z)$. Thus, Ey should satisfy

$$\nabla_{\mathbf{t}}^{\mathbf{s}} \mathbf{E}_{\mathbf{y}} + (\kappa \mathbf{k}^{\mathbf{s}} - \boldsymbol{\beta}^{\mathbf{s}}) \mathbf{E}_{\mathbf{y}} = \mathbf{0}. \tag{4-9}$$

In the following sections, the theory developed in Chap. 3 is applied to solving Eq. 4-9.

. An Integral Equation Formulation

∫**_**8{`

Green's second identity can be rearranged as

$$\psi[\nabla_t^a \psi (\kappa k^3 - \beta^3) \varphi] - \varphi[\nabla_t^2 \psi + (\kappa k^3 - \beta^3) \psi] \} dS =$$

$$\int d \psi (\partial \varphi / \partial n) - \varphi (\partial \psi / \partial n)] dC. \qquad (4-1)$$

where S is the area enclosed by the curve C. Let

and let Ψ be an auxiliary function such that

$$\nabla_t^{\mathbf{a}} \psi + (\kappa \mathbf{k}^{\mathbf{a}} - \boldsymbol{\beta}^{\mathbf{a}}) \psi = 0. \qquad (4-12)$$

The boundary conditions for γ will be described below.

Considering Eqs. 4-9, 11, and 12, Eq. 4-10 reduces to $\int c \left[\frac{\psi}{\partial \varphi} / \partial n \right] - \frac{\varphi}{\partial \psi} / \partial n \right] dC = 0. \qquad (4-13)$

The line is assumed to be shielded by a metallic plane at y=h+d (Fig. 4-1). In the x-direction, the line is assumed to extend to infinity.

Eq. 4-13 applied to S_1 and S_2 in Fig. 4-1 results in

$$\int c_{i} v c_{\sigma} [\psi(\partial \varphi / \partial n) - \varphi(\partial \psi / \partial n)] dC = 0, \qquad (4-14a)$$

 $\int_{c_{\rm SUC_4}} \left[\frac{\psi(\partial \varphi/\partial \mathbf{n}) - \varphi(\partial \psi/\partial \mathbf{n})}{\partial \varphi} \right] d\mathbf{C} = 0, \qquad (4-14b)$



Fig. 4-1 A single microstrip line shielded on top by a metallic plane.

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where it is assumed that φ and $\gamma \varphi / 2 n$ tend to zero for large x. To simplify the present problem, the boundary conditions on ψ are defined as follows:

 $\partial \psi/\partial n=0$ at y=0 and y=h+d, (4-15a) and

$$\partial \psi / \partial \mathbf{y}|_{\mathbf{y}=\mathbf{b}}^{-} = \varepsilon_{\mathbf{r}} (\partial \psi / \partial \mathbf{y}|_{\mathbf{y}=\mathbf{b}}^{+}).$$
 (4-15b)

Imposing the boundary conditions of Eqs. 4-15 on 14 and manipulating yields

$$\int \operatorname{nud} \left(\frac{\psi}{y-h} \right) - \left(\frac{\psi}{y-h} \right) \left(\frac{\partial \varphi}{\partial y} \right|_{y-h} \right) d\mathbf{x} = \left(\frac{1}{\varepsilon} \right) \int \operatorname{nuc}^{\varphi}(\mathbf{x}) \left(\frac{\partial \psi}{\partial y} \right|_{y-h} \right) d\mathbf{x}.$$
(4-16)

It is necessary to find ψ such that Eqs. 4-12 and 15 are satisfied. Thus let

$$\sum_{r=0}^{\infty} \cos(\alpha x) \cosh(\gamma' y) / [\gamma' \sinh(\gamma' h)]; \qquad 0 \le y \le h,$$

$$(-\cos(\alpha x)\cosh[\gamma(y-h-d)]/[\gamma \sinh(\gamma d)]; h < y \le h+d.$$

(4-17a)

where

$$\epsilon_r k^2 - \beta^3 + \gamma'^2 - \alpha^2 = 0,$$
 (4-17b)

and

$$k^2 - \beta^2 + \gamma^2 - \alpha^2 = 0.$$

(4-17c)

Substituting ψ from Eq. 4-17a into 16 results in $\int_{\mathbf{M}_{\mathbf{J}}} \widetilde{G}(\alpha) \cos(\alpha \mathbf{x}) \left(\frac{\partial \varphi}{\partial y} \Big|_{y=b} \right) d\mathbf{x} = (1/\varepsilon) \int_{\mathbf{M}_{\mathbf{J}}} \cos(\alpha \mathbf{x}) d\mathbf{x}. \quad (4-18a)$ where

$$G(\alpha)=\{\varepsilon_r/[\gamma' \tanh(\gamma' h)]\}+\{1/[\gamma \tanh(\gamma d)]\} \qquad (4-18b)$$

Multiplying both sides of Eq. 4-18a by $\cos(\alpha x_i)$ and integrating over α from zero to infinity results in

$$\int_{\mathbf{M}_{\mathbf{x}}} \mathbf{K}(\mathbf{x}, \mathbf{x}_{\mathbf{y}}) \left(\frac{\partial \varphi}{\partial \mathbf{y}} \right|_{\mathbf{y}=\mathbf{b}} d\mathbf{x} = \mathbf{0}, \qquad (4-19a)$$

where xi is assumed to lie on the MIC and

 $\vec{K}(\mathbf{x},\mathbf{x}_i) = 2\pi \int \vec{\mathbf{x}}(\mathbf{a}) \left[\exp(j\mathbf{a}|\mathbf{x}+\mathbf{x}_i|) + \exp(j\mathbf{a}|\mathbf{x}-\mathbf{x}_i|) \right] d\mathbf{a}.$ (4-19Ъ) Let

$$K(\mathbf{x}') = 2\pi \int \overline{\mathbf{G}}(\mathbf{a}) \exp(j\mathbf{a}|\mathbf{x}'|) d\mathbf{a}, \qquad (4-20a)$$

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then

$$K(x, x_{j}) = \bar{K}(x + x_{j}) + \bar{K}(x - x_{j}).$$
 (4-20b)

For a single microstrip line, Eq. 4-19a can be written as

$$\int \sqrt{2} a(x - \sqrt{2}) \left[\bar{K}(x + x_{i}) + \bar{K}(x - x_{i}) \right] dx = 0, \qquad (4-21a)$$

where

$$\mathbf{a}(\mathbf{x} - \mathbf{w}/2) = (\partial \boldsymbol{\varphi}/\partial \mathbf{y}|_{\mathbf{y} = \mathbf{b}}). \tag{4-21b}$$

The following changes of variables simplify the above equations.

at h

1.

11.

$$K(f) = \bar{K}(hf)$$
. (4-22d)

$$a(\xi) = \bar{a}(h\xi),$$
 (4-22e)

$$G(\nu) = \bar{G}(\nu/h) /h.$$
 (4-22f)

Considering Eqs. 4-22, Eq. 4-21a can be written as

$$\int_{0}^{\infty} a(\xi) [K(\xi + \xi_{1} + 2\eta) + K(\xi - \xi_{1})] d\xi = 0; \quad \xi_{1} > \eta. \quad (4-23a)$$

where (Eq. 4-20a)

$$\mathbf{K}(\boldsymbol{\xi}) = (2\pi) \int \underline{\mathbf{G}}(\boldsymbol{\nu}) \exp(j\boldsymbol{\nu}|\boldsymbol{\xi}|) \, \mathrm{d}\boldsymbol{\nu}. \qquad (4-23b)$$

and (Eqs. 4-17 and 18b)

$$G(\nu) = \{ \varepsilon_r / [\sqrt{2} - C^2 t \operatorname{anh}(\sqrt{2} - C^2)] \} + 1 / [\sqrt{2} + B^2 t \operatorname{anh}(\delta \sqrt{2} + B^2)]. \quad (4-23c)$$
with

$$B^{3}=(c,-1)(hk)^{3}$$
, (4-23d)

$C^{2} = (\varepsilon_{r} - \varepsilon_{e}) (hk)^{2}$

D. Evaluation of the Kernel K(2)

and

K(ξ) of Eq. 4-23b can be evaluated by complex integration. Assume that γ is a complex variable, and integrate $G(\gamma)exp(jy|\xi|)$ along the infinite semicircular path, Γ , shown in Fig. 4-2; it can be shown that the integrand

vanishes over Y_1 ; therefore

 $K(\xi) = 2\pi \int G(\nu) \exp(j\nu|\xi|) d\nu =$

 $-j[(\Sigma 0.5 \text{ Res. of poles on the real axis}) + (\Sigma \text{Res. of poles inside } \Gamma)].$

(4-24)

(4 - 27)

(4 - 28)

The poles of $G(\nu)$ are located at (Eq. 4-23c)

- $p_{\bullet}^{+}=C.$ (4-25a)
- **₽₀¯−−C.** (4-25b)
- $i\rho_{n}=j\sqrt{(n\pi)^{2}-C^{2}}; n=1, 2, 3, \cdots, (4-25c)$
- $j\sigma_{a}=j\sqrt{(n\pi/\delta)^{2}+B^{2}}; n=0, 1, 2, \cdots$ (4-25d)

Eq. 4-24 leads to

 $K(\xi) = \{ \xi [sin(C|\xi|)]/(2C) \}$

 $- \{\varepsilon_{\mathbf{r}} \underbrace{\Sigma}_{\mathbf{r}} [\exp(-\sigma_{\mathbf{r}} | \xi|)] / \rho - \{ \underbrace{\Sigma}_{\mathbf{r}} [\exp(-\sigma_{\mathbf{r}} | \xi|)] / (\delta \sigma_{\mathbf{r}}) \}. \quad (4-26)$

The kernel of Eq. 4-26 is not sufficient for solving the integral equation. This is evident by considering the limiting case k=0, which implies (Eq. 4-23e) that

$C|_{k=0} = \sqrt{\varepsilon_r - \varepsilon_o} (hk)|_{k=0} = 0.$

For the quasi-TEM mode in a microstrip line, c_e remains finite for k=0. Thus, from Eq. 4-23d

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 $B|_{k=0} = \sqrt{e_{0} - 1} (hk)|_{k=0} = 0.$

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(4-23e)



Fig. 4-2 Contour for the complex integration of Eq. 4-23b;

Since (from Eq. 4-25d)

v_+B+0 as k+0,

the first term in the second summation of Eq. 4-26 tends to infinity and $K(\xi)$ becomes independent of C. It is therefore necessary to find a complementary kernel which is dependent on C for small C.

Both sides of Eq. 4-18 can be multiplied by $\cos(\gamma \xi_i)$ and integrated along the small circle around $\nu=C$, namely s. in Fig. 4-2. ν and ξ are defined in Eqs. 4-22. Thus, Eq. 4-18a becomes

 $\int_{\eta} \left[\oint_{T_a} \dot{G}(\nu) \cos(\nu \xi) \cos(\nu \xi_j) d\nu \right] a(\xi - \eta) d\xi$ = $(1/\varepsilon) \int_{HOO}(h\xi) [\oint_{\gamma_0} \cos(\nu\xi) \cos(\nu\xi) d\nu] d\xi$ =0; regardless of ξ_{i}

(4 - 29)

(4 - 30)

The right hand side of Eq. 4-29 is identically zero since none of the functions in the integrand have a pole at y = C. Considering Eq. 4-23c G(ν) has a pole at ν =C, therefore the left hand side of Eq. 4-29 leads to

 $\int_0^{\infty} \cos \left[C(t+\eta) \right] \cdot a(t) dt = 0.$

For the quasi-TEM mode, Eqs. 4-23a, 27, 28, and 30, prove that ϵ_{e} should remain finite at zero frequency. Consider Eqs. 4-23d and 23e. As k tends to zero, both B and C tend to zero. The kernels of Eqs. 4-23a and 30 both become constant for B=C=0; in this limiting case, Eq. 4-23a tends to

$\int_{\theta} a(\xi) d\xi = 0,$

 $\int \mathbf{d} \mathbf{f} = 0,$

and Eq. 4-30 tends to

Thus, regardless of the method used to solve Eqs. 4-23a and

30, B=C=0 is a solution. This verifies that ϵ_e remains finite as the frequency tends to zero (from Eqs. 4-23d and 23e).

E. Numerical Solution

In order to solve the above equations numerically, $f(\xi)$ is defined with respect to $a(\xi)$ of Eq. 4-22e;

$$\mathbf{a}(\boldsymbol{\xi}) = \exp(-\boldsymbol{\xi}\mathbf{L})\boldsymbol{f}(\boldsymbol{\xi}), \qquad (4-31)$$

where L is an arbitrary number. This definition is based on the fact that the fields decay rapidly away from the MIC edges. L can be varied arbitrarily to obtain the most accurate numerical results; the obtained numerical results are nearly independent of L. Then Eq. 4-30 can be approximated by

where M determines the final matrix size, and (4-32a)

fff(**f**). (4−32b)

Eq. 4-23a can similarly be approximated by

 $\sum_{i=1}^{i} \int_{i_{ij}} \frac{1}{i_{ij}} \frac{1}{$

evaluating the integrals of Eqs. 4-32a and 32c.



Fig. 4-3 & -axis divided into various segments for the numerical integration of Eqs. 4-23a and 30.

 $G_{1, \frac{n}{2}} = [1/(2C)] \int_{\xi_{1}}^{\xi_{2}} \sin[C(\xi + \xi_{1} + 2\eta)] \exp(-\xi L) d\xi,$ (4-33 a) $G_{2, \frac{1}{2}} = \left[\frac{1}{2c} \right] \int_{\frac{d}{2}} \sin \left[C \left[\frac{d}{2c} - \frac{d}{2c} \right] \right] \exp(-\frac{d}{2c} L) d\xi,$ (4-33b) $G_{3n, 4} = (1/\rho_n) \int_{\ell_1}^{\ell_2} \exp[(\xi + \xi_1 + 2\eta)] \exp(-\xi L) d\xi.$ (4-33c) $G_{4n,4} = (1/\rho_n) \int_{f_1^{4}} \exp[-\rho_n [\xi - f_4]] \exp(-fL) df$ (4-33d) $G_{\mathbf{E},j} = \int_{\xi_{\mathbf{E}}}^{\xi_{\mathbf{E}}} \cos[C(\xi+\eta)] \exp(-\xi L) d\xi,$ (4-33e) $G_{en_{1}} \stackrel{\bullet}{=} \left(B/\sigma_{n} \right) \int_{\xi_{2}}^{\xi_{2}} \exp\left[-\sigma_{n} \left(\xi + \xi_{1} + 2\eta \right) \right] \exp\left(-\xi L \right) d\xi,$ (4-33f) $G_{\tau_n, t} = (B/\sigma_n) \int_{\xi_n}^{\xi_n} \exp[-\sigma_n |\xi - \xi_n] \exp(-\xi L) d\xi,$ (4-33g) The integrals of Eqs. 4-33 can be easily evaluated. Considering Eqs. 4-33 we can now rewrite Eq. 4-32a as Σ f _fG_{6, j}=0 (4-34a) and Eq. 4-32c can be expressed as $\sum_{i=1}^{n} f_{i} z_{i} \delta B[G_{i, ij} + G_{i, ij} - \sum_{i=1}^{n} (G_{i, ij} + G_{i, ij})] - \sum_{i=0}^{n} (G_{i, ij} + G_{i, ij}) = 0. \quad (4-34b)$ In matrix form Eqs. 4-34 can be represented as [G] { f } =0, (4 - 34)

where the first row of [G] is $G_{5,j}$ of Eq. 4-33e. The matrix [G] is a function of B and C of Eqs. 4-23d and 23e, which are both directly proportional to hk or hf; this signifies the fact that, for microstrip lines, the normalized frequency fh can be used (i.e., the dispersion relation can be plotted vs. fh rather than f). In a similar fashion, the strip width can be normalized to w/h as in the quasi-TEM regime.

The numerical results obtained by this method for different representative cases are shown in Figs. 4-4 and 5 and are compared to the results of [15], [23] and [52]. The results obtained by this method are in good agreement with other methods for high frequencies. For low frequencies, i.e. converges smoothly to the zero frequency limit of the



Co of a single microstrip line vs. normalized frequency;

Fig. 4-4

Cools obtained from quasi-TEM methods ([8] and the method of Chap. 2). As the frequency tends to zero, the results obtained by the present method smoothly converge to ε_{eo} .



Fig. 4-5 ε_{e} of a single microstrip line vs. normalized frequency: $c_{r}=10.1$ and w/h=2.5; *Cee* is obtained from quasi-TEM methods ([8] and the method of Chap. 2). As the frequency tends to zero, the results obtained by the present method smoothly converge to c_{eg} .

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effective dielectric constant, ϵ_{eo} , obtained by the quasi-TEM methods. The results of [15], [23], and [52] do not converge to ϵ_{eo} at zero frequency.

Considering the numerical efficiency of the present method the size of the final eigenvalue matrix used was 14x14 and fifty terms were needed in Eq. 4-26. The final matrix size in the TLM method [22] is 270x270, in the finite difference method [19] it is 100x100, and for the finite element method 21 it is 126x126. The computer programs are presented in App. C. The results of Figs. 4-4 and 5 have been obtained by finding the values of C_0 at which the determinant of [G] in Eq. 4-34 vanishes.

<u>F. Summary</u> In this chapter, it was shown

In this chapter, it was shown that, for microstrips, the boundary conditions for E_y could be separated from the other components of \vec{E} and \vec{H} . E_y satisfied Helmholtz's equation

$$\nabla_{\mathbf{t}}^{\mathbf{s}} \mathbf{E}_{\mathbf{y}} + (\kappa \mathbf{k}^{2} - \beta^{\mathbf{s}}) \mathbf{E}_{\mathbf{y}} = 0.$$
(4-9)

with the boundary conditions

$$E_r(E_{y|y=b}^-) = (E_{y|y=b}^+).$$
 (4-2a)

6)

on the DAI, and

$$\varepsilon_r(E_y|_{y=b}) - (E_y|_{y=b}) = \rho/\varepsilon$$
 (4-2b)

on the MIC. Moreover,

$$\partial E_{y} / \partial y|_{y=0}^{-} = (\partial E_{y} / \partial y|_{y=0}^{+})$$
 on the DAL (4-

and

$$(\partial E_y / \partial y|_{y=b}) = (\partial E_y / \partial y|_{y=b}) = 0$$
 on the MIC: (4-7)

Green's second identity was rearranged as $\int_{S} \frac{1}{2} \psi \left[\nabla_{t}^{2} \varphi + (\kappa k^{2} - \beta^{2}) \varphi \right] - \varphi \left[\nabla_{t}^{2} \psi + (\kappa k^{2} - \beta^{2}) \psi \right] dS =$

 $(\int_{c} [\psi(\partial \varphi/\partial n) - \varphi(\partial \psi/\partial n)] dC.$ (4-10)

where

φ=E,,

(4-11)

The method developed in Chap. 3 was applied to this case; it was assumed that

$$\nabla_t^2 \psi + (\kappa k^2 - \beta^2) \psi = 0. \tag{4-12}$$

Considering Eqs. 4-9, 10 and 12, the left hand side of Eq. 4-10 could be set equal to zero. By properly choosing the boundary conditions on Ψ , Eq. 4-10 resulted in $\int \operatorname{nu}\overline{G}(\alpha) \cos(\alpha x) (\partial \varphi / \partial y|_{y=0}) dx = (1/\epsilon) \int \operatorname{uco}(x) \cos(\alpha x) dx;$ (4-18a) $\overline{G}(\alpha) = \frac{1}{\gamma} \operatorname{tanh}(\gamma' h) \left[+\frac{1}{\gamma} \operatorname{tanh}(\gamma d) \right];$ (4-18b).

where

and

with

 $\varepsilon_r k^2 - \beta^2 + \gamma'^2 - \alpha^2 = 0;$ (4-17a) $k^2 - \beta^2 + \gamma^2 - \alpha^2 = 0.$ (4-17b)

Eq. 4-18a multiplied by $\cos(\alpha \cdot x_i)$ and integrated over in the complex α -domain resulted in

 $\int_0^{\infty} a(\xi) \cos[C(\xi+\eta)] d\xi = 0,$ (4-30)

 $\int_{0}^{\infty} a(\xi) [K(\xi + \xi_{1} + 2\eta) + K(\xi - \xi_{1})] d\xi = 0, \qquad (4 - 23\pi)$

where $a(\xi)$ was defined by $\partial \varphi(x,y)/\partial y$ on the DAI, where $\xi = x/h$, (4-23a)

and the kernel was given by

 $K(\xi) \approx sin(C|\xi|)/(2C)$

$$-\varepsilon_{r_{n-1}} \exp(-\rho_{n} |\xi|) / \rho_{n} - \tilde{\Sigma}_{n-0} \exp(-\sigma_{n} |\xi|) / (\delta \sigma_{n}). \qquad (4-26)$$

 $B = \sqrt{e_{-1}(hk)},$ (4-23d)

 $C = \sqrt{\epsilon_r - \epsilon_o} (hk).$ (4-23e)

$$\rho_{n} = \sqrt{(n\pi)^{2} - C^{2}}, n = 1, 2, 3, \cdots,$$
 (4-25c)

 $\sigma_n = \sqrt{(B\pi/\delta)^2 + B^2}, n=0, 1, 2, \cdots$ (4-25d)

Eqs. 4-23a and 30 yielded an eigenvalue matrix equation when discretized. The numerical results obtained by this method were presented in Figs. 4-4 and 5 and were compared to the results of [15], [23] and [52].

. Conclusions

It has been shown that the wave analysis of microstrips can be performed using only E. In contrast to the customary two potential functions $\psi^{(e)}$ and $\gamma^{(h)}$, the use of only one function greatly reduces the effort for analyzing micro-In order to solve Helmholtz's equation for E_v , strips. the theory developed in Chap. 3 was used. The results obtained for microstrip lines show good agreement with other methods (Figs. 4-4 and 5). As the frequency tends to zero; the results converge smoothly to the values obtained. by quasi-TEM methods. The method is economical (final matrix size of 14x14). However, it is not readily apparent how this method can be generalized to microstrip resonators. Therefore, in Chap. 5 the method of this chapter is modified so that it can be generalized more easily to microstrip resonators.

AN ALTERNATIVE INTEGRAL EQUATION METHOD FOR THE WAVE ANALYSIS OF MICROSTRIPS

A. Introduction

V.

It seems difficult to generalize the integral equation method of Chap. 4 to microstrip resonators of arbitrary shapes. Considering Eq. 4-19a, the domain of integration of this integral equation is the DAI. The resulting matrix equations would be smaller if an integral equation could be found whose domain of integration is the MIC alone. The generalization of such an integral equation to microstrip resonators would then be simpler. The development and solution of an integral equation for microstrip lines with only the MIC as the domain of integration is discussed in this chapter. This solution is then generalized to a rectangular resonator, resonating in the even mode.

B. Formulation

Eq. 4-18b can be inverted to result in

 $1/\vec{G}(a) = \gamma \cdot \sinh(\gamma d) \gamma' \cdot \sinh(\gamma' h) /$

 $[\varepsilon_{r}\gamma\cdot\sinh(\gamma d)\cosh(\gamma' h)+\gamma'\cdot\sinh(\gamma' h)\cosh(\gamma d)], \quad (5-la)$ where

$$\gamma^{a} = \alpha^{a} + \beta^{a} - k^{a},$$
 (5-1b)
 $\gamma^{a} = \alpha^{a} + \beta^{a} - \epsilon_{a} k^{a},$ (5-1c)

Multiplying Eq. 4-18a by Eq. 5-la results in $\int_{DM}\cos(\alpha x) \left(\frac{\partial \varphi}{\partial y}\right|_{y=b} dx = (1/\epsilon) \int_{MC} \left[\cos(\alpha x)/\overline{G}(\alpha)\right] \rho(x) dx. \quad (5-2)$

where $\varphi = E_y$. Eq. 5-2 cannot be integrated over α from zero to infinity, since

$$1/\overline{G}(\alpha) \sim \alpha$$
 for large α

However, both sides of Eq. 5-2 can be multiplied by

 $\cos(\alpha x_i) \cdot \sin^2(\alpha d'_i/2)/\alpha^2$

and integrated over a from 0 to .

Thus, the left hand side of Eq. 5-2 results in

 $\int_{\text{DAI}} f(\mathbf{X}) (\partial \varphi / \partial y |_{y=1}) d\mathbf{X}$

where

 $f(\mathbf{x}) = f_0 \cos(\alpha \mathbf{x}) \cos(\alpha \mathbf{x}_i) \sin^2(\alpha d'/2) / \alpha^2 d\alpha$ (5-3b) f(x) of Eq. 5-3b is nonzero only on the regions

> $\textbf{x}_i \text{-} \textbf{d}_i < \textbf{x} < \textbf{x}_i \text{+} \textbf{d}_i$, and $-(x_i+d_i) < x < -(x_i-d_i)$,

shown in Fig. 5-1. Thus, f(x)=0 on the DAI if

|x_i±d'₁ |≤w/2 V i. (5-4a) 115

(5-3a)

-(5-4b)

(5-5a)

(5-5b)

With the condition of inequality 5-4a, the integrand of Eq. 5-3a is identically zero. Thus, the right hand side of Eq. 5-2 results in

 $\int_{MC} K(\mathbf{x}, \mathbf{x}_{i}) \rho(\mathbf{x}) d\mathbf{x} = 0;$

where

 $K(\mathbf{x}, \mathbf{x}_i) = \int_0^{\infty} \left[\sin^2(\alpha d'/2) / \alpha^2 \right] \cos(\alpha \mathbf{x}_i) \cos(\alpha \mathbf{x}) / \overline{G}(\alpha) d\alpha;$ (5-4c)The integral which is needed for evaluating $K(x,x_i)$ of Eq. 5-3b is

 $\mathbb{K}_{1}(\zeta) = \int_{0}^{\infty} \exp(j\nu\zeta) / [\nu^{2}G(\nu)] d\nu,$

 $\nu = \alpha h$

where



Fig. 5-1 Microstrip line shielded on top by a metallic plane; f(x) of Eq. 5-4 is nonzero on $-(x_i+d_i)$ to

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 $-(x_i-d'_i)$, and $(x_i-d'_i)$ to $(x_i+d'_i)$.

(5-5c)

In other words,

$$K(x, x_i) = \sum_{q=1}^{6} a_q K_1(x_{qi}/h),$$
 (5-5d)

where the coefficients a_q and x_{qi} can be found easily from Eq. 5-3b. Moreover

$$\mathbf{G}(\mathbf{v}) = \overline{\mathbf{G}}(\mathbf{v}/\mathbf{h})/\mathbf{h}. \qquad (5-5e)$$

 $G(\nu)$ can be rewritten as

$$G(\nu) = P_{2}(\rho) / P_{1}(\rho),$$
 (5-6a)

where, from Eq. 5-la,

$$P_{1}(\rho) = -\rho \sin(\rho) \sqrt{A^{2} - \rho^{2}} \sinh(\delta \sqrt{A^{2} - \rho^{2}}); \qquad (5-6b)$$

$$r_{2}(\rho) = c_{r} \sqrt{A^{-} - \rho^{-} \sinh(\delta \sqrt{A^{*} - \rho^{*}}) \cos(\rho) - \rho \sin(\rho) \cosh(\delta \sqrt{A^{*} - \rho^{*}}) (5-6c)$$
with

$$\delta = d/h,$$
 (5-7a)
 $\rho^{8} = -(\gamma' h)^{2}$ (5-7b)

$$(5-7c)$$

$$v^{3} = C^{3} - \rho^{3}$$
. (5-7d)

To evaluate K_1 of Eq. 5-5a, it is assumed that γ is a complex variable and the integrand of Eq. 5-5a is integrated over the contour shown in Fig. 5-2. The integral vanishes over the semicircle, C_L , when the radius of the semicircle becomes infinitely large. Then

 $K_1(\xi) = \pi j \Sigma[(\text{Res. on the real axis})]$

+(Res. on the imaginary axis)]. (5-8) The real poles in Eq. 5-8 are treated differently from those in Eq. 4-24 of the previous chapter. The reason for



Fig. 5-2 Contour for the integral of Eq. 5-5a.

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including the real poles inside the contour of integration in Fig. 5-2 is that f(x) of Eq. 5-4 is defined on the basis of step functions; in defining the step functions by Fourier transform methods the contour of integration approaches the real axis from below and includes any pole on the real axis.

It is then necessary to find the poles of the integrand in Eq. 5-5a; they can be obtained from the roots of $P_2(P)$ of Eq. 5-6c. It can be shown that all the roots of Eq. 5-6c are real. Let the m-th positive root of $P_2(P)$ be denoted by P_m . The poles, y_m , can be found from P_m via Eq. 5-7d. The poles of the integrand of Eq. 5-5a are located at

$$\nu_{\rm o}=0$$
, double pole; and (
 $\nu_{\rm m}=\sqrt{c^2-\rho_{\rm m}^2}$, (

5-9a)

5-9Ъ)

or

 $\nu_{m} = \begin{cases} \pm \overline{\nu}_{m} = \pm \sqrt{C^{2} - \rho_{m}^{2}} \text{ for } \rho_{m} < C; m = 1, \cdots, M, \\ \\ \pm \overline{\nu}_{m} = \pm \sqrt{\rho_{m}^{2} - C^{2}} \text{ for } \rho_{m} > C; m = M + 1, \cdots. \end{cases}$

Eq. 5-8 leads to

 $K_{i}(\xi) = Q_{o}\xi +$

$$2\bar{\mathbf{Q}}_{\mathbf{m}}\sin(\bar{\mathbf{v}}_{\mathbf{m}}\boldsymbol{\xi}) + \sum_{m=\mathbf{M}+\mathbf{i}} \bar{\mathbf{Q}}_{\mathbf{m}}\exp(-\bar{\mathbf{v}}_{\mathbf{m}}\boldsymbol{\xi}). \quad (5-10a)$$

where

$$Q_{o} = (-\pi/2) P_{1}(C) / P_{2}(C). \qquad (5-10b)$$

$$\bar{Q}_{m} = -\pi P_{1}(\rho_{m}) / [\bar{\nu}_{m}^{2} P_{3}(\rho_{m})]. \qquad (5-10c)$$

$$\bar{Q}_{m} = -\pi \bar{P}_{1}(\rho_{m}) / [\bar{\nu}_{m}^{2} P_{3}(\rho_{m})]. \qquad (5-10d)$$

and

$$P_{g}(\rho) = (1/\rho) P_{g}'(\rho)$$
 (5-10e)

C. Single Microstrip Lines

Due to the even symmetry of the quasi-TEM mode in microstrip lines, Eq. 5-3a can be rewritten as

 $\int d^{\pi/2} \rho(x) K(x, x_i) dx = 0;$

 $0 \le x_1 \pm d_1' \le w/2.$ (5-11) where $K(x, x_1)$ is a linear combination of forms like $K_1(\zeta)$. As evident from Eq. 5-10a

 $K_i(\ell) - in(\ell)$ for small ℓ : K(x;x;) behaves logarithmically as x approaches f(x;x;) behaves logar

singular for x=w/2.

By devising a numerical method which includes both the singularities in the kernel and the charge distribution of Eq. 5-11, accurate results could be obtained. However, generalizing such a method to microstrip resonators of arbitrary shapes seems very difficult. Two approximate methods for solving Eq. 5-11 can be devised. The singularity in the charge distribution can be included in the kernel of Eq. 5-11 and the logarithmic singularities of $K(x,x_i)$ can be "avoided" by dividing the domain of integration into intervals which have

 $(x_i-d_i'), x_i, \text{ or } (x_i+d_i')$

as their end points.

Alternatively, the singularity in the charge distribution can be implicitly included in the integration procedure by choosing finer intervals near the singular point, x=w/2. The two methods yielded very similar numerical results and the computational efficiencies were also comparable. However, for reasons of conciseness, only the former method will be explained.

As in the previous chapters, let

$$\rho(\mathbf{x}) = \chi(\mathbf{x}) / \sqrt{1 - (2\mathbf{x}/\mathbf{w})^2}.$$
 (5-12)

Substituting Eq. 5-12, together with the change of variable $sin\theta = 2x/w$, (5-13)

into Eq. 5-11, results in

 $\int d^{\pi/2} \chi(0, 5 \text{ w sin}\theta) K(0, 5 \text{ w sin}\theta, 0, 5 \text{ w sin}\theta) d\theta = 0.$ (5-14) The change of variable of Eq. 5-13 removes the singularity at x=w/2.

Eq. 5-14 can be approximated by

$$\sum_{r=1}^{\infty} \chi_r \int_{\theta_R} W K(0.5 \text{ w sin}\theta, 0.5 \text{ w sin}\theta_s) d\theta \sim 0, \qquad (5-15a)$$
where

$$\chi_r = \chi(0.5 \text{ w } \sin\theta_r); \qquad (5-15b)$$

$$\sin\theta_{\mathbf{k}} = 2(\mathbf{x}_{\mathbf{r}} - \mathbf{d}_{\mathbf{r}}') / \mathbf{w}; \qquad (5-15c)$$

$$sin\theta_r = 2x_r/w; \qquad (5-15d)$$

$$\sin\theta_{\pm} = 2(\mathbf{x}_{r} + \mathbf{d}_{r}') / \mathbf{w}. \qquad (5-15e)$$

Eqs. 5-15c, d, and e are graphically represented in Fig. 5-3.

Eq. 5-15a can be written in matrix form as

$$[H] \{\chi\} = 0,$$
 (5-16)

where [H] is a square matrix, with elements

$$H_{L} = \int_{\theta_{L}}^{\theta_{L}} K(0.5 \text{ w sin}\theta, \mathbf{x}_{i}) d\theta, \qquad (5-17)$$

and $\{X\}$ is a column matrix with χ_r , as its elements.

Substituting from Eq. 5-5d into 17 results in

24,-

X1

θ11

0

θ1

2d.

xg

Q

Fig. 5-3 MIC divided into several intervals for the numerical integration of Eq. 5-15.

0 B

θ **u**2

¢.

θ2

\theta_{u1}

θ12

MIC

122

DAI

w/2 x

2d +

XR

θ_{uk}

 $\pi/2$

θ

5

θ.R

 $\theta_{u(R-1)}$

θ

$$\mathbf{H}_{\mathbf{f}} = \sum_{q=1}^{n} \mathbf{a}_{q} \int_{\boldsymbol{\theta}_{\mathbf{f}}} \mathbf{w} \mathbf{K}_{\mathbf{g}}(\boldsymbol{\zeta}_{q}) \, \mathbf{d}\boldsymbol{\theta} \tag{5-18}$$

From Eqs. 5-3b, 5d, and 13 x_{1} ; can be found as

 $\mathbf{x}_{11}/(\mathbf{w}/2) = |\sin\theta - \sin\theta_{1}|; \qquad (5-19a)$ $\mathbf{x}_{11}/(\mathbf{w}/2) = |\sin\theta - \sin\theta_{1}|; \qquad (5-19b)$

 $x_{al}/(w/2) = sin\theta = sin\theta_{l};$ (5-19c)

 $x_{u}/(w/2) = \sin\theta - \sin\theta_{u};$ (5-19d)

 $x_{st}/(w/2) = sin\theta - sin\theta_{s};$ (5-19e)

Finally $K_1(\zeta)$ must be evaluated from Eq. 5-10a. To simplify the evaluation procedure, the following definitions are introduced.

$$\begin{aligned} \eta| = + e' | \text{ for } m = 0, \\ 2 \sin(\eta \overline{\nu}_{m}| = + e' |) \text{ for } 1 \le m \le M, \\ \exp(-\eta \overline{\nu}_{m}| = + e' |) \text{ for } m > M; \\ f_{2,m}(z, z') = f_{1,m}(z, -z') + f_{1,m}(z, z'); \\ (5-20b) \\ = -(\sin\theta, z \sin\theta) = f_{2,m}(z, -z') + f_{2,m}(z, z'); \end{aligned}$$

• 3, m(sum) ~ 2, m(suno, suno)

 $-2f_{\mathbf{k},\mathbf{m}}(\sin\theta,\sin\theta_i) + f_{\mathbf{k},\mathbf{m}}(\sin\theta,\sin\theta_i);$ (5-20c) Substituting from Eqs. 5-10a and 20 into 18 results in $\mathbf{H}_{\mathbf{m}} = \sum_{i=0}^{n} \mathbf{Q}_{\mathbf{m}} \left[\int_{\mathbf{Q}_{\mathbf{m}}} f_{\mathbf{k},\mathbf{m}}(\sin\theta) d\theta + \int_{\mathbf{Q}_{\mathbf{m}}} f_{\mathbf{k},\mathbf{m}}(\sin\theta) d\theta \right].$ (5-21) The integration domain of Eq. 5-21 is divided into two regions to avoid the logarithmic singularity in $K_i(\boldsymbol{\xi})$, as discussed above. The integrals of Eq. 5-21 can be carried out numerically using the Gauss quadrature formulae. The programming details are presented in App. D. The dispersion relation is obtained by the determinant search of [H] in the eigenvalue Eq. 5-16.
Having formulated the above modified method for analyzing microstrip lines, we now generalize it to microstrip resonators. The numerical results for both cases are subsequently presented.

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(5-24b)

D. Microstrip Resonators

In this section, an example is given of how the general problem of microstrip resonators can be analyzed. The case of a rectangular resonator (Fig. 5-4) with the even mode of resonance is studied since, for it, the results of the previous section can be more easily generalized. Eq. 5-3a can be generalized to

$\int_{i=0}^{\infty} K(x_{i}, x_{i}; x_{i}, z_{i}) \rho(x_{i}, z) dx dz = 0 \qquad (5-22)$

where f(x,z) is now the two-dimensional charge distribution on the MIC and

 $K(x,z;x_{ij}z_{i}) = \int_{0}^{\infty} \int_{0}^{\infty} (P_{1}/P_{2}) (\sin\alpha d_{i}'/\alpha)^{2} (\sin\beta d_{i}''/\beta)^{2}.$ $\cos(\alpha x) \cos(\alpha x_{i}) \cos(\beta z) \cos(\beta z_{i}) d\alpha d\beta. \qquad (5-23)$ $P_{1}(P) \text{ and } P_{2}(P) \text{ are defined in Eqs. 5-6b and 6c. From}$

Eqs. 5-lc and 5-7b

 $\rho^{2} = D^{2} - (\alpha h)^{2} - (\beta h)^{2},$ (5-24a)

where

$D^2 = \varepsilon_r (hk)^2$

K of Eq. 5-23 is a linear combination of terms like $K_2(\zeta, \zeta) = \int \int P_1/P_2 \exp[j(\nu \xi + \nu' \zeta)]/(\nu \nu')^2 d\nu d\nu', (5-25a)$ where

> **{ = x/h;** (5-25b) **{ = 2/h;** (5-25c)

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		x y=h plane	🏠 🔍 😅 - 10 gard - 1 da dag - 12 gard - 12 g
		▼/2 +	
ο το		-> 2di'	
<u>-L/2</u>			L/2
			2
	a ser a la ser a ser		

5-4 Rectangular microstrip resonator with even mode of resonance; + indicates the charge polarity.

Fi

venh (5-25d) ν' =βh,

To integrate K2, the following transformations are

introduced ν=σcosθ.

 $\nu' = \sigma \sin \theta$.

Substituting from Eqs. 5-26 into 25a results in

 $K = \int (P_1/P_2) (I(\theta)/\sigma^3) d\sigma.$ (5-27a)

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(5-25e)

(5-26a)

 $(5-26b)_{1}$

(5-27c)

where

3

• • • • •

 $I(\theta') = 2 \int_{\theta}^{\theta \pi} \exp(j\sigma E) / [(1 - \cos \theta')(1 + \cos \theta')] \cdot d\theta',$ (5-27b)

with

*θ' =*28.

and

 $E = (\cos(\theta'/2) + \sin(\theta'/2). \quad (5-27d)$

Eq. 5-27b can be evaluated by complex integration methods. Let

 $\overline{Z} = \exp(j\theta')$. (5-28)

then

 $d\bar{Z}/(j\bar{Z}) \rightarrow d\theta'$, (5-29)

 $I=(-8/j) \oint_{\overline{z}} \overline{z} \cdot \exp(j\sigma E) / [(\overline{z}-1)(\overline{z}+1)]^{2} d\overline{z},$ (5-30) where C is the contour shown in Fig. 5-5. There are two double poles at

 $\overline{Z}=1$ and $\overline{Z}=-1$.

Whether these poles should be fully enclosed within C of Fig. 5-5 or not is a valid question. However, in either case, the solutions to Eq. 5-3a will be the same, since the right hand side of Eq. 5-3a is zero and multiplying both sides by a constant will, not affect the solutions.

and



Re[Z]

Fig. 5-5 Contour for the integration of Eq. 5-30.

128 To evaluate I of Eq. 5-30, the residues of the integrand at the right hand side of Eq. 5-30 should be found: Let $R_{1} = (d/d\overline{Z}) \left[\overline{Z} \cdot \exp(j\sigma E) / (\overline{Z}+1)^{2} \right]_{\overline{z}=4}$ ={ [$\exp(j\sigma E$) + $j\sigma(dE/d\theta')(d\theta'/d\overline{Z})\overline{Z} \cdot \exp(j\sigma E)$] ($\overline{Z}+1$)* $-2(\bar{Z}+1)\bar{Z}\cdot \exp(j\sigma E) \}/(\bar{Z}+1)^{4}|_{\bar{Z}=1}$ + (5-31) From Eq. 5-28 $\theta' \mid_{\overline{z}=1} = 0.$ (5-32) Substituting from Eq. 5-32 into 27 regults in E 2-1=0. 5E (5-33a) and dE/d8' 11-1=0.55 - (5-33b) Substituting from Eqs. 5-33 into 31 results in $R_1 = (1/8) \sigma \xi \exp(j\sigma \xi)$. (5-34)Similarly, $R_{z} = (d/d\overline{Z}) [\overline{Z} \cdot \exp(j\sigma E) / (\overline{Z} - 1)^{s}]_{z = -1} = (-1/8) \sigma \xi \exp(j\sigma \zeta).$ (5-35) The addition of the two residues yields $I = (-8/j) (2\pi j) (R_1 + R_g)$ = $16\pi\sigma[\zeta \exp(j\sigma\xi) + \xi \exp(j\sigma\zeta)].$ (5-36) Substituting this result into Eq. 5-27a, we obtain $K_{g} = (M(\xi) - \ell M(\xi))$ (5-37a) where 🐱 🛩 $M(\xi) = \int \mathcal{A}(P_1/P_2) \left[\exp(j\sigma\xi) / \sigma^2 \right] d\sigma,$ (5-37b) The evaluation of $M(\xi)$ is similar to the evaluation of $K_1'(\zeta)$ in Eq. 5-5a, above. The results are similar to Eq. 5-10. In this way, K₂ of Eq. 5-37a is found. The kernel of Eq. 5-23 is a linear combination of terms like K₂ of Eq. 5-37a. Having found the kernel, Eq. 5-23 can be discretized. The resulting eigenvalue matrix equation

yields the resonant frequency of the resonator. The procedure for finding and solving this matrix equation closely parallels that in the previous section. The numerical results obtained by this method are presented below.

E. Numerical Results

The numerical results obtained by this method for single microstrip lines are shown in Fig. 5-6 and are compared to results obtained in [24]. The results show good agreement with [24] for higher frequencies. This method is less accurate for lower frequencies. At f.h=20 GHz.mm, for example, the error is 10.7%.

A numerical error analysis is performed as follows. The effect of truncating the infinite sum of Eq. 5-10a to N_x terms is demonstrated in Fig. 5-7. The final matrix size, M_x , is assigned the constant value of 4. The curve shows the change in the calculated value of ε_e vs. N_x ; the kernel of Eq. 5-11 converges very slowly. Fig. 5-8 shows the effect of increasing the final matrix size, M_x . N_x is assigned the fixed value of 500. It is seen that an increase in the matrix size from 4x4 to 8x8 has little effect upon the obtained results.

Unfortunately, the rate of convergence varies for different frequencies. For frequencies below the inflection point in the dispersion curve, even values of $N_x = 1000$ provide poor results. Furthermore, the cost of running the computer programs becomes prohibitive as N_x becomes very large, even though the matrix size is as small as 4x4.







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Fig. 5-7 Calculated effective dielectric constant vs. N_x (N is the number of terms to which Eq. 5-10a is truncated). fh=40.0 GHz mm, w/h=0.96, Cr=11.7 and $M_R = 4$ (M_R is the final matrix size). The actual value of $\boldsymbol{\varepsilon}_{\bullet}$ is 10.5.



Fig. 5-8 Calculated effective dielectric constant vs. final matrix size, M_R ; fh=40.0 GHz·mm, w/h=0.96, G =11.7 and N_x=500. (N_x is the number of terms to which Eq. 5-10a is truncated).

Thus, the approximate range of usefulness of this method is the frequency range above the inflection point in the dispersion curve (Fig. 5-6). In order to obtain accurate results with this method, the dimensions of a rectangular resonator should be chosen such that the resonant frequency remains within this range. In other words, the product of the resonator's expected resonant frequency and substrate height should be above the inflection point in the corresponding dispersion curve (i.e., the dispersion curve for the line which results from extending the resonator length to infinity). Thus, a resonator with the following specifications is analyzed (Fig. 5-4); 133

\$\vert_r=11.7,
h=3.17 mm,
w/h=0.96, and
L/h=3.253.

According to the transmission line model described in Chap. 1, where dispersion in the line is included and fringing at the ends neglected, the resonant frequency should be 9.2 GHz. With the method developed in Chap. 5, the calculated resonant length for this resonant frequency is L/h=3.248. This indicates an error of 0.15% from the specification. However, the transmission line model by itself may be in error by a few percent [32] and [35].

F. Summary

In this chapter, the integral equation method of Chap. 4 was modified such that the domain of integration of the integral equation was the MIC. In this way, the method, could be more easily applied to the rectangular resonator. Eq. 4-25b was rearranged as

 $\int_{\text{BM}} \cos(\alpha \mathbf{x}) \left(\frac{\partial \varphi}{\partial \mathbf{y}} \Big|_{\mathbf{y}=\mathbf{b}} \right) d\mathbf{x} = (1/\varepsilon) \int_{\text{MC}} \left[\cos(\alpha \mathbf{x}) / \overline{G}(\alpha) \right] \rho(\mathbf{x}) d\mathbf{x}. \quad (5-2)$ where $\varphi = \mathbf{E}_{\mathbf{y}}$ and

$$1/G(a) = \gamma \cdot \sinh(\gamma d) \gamma' \cdot \sinh(\gamma' h) /$$

 $[\varepsilon_r \gamma \cdot \sinh(\gamma d) \cosh(\gamma' h) + \gamma' \cdot \sinh(\gamma' h) \cosh(\gamma d)], \quad (5-1a)$ with

Both sides of Eq. 5-2 were multiplied by

$$os(ax_i) \cdot sin^2(ad'_i/2)/a^2$$

and integrated over a from zero to infinity to result in

$$\int_{MC} K(\mathbf{x}, \mathbf{x}_{i}) \rho(\mathbf{x}) d\mathbf{x} = 0; \qquad (5-3a)$$

 $K(x,x_i)$ was a linear combination of forms like

$$K_1(\zeta) = \int_0^\infty \exp(j\nu\zeta) / [\nu^2 G(\nu)] d\nu,$$
 (5-5a)

where

$$G(\nu) - \bar{G}(\nu/h) / h.$$
 (5-5d)

 $K_1(\boldsymbol{\zeta})$ could be found by complex integration techniques.

Eq. 5-3a was further developed for the case of the rectangular resonator in the even mode of resonance.

The numerical results for microstrip lines obtained by

this method were presented in Fig. 5-6 and showed good agreement with the results of [24] at higher frequencies. The method failed to be accurate at lower frequencies. The range of usefulness of this method was for frequencies higher than the inflection point in the dispersion curve. Using this range of usefulness, the method was then applied to the rectangular resonator and a numerical example was provided, which showed good agreement with transmission line model methods.

G. Conclusions

The method developed in this chapter reduces the problem of analyzing microstrips to an integral equation with only the MIC as the domain of integration. The method for solving the final integral equation has been presented. This method gave results which are in good agreement with those of other methods for high frequencies, but is less accurate for low frequencies (e.g., the error at f.h=20 GHz. mm is 10.7% for the dispersion curve shown in Fig. 5-6).

 $K_1(\zeta)$ of Eq. 5-10a converges very slowly and becomes logarithmically singular for small arguments. The numerical analysis indicates that a better accuracy can be achieved for lower frequencies if more terms are included in Eq. 5-10a. However, this causes a large increase in computational costs even when the final matrix size is as small as 4x4. For frequencies above the inflection point in the dispersion curve, the method is quite useful and can be generalized to microstrip resonators, as indicated by the example given in this chapter.

VI. CONCLUSIONS

In the previous chapters, various integral equation methods were applied to the analysis of microstrips. The BEM was applied to single and coupled microstrip lines in the quasi-TEM regime. The analysis was capable of evaluating the characteristic impedance, Z, the effective dielectric constant, ϵ_e , as well as the charge density, $\rho(x)$, and the potential distribution, φ . The inclusion of the singularity of the charge distribution in the formulation resulted in increased efficiency, increased accuracy, and reduced final matrix sizes.

However, complications were evident for generalizing the BEM to the wave analysis of microstrips, since it was difficult to obtain the "fundamental solution" (see p. 45). It was easier to obtain the results by modifying the classical integral equation solution of Chap. 2. Thus, in Chap. 3, the quasi-TEM microstrip line was analyzed by a novel method which can be considered as a generalization of Green's functions. Green's functions are customarily defined so that they satisfy a nonhomogeneous differential equation. For example, the forcing function can be chosen to be a point charge. In Chap. 3, it was shown that instead of Green's functions; a fundamental solution could be chosen which satisfies a homogeneous differential equation. The boundary conditions on this fundamental solution could be arbitrarily chosen in such a manner that the final integral equation was simplified.

This method resulted in reasonably accurate expressions for the characteristic impedance and ϵ_e of microstrip lines.

il.

1.

This method was then generalized in Chap. 4 to the wave analysis of microstrip lines. The problem of analyzing microstrip lines reduced to solving an integral equation with the DAI as the domain of integration. Moreover, unlike the customary employment of two potential functions for the wave analysis of microstrip lines, it was shown that only one properly chosen function, namely E_y , was sufficient for obtaining the parameters of the microstrips. This approach reduced the effort for analyzing microstrips.

The obtained results exhibited good agreement with other methods and converged smoothly to the quasi-TEM results. Furthermore, there were two conclusions of interest regarding the wave analysis of microstrips:

as in the quasi-TEM regime, the dimensions of microstrips could be normalized to the substrate height, h, and

2. the frequency, f, could be normalized to f.h.

In order to generalize the formulation to resonators, an alternative integral equation method was developed in Chap. 5 with the MIC as the domain of integration. This method was more elaborate, but could be more easily generalized to microstrip resonators. The obtained results were accurate for higher frequencies but the accuracy was reduced for lower frequencies (i.e., below the inflection point in the dispersion curve).

The rectangular microstrip resonator with an even mode

of resonance was then analyzed using this method. This analysis indicated how the method could be generalized to microstrip resonators in order to provide a basis for the computer-aided design of microstrips. For the further development of the above methods, the following recommendations can be employed:

The general problem of analyzing microstrip resonators can be approached in a way similar to the analysis of the rectangular resonator. The MIC area of an arbitrarily shaped resonator can be subdivided into a mesh of rectangles; in this way, the obtained integral equations can be discretized. Due to the singularity in the charge distribution, smaller rectangles can be chosen near the MIC edges. Furthermore, the numerical errors caused by the slow convergence of the obtained functions could perhaps be reduced by expressing these functions in terms of more rapidly convergent functions (e.g., a logarithmic function added to a Taylor series).

The methods developed in this thesis can also be used for analyzing coplanar microwave integrated circuits (i.e. circuits in which the dielectric substrate is metalized on one side only). Another possible field of application can be the analysis of the higher order modes in microstrips.

This thesis can therefore be viewed as a stepping stone toward the eventual analysis of arbitrarily shaped resonators. In addition, the methods proposed for the analysis of microstrip lines and coupled lines can be applied directly to engineering designs.

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Appendix A

Computer Programs for Single MIC Lines

The programs are written in APL. The workspace is called SINGLE. The symbols used in the programs and their relation to the symbols in Chap. 2 is as follows:

APPENDICES

- {X} in Eqs 2-18 and 37 CH 1
- CO : C_{n} capacitance of the microstrip line for $\ell_{r}=1$
- C capacitance of the microstrip line for $\boldsymbol{\xi}_r \neq 1$ Cl:
- ER : e,
- ET: 7 Eq 2-21a
- [G] Eqs 2-22b and 37 Gl #
- G2 # [G₂] Eqs 2-22b and 37
- [G₃] Eq 2-37 G3:
- [G4] Eq 2-37 G4 :
- [Ĝ₅] Eq.2-37-G5 1'
- γ; Eq 2-25a NJ±
- \bar{v}_i NF : Eq 2-36d
- Abscissa for Gaussian integration NM :
- **6**, Eq² 2-29c THI :
- 0, Eq 2-29a TH1:
- TH2:
- **∂** Eq 2-29b
- WJ 1 W; Eq 2-24
- W, Eq 2-36c WF:
- Weight factor for Gaussian integration WM z

DTH+TH2CJ3-TH1CJ3 TH+0.5×(TH2EJ3+TH1EJ3)+NM×DTH [2] [3] A+IH-THICIJ [4] B+0.5×TH+THICIJ C53 C+B-00.5

RR+INT

This program evaluates the elements of $[G_2]$ (Eq. 2-32).

Program INT

[1]

NJ+ 0.07652652109999999 0.2277858511 0.3737060887 .D. [2] 0.51086770019 0.6360536807 [3] NJ+NJ, 0.7463319064 0.8391169718 0.9122344282 ,0 C43 0.9639719272 [5] NJ+NJ,0.9931285991 E63 WJ+ 0.1527533871 0.1491729864 0.1420961093 0.1316886384 WJ+WJ, 0.1181945319 0.1019301198 0.0832767415 [7] C83 WJ+WJ, 0.06267204830000001 0.0406014298 0.0176140071 [9] TH1+00.5×0.0.5×(-1+NJ)+1+NJ [10] TH2+(1+TH1),00.5 C111 THI+00.5XNJ [12] ZE+1OTHI C13] CF+6+#4 NF+ 0.2635603197 1.4134030591 3.596425771 7.0858100058 .0 [14] [15] 12.6408008442 E16] WF+ 0.6790940422 1.6384878736 2.7694432424 4.3156569009 .D [17] 7.2191863544 [18] ZF+NF+1

from Ref. [48].

V POINT

E1J

Program POINT

This program assigns the values to the parameters necessary for numerical integration; the data are obtained 146

ZEF: ζ ; with $0 < \zeta$

ZF: C: with 1<4

ZE: ξ ; with $0 < \zeta < 1$

WOH: w/h

E6]	AR+@((10A)+A)X((10B)+B)X(10C)+C
[7]	D1+DTH×+/WM×AR
[8]	A1+TH1EJ3-THIEI3
[9]	A2+TH2[J]-THI[]
[10]	BI+THICJJ+THICIJ
C111	B2+TH2CJJ+THICTJ
[22]	C1+B1-01
C131	C2+B2-01
E143 .	D2+2**((1A2)*A2)*((1B2)*B2)*((1C2)*C2)
C153	D2+D2-2x*((A1)+A1)x((B1)+B1)x(C1)+C
E163	RR+D1+D2-DTH×CF

Program INT2

This program evaluates the elements of $[G_3]$ (Eq. 2-37).

```
RS4INT2
Č13
      DTH+TH2EJ3-TH1EJ3
נ23
      TH+0.5×(TH2EJ3+TH1EJ3)+NH×DTH
[3]
      STH+10TH
[4]
      R1+STH+STH+ZFEIJ
[5]
      R2+((TH-00,5)x20TH)+ZFEIJ-STH
[6]
      R3+2×DTH×+/WM×R1×R2
[7]
      ZS+ZFEIJ+2
      R5+ (ZS-(10TH1EJ3) +2) +TH1EJ3-00.5
[8]
[9]
      R6+(ZS-(10TH2EJ3) +2) +TH2EJ3-00.5
[10]
      R7+2×eR6+R5
C113
      RS+R3+R7
```

Program FIRST

This program forms the matrix [G1] (Eqs. 2-24, 22b).

	FIRST	COJ.	
	 FIRS 	TET	
	GF1+(2 JM+pWJ	+ET) *2	
[3]	AR1+CF	1+(ZE•.	+ZE) +2
[4] [5]	9R2+CF	1+(ZE•. R1×AR2	-ZE) +2
			L (M, JM)

Program SECOND

This program forms (G21 using INT2 (Eqs. 2-31, 22b).

```
V SCND
[1]
       G2+ (JM, JM) PO
[2]
       I+1
[3]
      L2: J+1
E43
      L3:G2EIIJJ+INT
[5]
       1+1+1
[6]
       +(JEJH)/L3
[7]
       I+I+1
[8]
       +(I_JM)/L2
```

Program THRD

This program forms [G3] using INT2 (Eqs. 2-37).

```
▼ THRD
[1]
        JF+PZF
[2]
       G3+(JF, JM) PO
[3]
       I+1
E43
      L4: J+1
[5]
      L5:G3[I;J]+INT2
[6]
       J+J+1
[7]
       →(JEJH)/L5
C83
       I \leftarrow I + 1
[9]
       +(I_JF)/L4
```

Program FRTH

This program forms $[G_{4}]$ (Eqs. 2-24,37).

```
    FRTH ET
    CF1+(2+ET)*2
    C2] R1+CF1+(ZF*.+ZE)*2
    C3] R2+CF1+(ZF*.-ZE)*2
    C4] R3+@R1*R2
    C5] G4++00.5*R3*(JF*JM)PWJ
```

Program FFTH

This program forms $[\hat{G}_5]$ (Eqs. 2-36, 37).

- ▼ FFTH
- [1] ZEF+ZE,ZF
- [2] JN+PZEF
- [3] R1++CF1+((-ZEF)++ZF)+2
 - [4] R2++CF1+(ZEF+++ZF)+2
- [5] R3+R1+R2 [6] G5+(2x(FR-1
 - 6] 65+(2×(ER-1)+ET)×R3×(JN,JF)PWF

Progran FNL

This program performs the final assembly for the case

and solves the resulting equations to obtain $\{X\}$ and C. (Eq. 2-34).

€<u>_=1</u>

- ▼ FNL [1] GG+G1+G2
- [2] FF+JMP04 [3] CH+FF866 [4] CO++/CHXWJ

Program FNL2

This program performs the final assembly for the case

€,≠1

and solves the resulting equations (Eqs. 2-37,38).

	FNL2 ER		\sim		
[1]	CF3+02xFR+1				
[2]	F+-CF3+(ER-1	XCTANET	~ / 4		
[3]	F+-CF3+(ER-1 G+((G1+G2),C	17 GZ_GA	^\1- <u>7</u> EF)÷ \ CE	2)+-30E	Tx(1+ZEF)+2
C43	I+JM+1		//00		
[5]	L6:GCI;IJ+GCI	+TT+CET			
[6]	FEIJ+FEIJ+CF	743TUF3 7			
[7]	I+I+1				
[8].	→(I≤JN)/L6				
[9]	CHP+FBG		4		
E103	C1++/(JM+CHP	Y X LI I		arta al	
		· · · · · · · · · · · · · · · · · · ·			

Program TTL

[1]

[2]

This program produces the titles needed for the output in the main program IMPD.

150

T1+'CHARACTERISTIC IMPEDANCE' T2+'EFFECTIVE DIELECTRIC CONSTANT'

[3] T3+'CHARGE DISTRIBUTION;CH VS. ZE' [4] T4+'POTENTIAL DISTRIBUTION ON THE DAI' [5] T5+'FIRST COLUMN: NORMALIZED DISTANCE' [6] T6+'SECOND COLUMN: ROTENTIAL' [7] T7+'' [8] T8+'SECOND COLUMN: CH'

Program IMPD

This program is the main program; it executes the above programs and prints out ϵ_e , Z, charge distribution (X of Eqs. 2-18 and 21e), and the potential distribution on the DAI. The input to IMPD is w/h and ϵ_r .

	WOH IMPD ER
[1]	ET+WOH+2
[2]	FIRST ET
[3]	FNL .
. E43	FRTH ET
[5]	
	FFTH
[6]	FNL2 ER
[7]	T2
[8]	IC1÷C0
[9]	TZ
[10]	T7
[11]	Tit State and the second s
[12]	120÷(/C0×C1)+0.5
Č133	T7
[14]	T7
[[15]	T 3
[16]	- TS - 1 - 1 - 1 - 1 - 1 - 1 - 1 - 1 - 1 - 1 - 1 - 1 -
[17]	ТВ
[18]	
	A(2, JM) PZE, (JM+CHP)
[19]	T7

[20] T7 [21] T4 [22] T5 [23] T6 [24] B(2,JF)PZF,(JM+CHF)

Example

To analyze a microstrip line with w/h=l and ξ_r =9.9. The workspace SINGLE is loaded for st; 151

)LOAD SINGLE

IMPD is executed next

1 IMPD 9.9 EFFECTIVE DIELECTRIC CONSTANT 6.090198244

CHARACTERISTIC IMPEDANCE . 51.26247005

CHARGE DISTRIBUTION; CH VS. ZE FIRST COLUMN: NORMALIZED DISTANCE SECOND COLUMN: CH 0.1199182902 5.979617834 0.3502192597 5.932851971 0.5538791487 5.854585711 0.7190733836 5.767108169 0.8409902074 5.689695601 0.9216592529 5.632856882 0.9682372823 5.598098021 0.9905120983 5.580976234 0.9983990569 5.574818233 0.99994175 5.573570186 POTENTIAL DISTRIBUTION ON THE DA1 FIRST COLUMN: NORMALIZED DISTANCE SECOND COLUMN: POTENTIAL 1.26356032 0.641102785 2.413403059 0.2778148304 4.596425771 0.08741715987 8.085810006 0.02427627784 13.64080084 0.00750436892

Appendix B

Computer Programs for Coupled Microstrip Lines

The workspace is called COUPLED. The parameters for numerical integration are the same as in SINGLE (App. A) so they are copied into COUPLED. Besides the symbols defined in App. A, there are some symbols used in COUPLED which are defined below:

El through E8: $[E_1]$ through $[E_8]$. Eqs 2-56 and 57 FF1: $[F_1]$; Eq. 2-58 Gl through G4: $[G_1]$ through $[G_4]$; Eqs 2-50, 51 H1: $[H_1]$ Eq. 2-58 SIG: δ' Eq. 2-55b 2D: $1 < \xi_i < \delta'$ 2E: $-1 < \xi_i < 1$ 2F: $-\infty < \xi_i < -1$ 2Z: $-\infty < \zeta_i < \delta'$ 2PD: ζ_i' , $1 < \xi_i < \delta'$ 2PE: ζ_i' , $-1 < \xi_i < 1$ 2PF: ζ_i' , $-\infty < \zeta_i < -1$ 2P: ζ_i' , $-\infty < \zeta_i < \delta'$

Program PNT

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This program evaluates the coefficients and vector sizes and forms matrices which are necessary for the numerical integrations.

	▼ PNT
[1]	CF+6+2xe04
[2]	JD+PNM
[3]	JE+PZE
[4]	JF+PZF
[5]	JT+JD+JE+JF
[6]	WWD+(JT, JD)PWM
[7]	WWE+(JT, JE)PWJ
[8]	WWF+(JT, JF)PWF
· · ·	

Program DATA

This program evaluates ζ_i and ζ'_i for a given σ .

DATA SIG
 [1] ZD+0.5×(SIG+1)+(SIG-1)×NM
 [2] ZPD+(2×SIG)-ZD
 [3] ZPE+(2×SIG)-ZE
 [4] ZPF+(2×SIG)-ZF
 [5] ZP+ZPD,ZPE,ZFF
 [6] ZZ+ZD,ZE,ZF

Program INT1

This program performs the integration of Eq. 2-53.

•	V RR+INTT
[1]	A1+TH1CJJ-THICIJ
[2]	A2+TH2CJ3-THICI3
[3]	R1+((1A2)*A2)+(1A1)*A1
E43	B1+(01)-TH1EJ3+THIEI3
[5]	B2+(01)-TH2CJJ+THICIJ
[6]	R2+((1B1)+B1)+(1B2)+B2
[7]	C1+(01)+TH1EJ3+THIEI3
[8]	C2+(01)+TH2EJJ+THIEIJ
[9]	R3+((1C2)+C2)+(1C1)+C1
[10]	R4+2x#R1xR2xR3

- E113 S1+0.5×THEJ;J-THIEIJ
- [12] S2+0.5×THEJ#J+THIEIJ
- [13] S3+(10S1)+S1
- [14] S4+@(020S2)+((00.5)-S2)x(00.5)+S2
- [15] R5+DTHEJJX+/WMXS4
- [16] RR+R4+R5-DTHEJJ×CF

Program INT2

Consider Eq. 2-50b

$$G_{z,ij} = \int_{E_{ij}}^{E_{ij}} \ln(\zeta_1' - \zeta_1) / \sqrt{1 - \zeta^*} d\zeta.$$
 (2-50b)

Applying the transformation

(2 - 32)

(B-1)

(B-3)

(2 - 48)

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to Eq. 2-50b yields

$$S_{\mathbf{s},\mathbf{ij}} = \int_{\theta_1}^{\theta_2} \ln(\zeta_i' - \sin\theta)^2 d\theta.$$

Applying the identity

$$(d/d\theta)[(\theta \pm \pi/2)\ln(\zeta_{i}' - \sin\theta)] = \frac{1}{\ln(\zeta_{i}' - \sin\theta) - (\theta \pm \pi/2)/(\zeta_{i}' - \sin\theta)}. \quad (B-2)$$

to Eq. 2-50b results in

Ga

$$\frac{1}{2} = 2\ln(|\zeta_i' - \sin\theta_2|^{\theta_2 - \pi/2}/|\zeta_i' - \sin\theta_1|^{\theta_1 - \pi/2}) + 2\int_{\theta_1}^{\theta_2} [(\theta - \pi/2)\cos\theta/(\zeta_i' - \sin\theta_1] d\theta]$$

where the minus sign in Eq. B-2 is used. This choice of sign is used to remove the singularity occuring at $\zeta_i=1$; Considering that

$$i_1 = 2(\sigma/\eta) - \zeta_1$$

and the fact that c_i lies on the MIC for $c_r = 1$, it is concluded that $c'_i \ge 1$.

For coupled lines with $\epsilon_r \neq 1$ an integral similar to that of Eq. B-l occurs in which ζ'_i is replaced by ζ_i and can be less than or equal to minus one. Specifically, consider $H_{1,ij}$ of Eqs. 2-57d, 58a, and 58b

$$H_{1,ij} = -\eta \int_{z_{1j}}^{z_{1j}} \ln(z_{1}-z_{1})^{2} / \sqrt{1-z^{2}} dz . \qquad (B-4)$$

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Applying the transformation of Eq. 2-32 followed by the identity of Eq. B-2 yields

 $H_{1, \frac{1}{2}} = 2\eta \ln \left[\left| \zeta_1 - \sin \theta_2 \right|^{\theta_2 + \pi/2} / \left| \zeta_1 - \sin \theta_1 \right|^{\theta_1 + \pi/2} \right]$

$$-2\eta \int_{\theta_1}^{\theta_2} (\theta + \pi/2) \cos \theta / (\zeta_1 - \sin \theta) d\theta. \qquad (B-5)$$

where the plus sign of Eq. B-2 is used.

Program INT2 evaluates both Eqs. B-3 and B-5.

AZ can be ζ_i of Eq. B-3 in which the minus sign of Eq. B-3 is relevant, or AZ can be ζ_i , of Eq. B-5 in which case the positive sign applies. Correspondingly SGN can be -1 or +1.

	V RS+SGN INT2 AZ
[1]	SP+OSGN×0.5
[2]	R24(AZEIJ-10TH2C, IT)+TH2C IT+CO
.233	R1+(AZEIJ-10TH1EJ) +TH1EJJ+SF
E43	R3+2×01R2+R1
[5]	R4+((THEJ;]+SP) x20THEJ;])+AZEI]-10THEJ;]
[6]	R5+DTHEJJX+/WMXR4
[7]	RS+R3+R5

Program FIRST

This program forms the matrix $[G_1]$ (Eqs. 2-51 and 58b).

	e
	V FIRST
[1]	G1+(JE,JE)PO
[2]	I+1
[3]	L2:J+1
[4]	L3:G1[I;J]+INT
[5]	J+1-1
[6]	+(J≰JE)/L3
[7]	I+I+1
C83	+(I∡JE)/L2

Program SCND

This program forms the matricies $[F_1]$, $[G_2]$, $[H_1]$, and $[E_8]$ (Eqs. 2-51, 56, and 58).

RA+V SCND AZ [1] RA+(2+V)PO [2] **I**←1 [3] L4: J+1 [4] L5:RAEI; J3+VE33 INT2 AZ [5] J+J+1 [6] +(J_V[2])/L5 [7] I€Ì+1 [8] →(I<u></u>∠VE1])/L4

Program THRD

This program assembles $[G_1]$ through $[G_4]$, $\{U\}$ of Eq. 2-51, $[E_1]$ through $[E_8]$ and $\{F\}$ of Eq. 2-56. The input to the program is VV, a vector which in this program contains \mathcal{E}_r , η , and σ' .

	THRD VV
[1]	ER+VV[1]
[2]	ET+VV[2]
E33	SIG+VV[3]
E43	DATA SIG
[5]	CE1+(2+ET) +2
[6]	E1+((ER-1)x(SIG-1)+ET)xWWD+CF1+(ZZZD)+2
[7]	E2+((ER-1)×(SIG-1)+ET)×WWD+CF1+(ZF•ZD)+2
[8]	E3+(2×(ER-1)+ET)×WWF+CF1+(ZZ++-ZF)+2
[9]	E4+(2×(ER-1)+ET)×WWF+CF1+(ZP+#ZF)*2
[10]	E5+00.5XWWEX@CF1+(ZZZE)*2
[11]	E6+00.5×WWE×OCF1+(ZPZE)*2
E123	FF1+(JD,JE, T) SCND ZD
C133	H1+(JF, JE, 1) SCND ZF
[14]	E7+(FF1,E1J G1),E1J H1
C153	EB+(JTAJE, 1) SCND ZP
[16]	U+JEP04
E173	G2+(JE, JE, -1) SCND ZPE
C183	634-00.5×WW×+CF1+(ZE+ZE)+2
[19]	G4+-00.5×WW×@CF1+(ZPE+ZE)+2
[20]	GGE+G1+G2+G3+G4
[21]	GGD+G1+G3-G2+G4

Program FNL

The final assembly and rearrangement of the equations are performed by this program.

€, ≠1

(i.e., to rearrange Eq. 2-56 into Eqs. 2-59).

	▼ FNL
[1]	F1+-300.5×ET×1-ZZ
[2]	F2+-300.5×ET×1+ZZ
[3]	F34-300.5×ET×1-ZP
[4]	F44-300.5×ET×1+ZP
[5]	FE+(1-ER)×F1+F2+F3+F4
[6]	F0+(1-ER)×F1+F2-F3+F4
[7]	CF2+02x1+ER
C83	V1+JD+1JE
E93	FEEV1J+FEEV1J-CF2
[10]	FOEV1J+FOEV1J-CF2
`[11]	GE+(E1+E2),(E7+E8-E5+E6),E3+E4
[12]	GO+(E1-E2),(E7-E8+E5-E6),E3-E4
C133	141
E143	L6:GECI;IJ+GECI;IJ+CF2
C153	GOCI+IJ+GOCI+IJ+CF2
[16]	I+I+1
C173	→(I∠JD)/L6
[18]	I+I+JE
[19]	L7:GECI;IJ+GECI;IJ+CF2
E203	GOCI;IJ+GOCI;IJ+CF2
[21]	I+I+1
[22]	→(I≟JT)/17

Program FNL2

The final equations for both cases

 $\epsilon_r = 1$ and $\epsilon_r \neq 1$

are solved and the various coupled mic line parameters are evaluated by this program.

	V FNL2
[1]	ABCE+FEBGE
[2]	AE+JD+ABCE
[3]	BE+JD+(-JF)+ABC
C43	CE+(-JF) +ABGE
C 5 J	ABCO+FODGO

[6] AD+ JD+ABCO [7] BO+JD+(-JF)+ABCD [8] CO+(-JF)+ABCD [9] CE1++/WJXBE [10] CO1++/WJXBO [11] CEO++/WJ×UBGGE [12] COO++/WJXUBGGO £133 T12 [14] T12 E153 T1 . [16] + 240+(ICE0×CE1)+0.5 [17] T12 C183 T12 [19] T2 240+(|C00×C01)+0.5 [20] [21] T12 [22] T12 [23] T2P [24] IGE1+CE0 [25] T12 [26] T12 [27] T3P [28] |C01+C00 T12 。 [29] C303 T12 [31] T3 [32] T4 [33] T5 [34] **T6** [35] a(3, JE) PZE, BE, BO [36] T12 [37] T12 [38] T7 [39] TB [40] T9 [41] T10 [42] a(3, JB) PZD, AE, AD [43] T12 [44] T12 [45] T11 [46] **T8** [47] T9 [48] T10 [49] a(3, JF) PZF, CE, CD
IMPD

This is the main program. The input to this program is VV. In this program VV is a vector with the following elements:

 $VV[1] = \varepsilon_r,$

VV [2]=w/h (Fig 2-10a) and

VV[3]=s/h (Fig 2-10a).

VV is modified by IMPD to contain \mathcal{E}_r,η , and σ needed, as the input to THRD.

```
• IMPD VU

[1] VV[3]+1+VV[3]+VV[2]

[2] VV[2]+VV[2]+2

[3] THRD VV

[4] FNL

[5] FNL2
```

```
Program TTL
```

This program produces the titles and comments necessary for the output in FNL2.

	이 수 같이 것은 것은 것이 가 있는 것은 것이 있는 것이 것 같이 있는 것이 같이 없다.
ַנַזַזַ	T1+ EVEN_MODE CHARACTERISTIC IMPEDANCE
[2]	
C33	· 2.5 중심 · 2.5 여행 지수 않는 것이 같은 것이 같이 가지 않는 것이 같은 것이 있는 것이 있다. 것이 있는 것이 없다. 것이 있는 것이 있 않는 것이 있는 것이 있는 것이 없는 것이 없다. 것이 있는 것이 없는 것이 있는 것이 있는 것이 있는 것이 있는 것이 없는 것이 있
C43	
[5]	
[6]	195 FIRST COLUMNS ADDMAL TOD AT A TOD
.[7]	TS+ SECOND COLUMN: EVEN_HODE CH
[8] [9]	NASTRY TEXUS COUNTRY AND TO MODELAND STRUCTURE STRUCTURES TO A STRUCTURE STRUCTURE STRUCTURES.
Ē10]	THE UTENTIAL BISTOTON ON A LOCAL STREET
£113	
£12] £13]	人名英格兰斯 化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化化
	TIT POTENTIAL DISTRIBUTION ON DAT OUTSIDE MICS
C143	

Example

To analyze coupled mic lines with

 $\epsilon_r = 9.9,$ w/h = 1.0, and S/h = 1.0 161

the workspace COUPLED is loaded first. The response to

IMPD 9 1 1

is

EVEN_MODE CHARACTERISTIC IMPEDANCE 59.70066832

ODD_MODE CHARACTERISTIC IMPEDANCE 43.22294308

EVEN_MODE EFFECTIVE DIELECTRIC CONSTANT 5.856033191

ODD_MODE EFFECTIVE DIELECTRIC CONSTANT 5.225940583

CHARGE DISTRIBUTION: FIRST COLUMN: NORMALIZED DISTANCE

	JOUNDETTED DIS	TANCE ON THE MI
SECOND COLUMN:	EVEN_MODE CH	THE BRANCE NI
sent a second	DD_MODE CH	"
0.99994175		
	6.754553263	7.964977794
-0.9983990569	이 김 김 김 김 김 씨가 아내는 수가 있다.	6.8120589
0.9905120983	5.623564688	6.335101657
-0.9682372823	5.390650995	6.003415031
-0.9216592529	5.235309422	
0+8409902074	5.138075753	5.789411168
-0.7190733836		5.67031868
-0-5538791487	5.084286331	5.634514068
	5.054407753	5.669359218
0.3502192597	5.022212962	5.758712778
-0.1199182902	4.959754888	5.886318488
0.1195182902	4.848171275	6.042027748
0.3502192597	4.688702156	6.224333422
0.5538791487	4.506285863	
0.7190733836	4.342177833	6.435227221.
0.8409902074		.6.672403318
0.9216592529	4.239352342	6+728322168
	4.229350085	7.198439857
0.9682372823	4.328538908	7.491717851
0,9905120983	4.549176108	7.840944982
0.9983990569	4.900981007	8.289778812
0.99994175	5.777186024	
		9.335118178

POTENTIAL BISTRIBUTION ON DAI OUTSIDE MICS FIRST COLUMN: NORMALIZED DISTANCE SECOND COLUMN: EVEN_MODE PPOTENTIAL THIRD COLUMN: ODD MODE POTENTIAL 1.26356032 0.6779665161 0.6687968417 2.413403059 0.3032838761 0.2755921618 4.596425771 0.101707095 0.07841470369 -8.085810006 0.03033464862, 0.01752825718 13.64080084 0.008757300631 0.003875702662 162

POTENTIAL DISTRIBUTION ON DAI BETWEEN MICS FIRST COLUMN: NORMALIZED DISTANCE SECOND COLUMN: EVEN_MODE PPOTENTIAL THIRD COLUMN: ODD MODE POTENTIAL 1.013046736 0.9955866221 0.9516569076 1.067468317 0.908074752 0.7938957452 1.160295216 0.8321237625 0.6461210028 1,283302303 0.7693159969 0.509282825 1.425562831 0.7208040195 0.3846162811 1.574437169 0.6865892529 0.2734562838 1.716697697 0.6653052949 0.177496482 1.837704784 0.6543171934 0.09913397699 1.932531683 0.6501500673 0.04152114196 1. 9869 53264 0. 6492924917 0.008021078655

Appendix C

Workspace THAT

This workspace contains several functions for evaluating and solving the final equations of Chap. 4. The notation used is as follows:

B , BB :	B,Eq. 4-23d,
Cs	C,Eq. 4-23e,
DEL :	8, Eq. 4-22g,
EFs.	E _e ,
ER :	
ET :	Ŋ,Eq. 4-22c,
F :	(fh) normalized frequency GHz.mm
Gl [I;J]	G _{1,ij} Eqs. 4-33
L .	L, Eq. 4-31
M z	M, Eq. 4-32a and 32c
PH=tan ⁻¹ (C/L)	C, and L are defined in Eqs. 4-23e and 31
RO:	$n_{\rm r}$, Eq. 4-25c,
SG:	5n.Eq. /4-25,
WI [I]:	Wi, Fig. 4-3.
XI [I]:	ζ _{i,} Fig. 4-3,
XI[];	\$11, Fig. 4-3.
XU[1]:	ξ _{vi} ,Fig. 4-3.

FO computes ℓ_{ij} and ℓ_{ij} given the values of ℓ_{ij} and W_{j} .

		FO	NI	
 1]		PWI		
 2]		+NP	0	inte State
 3] 4]		• . •		
53	L11			
 5]		J <n< td=""><td></td><td>N 1.</td></n<>		N 1.
 73		-0,		
			. 	 12.0

<u>D1</u>

...<u>FO</u>

D1 computes the matricies with elements

(Eu-E). (Eu-E). (Eu+E1+27), and (Eu+E1+27)

used as the arguments of Eqs. 4-33a, c, and d.

▼ D1
 C13 XI1+XI•.-XL
 C23 XI2+XI•.-XU
 C33 Z1+XI•.+XL+2×ET
 C43 Z2+XI•.+XU+2×ET
 C53 M+PXL

<u>D2</u>

D2 computes the factors

 $exp(-f_{uL}), exp(-f_{uL}), exp(-f_{L})$

which appear when integrating Eqs. 4-33.

	• D2 L	
[1] [2]	EI+(M,M) I+0	۶0 .
	10:1+1+1	
	+(I <m) l<="" td=""><td>*-LXXICI: 10</td></m)>	*-LXXICI: 10
[6]	EX1+(M,M) P + - LXXL
[8]	EX2+(M,M LX2+(M,M	>PLXXU
[9]	LX1+(M,M	PLXXL

, and G 5.ij respectively. L F1 C S+(L+2)+C+2 C13 [2] SQ+S+0.5 [3] CLI+C+L [4] PH+ 30CLI [5] LIQ+(PH+CLI)+L [6] E2+EX2+2×SQ [7] E1+EX1+2xS0 C83 R1+PH-CXXI1 [9] R2+PH-CXXI2 [10] R3←-SNUXE2×(LIR+XI2)×(10R2)÷R2 R4+-SNL×E1×(LIQ+XI1)×(10R1)+R1 [11] G2+R3+R4+E1+S [12] E133 R5+PH+CxZ1 [14] R6+PH+C×Z2 [15] R7+E1*(L10+Z1)*(10R5)+R5 R8+E2x(LIQ+Z2)x(10R6)+R6 [16] [17] G1+R7-R8 [18] R9+E1C1; J×20PH+C×ET+XL [19] R10+E2C1#Jx20PH+CxET+XU [20] 65+R9-R10

<u>D3</u>

G 2, 1j

forms matricies Gl, G2, and G5 with elements G1.ij,

F1 Using the matrices computed in DL, D2, and D3, F1

evaluating the integral in Eq. 4-33c, for the given conditions • D3 SNU+2x-0.5+XL . <XI [1] [2] SNL+2×-0.5+XU..>XI

D3 computes the matrices SNU and SNL such that correct signs can be allotted to the different terms for

F2 finds the matrices G3 and G4 (Eqs. 4-33a and b).

	▼ L,F2 C
C13	G4+G3+0
[2]	N+O \
[3]	L1:N+N+1
/[4]	RS+((ON)+2)-C+2
[5]	RD+RS+0.5
C63	DR++RO×RO+L
[7]	G3+G3+DR*(+-LX1+R0*Z1)-+-LX2+R0*Z2
[8]	G41+EX1×(*-RO× XI1)
[9]	G41+G41+RO×L-SNL×RO
[10]	G42+EX2×(+-RD×1XI2)+RD×L+SNU×RD
C117	G4I+2×EI+(L+2)-RS
[12]	G4+G4+G41-G42+G4I
C133	→(N <hax) l1<="" th=""></hax)>
	그는 그는 것이 아니는 것이 같은 것이 아니는 아니는 것이 아니. 것이 아니는 것이 아니. 것이 아니는 것이 아니는 것이 아니는 것이 아니는 것이 아니는 것이 아니. 것이 아니는 것이 아니는 것이 아니는 것이 아니는 것이 아니. 것이 아니는 것 이 아니는 것이 아니는 것이 아니. 아니는 것이 아니는 것이 아니는 것이 아니. 것이 아니는 것이 아니는 것이 아니. 것이 아니는 것이 아니는 것이 아니는 것이 아니. 것이 아니는 것이 아니. 것이 아니는 것이 아니. 것이 아니는 것이 아니는 것이 아니. 것이 아니는 것이 아니. 것이 아니는 것이 아니. 것이

<u>F3</u>

<u>F2</u>

Similarly, F3 finds G6 and G7 (Eqs. 4-33f and 2).

935 1997 - 1997 - 1997	▼ L F3 B
[1]	66+67+0
`[2]	N(-1
[3]	L2:N+N+1
[4]	SGS+(BA2)+(ON+DEL)+2
[5]	SG+SGS+0.5
[6]	BSG+B+SG
[7]	DR+BSG+SG+L
C83	06+66+DR×(*-LX1+56×Z1)-*-LX2+56×Z
[9]	G71+BSG×EX1×(*-SG× XI1)+L-SNL×SG
[10]	G72+BSG×EX2×(A-SGXIXI2)+L+SNU×SG
[11]	G71+2×EI+(L+2)-5G5
[12]	67+67+671-672+671
[13]	+(N <hax) l2<="" th=""></hax)>
	그는 것이 많은 전쟁을 가들을 수 있었다. 그는 것 같은 것은 것이 가지 않는 것이 것이 같이 않는 것이 것이 같이 같이 없다.

<u>F5</u>

Having the necessary input, F5 assembles the final matrix equation and evaluates the determinant of [G] (Eq. 4-35); DET is a function for evaluating the determinant of

a matrix.

V F F5 EF [1] C+C1×F×(ER-EF)+0.5 BB+C1×F×(EF-1)+0.5 [2] [3] L F1 C [4] L F2 C [5] L F3 BB 6+61+62-63+64 [6] [7] H+G5, C1J(ER*DEL*BB*G)-G6+G7 DET 14 14 +H [8]

Fixing the frequency, F5 should be executed few times around the expected ϵ_e , until the point is found for which the determinant of [G] vanishes.

Appendix D

Workspace RT

The following notation is used in this workspace: the precision to which the roots of Eq. 5-6c EPS: should be found, ER:

8,

F: fh in GHZ . mm.

number of positive roots of Eq. 5-16b to be found, NX : RO s Pm

D

This function evaluates Eq. 5-16b.

	▼ RR+D R1
[,1]	RS+R1+2
[2]	MU+(IAS-RS)+0.5
[3]	→(AS RS)/L1
[4]	F1+MUX,50DELXMU
[5]	F2+60DEL XMU
[6]	+L2
[7]	L1:F1+-MUx10DELXMU
[8]	F2+20DEL XMU
[9]	L2:RR+(ER*F1*20R1)-R1*F2*10R1

ROOT

Given a certain frequency, ROOT finds Pm, the first NX positive roots of Eq. 5-6c.

F ROOT NX [1] AS+(ER-1)×(CC1×F)* [2] RD+NXPO [3] N1+N+O E43 LO:N+N+1 [5] +(N>NX)/0 E63 L1:I+0 [7] A+00.5×N+N1-1 ·... [8] B+00.5×N+N1 [9] L2:M+0 E103 HA+TXB-A [11] L3:M+M+1 [12] I+1+1 E133 →(I>IM)/L7-E143 RS1+D VEMI [15] RS2+D VLM+13 E163 SN+RS1×RS2 [17] +(SN<0)/L4 [18] →(SN=0)/L5 [19] →(M=10)/L31 [20] +L3 [21] L31:N1+N1+1 [22] +L1 [23] L4:A+VEM] [24] B+VEM+1] [25] +((B-A)>EFS)/L2 E263 ROENJEVENJ [27] +LO [28] L5:+(RS1=0)/L6 [29] ROENJ+VEM+1] CB03 +L0 E31 L6:RDENJEVENJ [32] +LO 17: 'NO CONVERGENCE' [33] [34] 'N IS' [35] N [36] 'ITERATION NU. IS [37] Ι

Workspace NIN

The notation used in this workspace is as follows:

-is A, Eq. 5-7c, As is C, Eq. 5-7e, . Ci EF: is Ł, ER : is t, ET : is **ŋ**, Eq. 4-22c, Ml: is M, Eq. 5-10a, is the number of terms retained in Eq. 5-10a, M3: is R, Eq. 5-15, MR : x, Eq. 5-9c, NDB : is NMB: ів x, Eq. 5-9c, J RO : Pm THE 0; , Fig. 5-3, θ_{li}, Fig. 5-3, THL: THU: θ_{ui}, Fig. <u>5</u>-3.

DATA

Finds θ_{ur} , θ_r , and θ_{1r} (Fig. 5-3).

V DATA [1] MV+PW [2] THU+00+5×(1MR)+MK [3] THL+0, 1+THU [4] SL+10THL [5] SU+10THU [6] SM+0.5xSL+SU [7] TH+-10SM [8] MBB+0.5XTH-THL [9] PB+0.5×TH+THL [10] MDB+0.5×THU-TH

- [11] PDB+0.5xTHU+TH
- E123 SB+10(GM+.*MBB)+(MV,MR)PPB
- E13] SDB+10(GM+, XMDB)+(MV,MR)PFDB

F2

Computes f_2 of Eq. 5-38b. f_1 of Eq. 5-20a is included.

- ▼ R2+S F2 SP
- [1] R11+RR1, (10NMB×RR1), +-NDB×RR1+ETXIS+SP
- [2] R12+RR2, (10NMB×RR2), *-NDB×RR2+ET×IS-SF
- [3] R2+R11+R12

<u>F3</u>

Computes f₃ of Eq. 5-20c.

```
▼F3EDJ▼
▼ R3+S F3 I
E1J R3+(S F2 SUEIJ)+(<sup>-</sup>2×S F2 SMEIJ)+S F2 SLEIJ
```

FO

Computes the coefficients of Eq. 5-10a using the roots of Eq. 5-6c; ρ should be copied from RT first.

	▼ F0 C
	M3+PRO -
[2]	M+O
[3]	L3:M+M+1
E43	+(M>M3)/L31
េទ្យ	+(C>ROCM3)/L3
[8]	L31:M1+M-1
. [7]	M+O
C83	L4:M+M+1
CS J	→(M>M3)/L41 .
[013]	+(A>ROEM3)/L4
§ [11]	L41:MA+M-1
C123	RS+LD+2
j [13].	CS+C+2
[14]	
E15]	NMB+M1+NU
_C163	NDB+M1+NU

	E173	MU+(1AS-RS)+0+5
	[18]	MB+MA+MU
	E19]	MD+MAVMU
.,	[20]	S1B+5QDEL XMB
	[21]	S1D+10DELXMD
	[22]	C1+(%ODEL×MB),20DEL×MD
	E233	52+10RD
·	[24]	C2+20R0
	[25]	Q1+(S1B,S1D)+DELXMU
	E263	Q2+MU×S1B,-S1D
_	[27]	P1B+R0×S2×Q2
·	[28]	P3+(ER×DEL×QT*C2)+(C1×C2×1+ER×DEL)+ER×Q2×S2+R0
	[29]	P3+P3+(C1×S2+R0)-Q1×R0×S2×DEL+2
	[30]	G+F1B+F3×NU+3
	E313	Q01+C×1oC
	[32]	Q02+(AS-CS)+0.5
	[33]	Q03+Q02×50DEL×Q02
	[34]	Q0+Q01×Q03+(ER×Q03×20C)-Q01×60DEL×Q02
,	[35]	Q+QO, Q

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FH

Given \mathcal{E}_{e} , FH finds the determinant of [H] using DET. FH is executed around the expected values of \mathcal{E}_{e} for a certain fh(for which \mathcal{P}_{m} is found in RT) until an \mathcal{E}_{e} is found for which the determinant of [H] vanishes (Eq. 5-16).

才	and the second secon			•14 C		+
19 19 - 19	V FH EF					•
[1]	A+AS+0.5	n an	•			•
[2]		+ER-1)+0	.5			
[3]	FO C					
[4]	H+ (MR+MR) PO					
[5]	I+1					
[6]	L0:R+1			1		
[7]	L1:SUM1+SUM2+	(M3+1) 00				
- [8]	V ←1			, \$		
-[9]	L2:SUM1+SUM1+	WEVIXSBE	UART FT	• • • • • •		
[10]	SUM2+SUM2+WE	VIXSNETU	107 E7	· •		
[[1]]	V+V+1			.		- N
E123	+(V≤MV)/L2			· · ·	an a	-1
[13]	HEIJRJEHEIJR	1++/0% (5	IM1 YMRE	[P]) + P		
[14]	R+R+1		wii 12 - 112 - 1	LUCI / 200	USAUDR	LKJ
		1		7		

